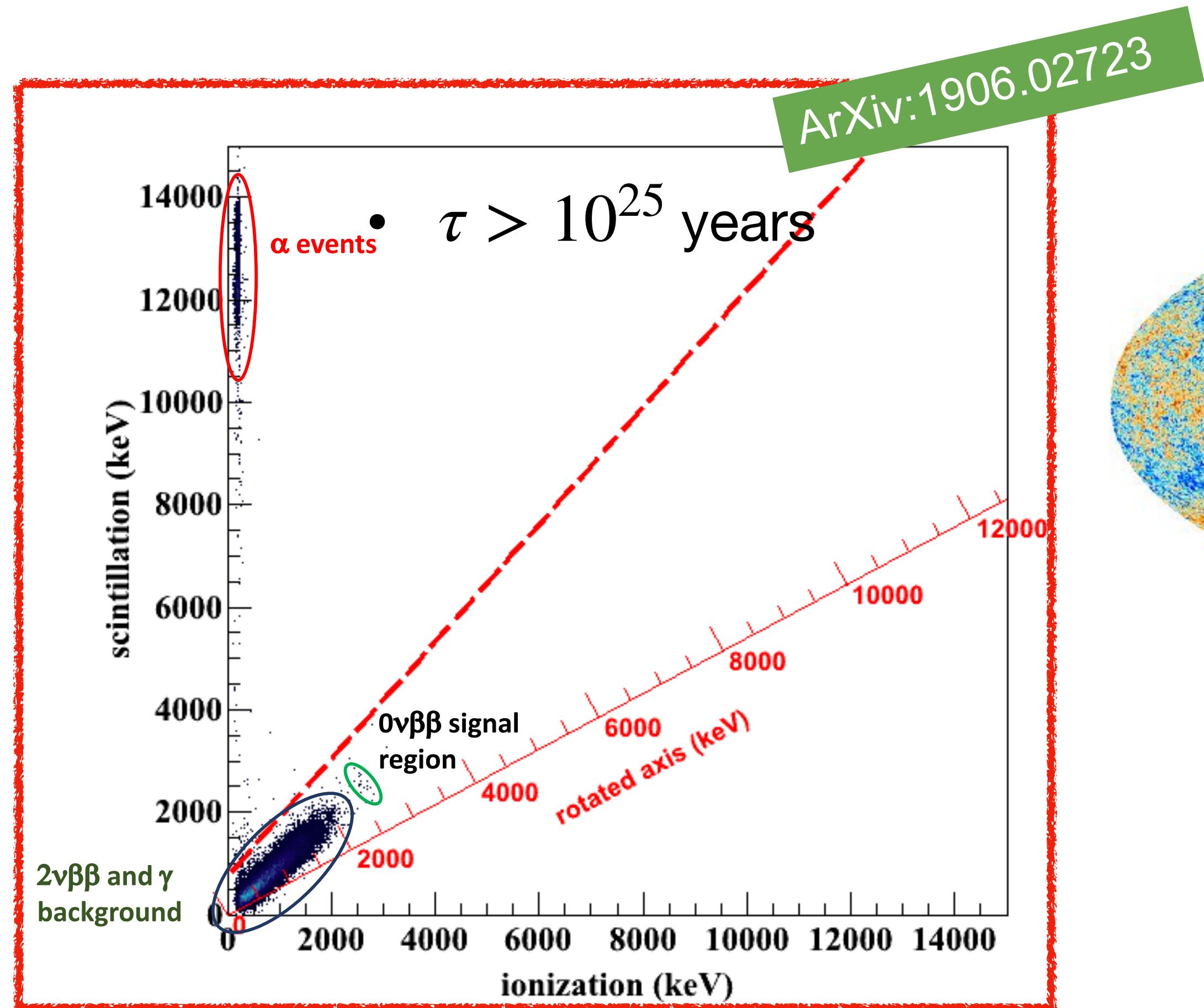


Performance of novel Silicon Photo-Multipliers for the nEXO and Darkside-20k experiments

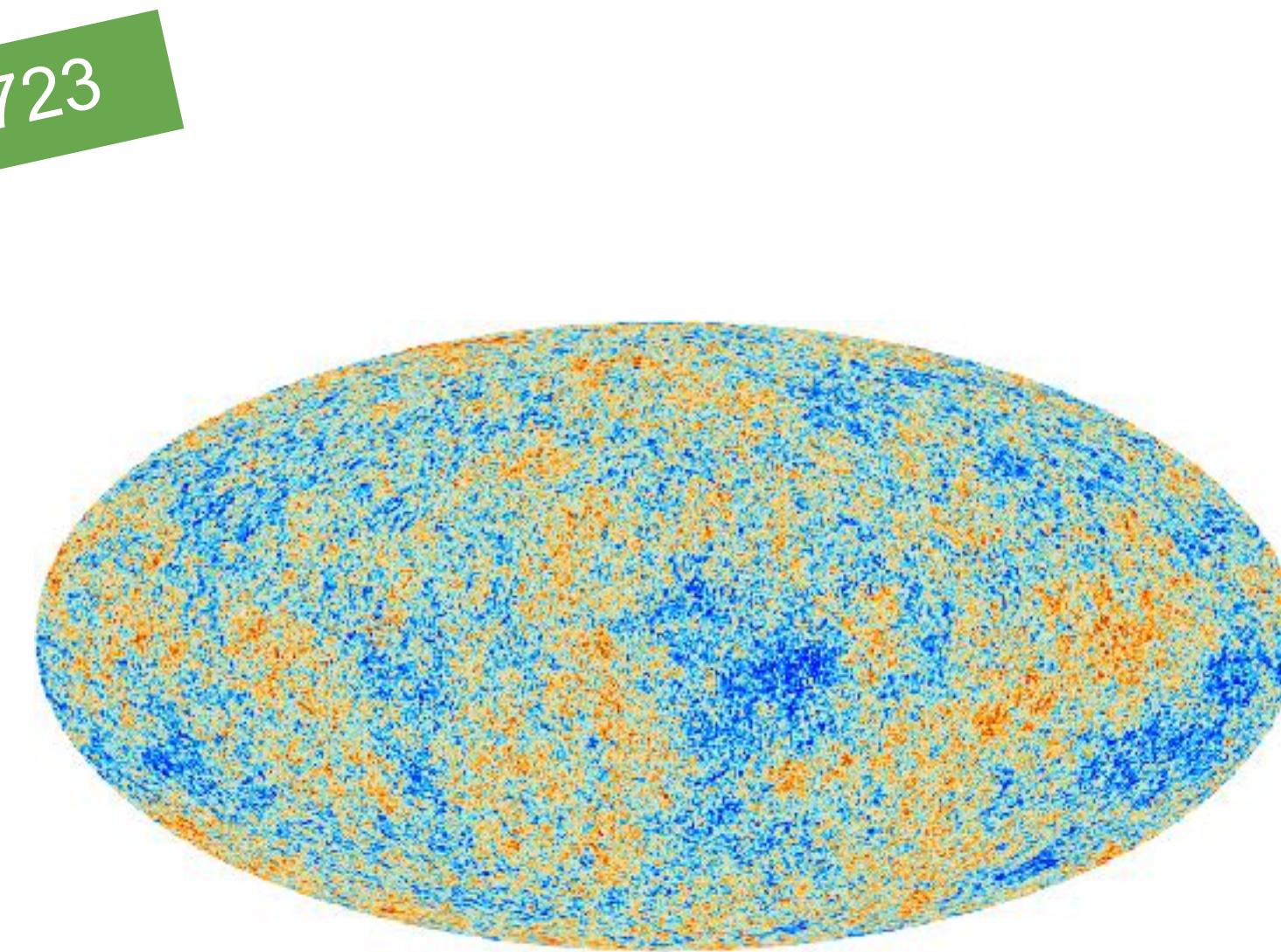
G. Gallina

Overview

Signal of new Physics



Neutrino Physics: $0\nu\beta\beta$ decay

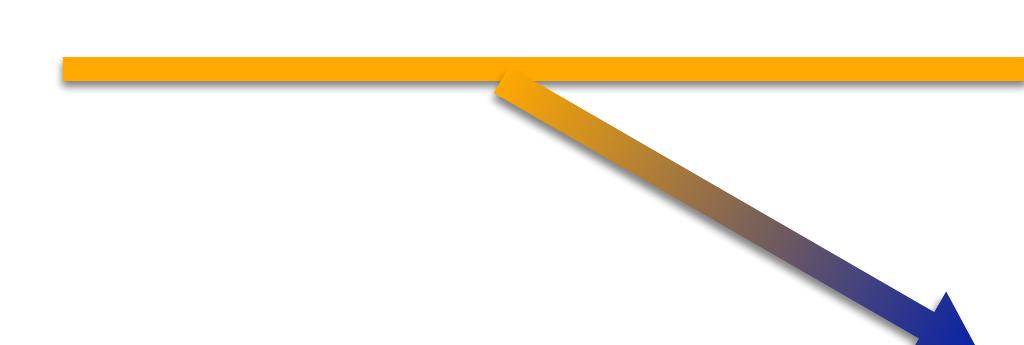


Thermal anisotropies

Galactic clusters



Galaxy velocities



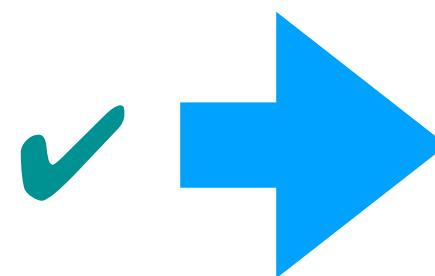
Direct Dark Matter Search

Search with liquified noble elements

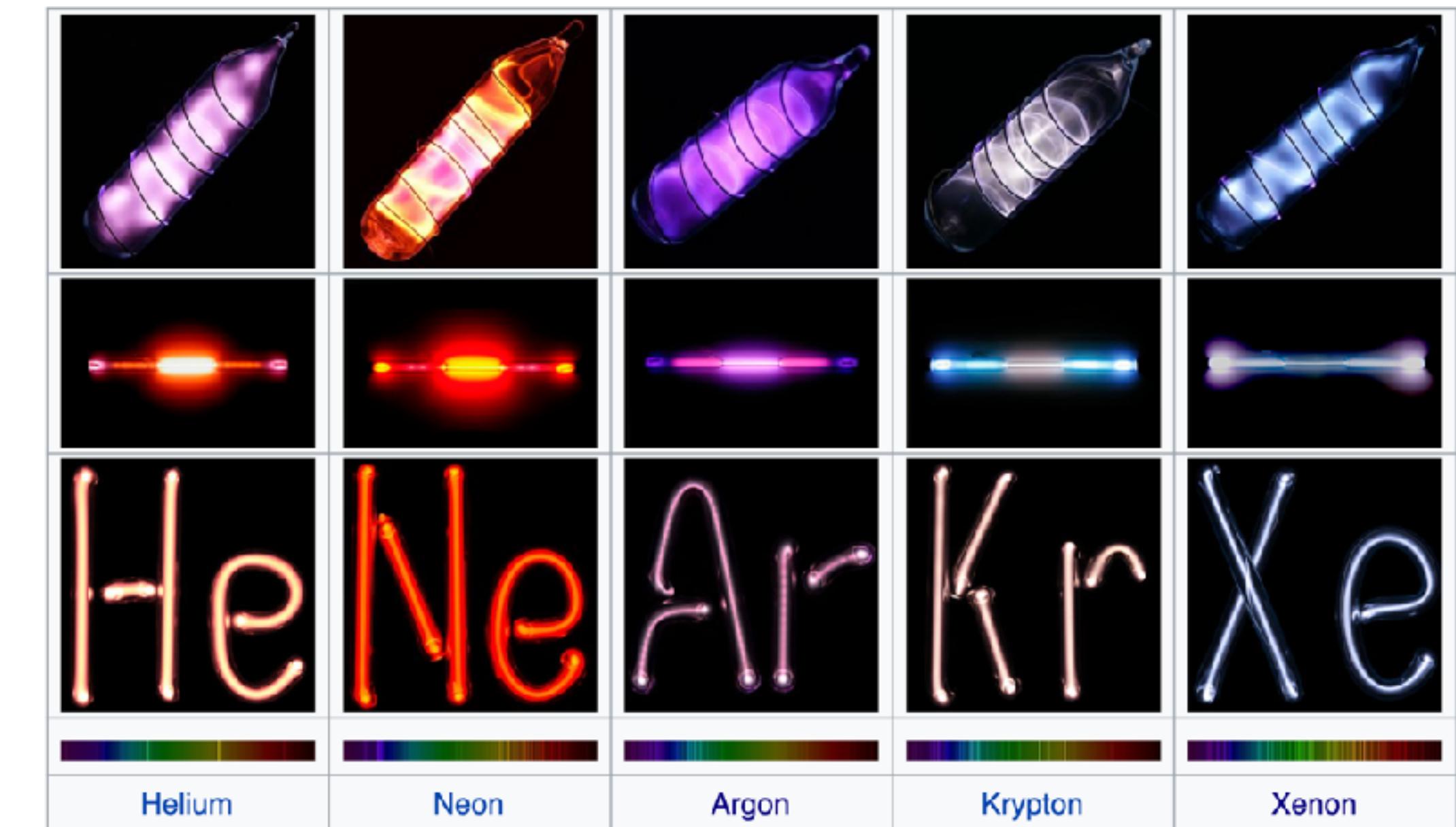
- High density ✓
- Self screening
- Good scalability
- Easy(-ish) purification, also online ✓
- Scintillation: good light yield ✓
- Ionisation ✓
- ER rejection ✓

Excellent detection medium!

and even source !



Need Light
Detectors!



		LAr	LKr	LXe
Physical properties	Atomic number	18	36	54
	Boiling point at 1 bar, T_b (K)	87.3	119.8	165.0
	Density at T_b (g/cm ³)	1.40	2.41	2.94
Ionisation	W (eV) ¹	23.6	20.5	15.6
	Fano factor	0.11	~0.06	0.041
	Drift velocity (cm/μs) at 3 kV/cm	0.30	0.33	0.26
Scintillation	Transversal diffusion coefficient at 1 kV/cm (cm ² /s)	~20		~80
	Decay time ² , fast (ns)	5	2.1	2.2
	slow (ns)	1000	80	27/45
	Emission peak (nm)	127	150	175
	Light yield ² (phot./MeV)	40000	25000	42000
	Radiation length (cm)	14	4.7	2.8
	Moliere radius (cm)	10.0	6.6	5.7

Excellent discrimination power!

SiPMs technology

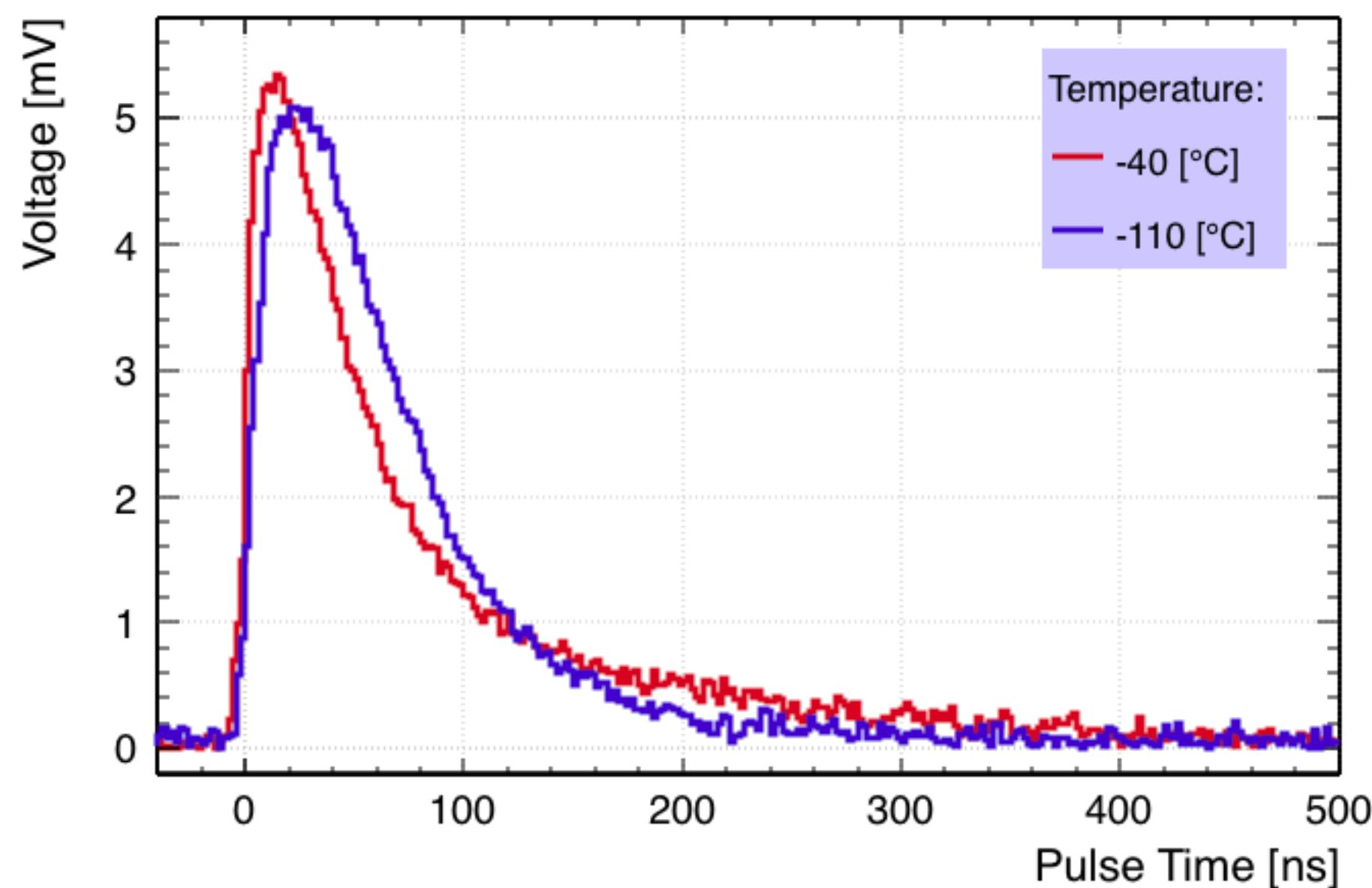
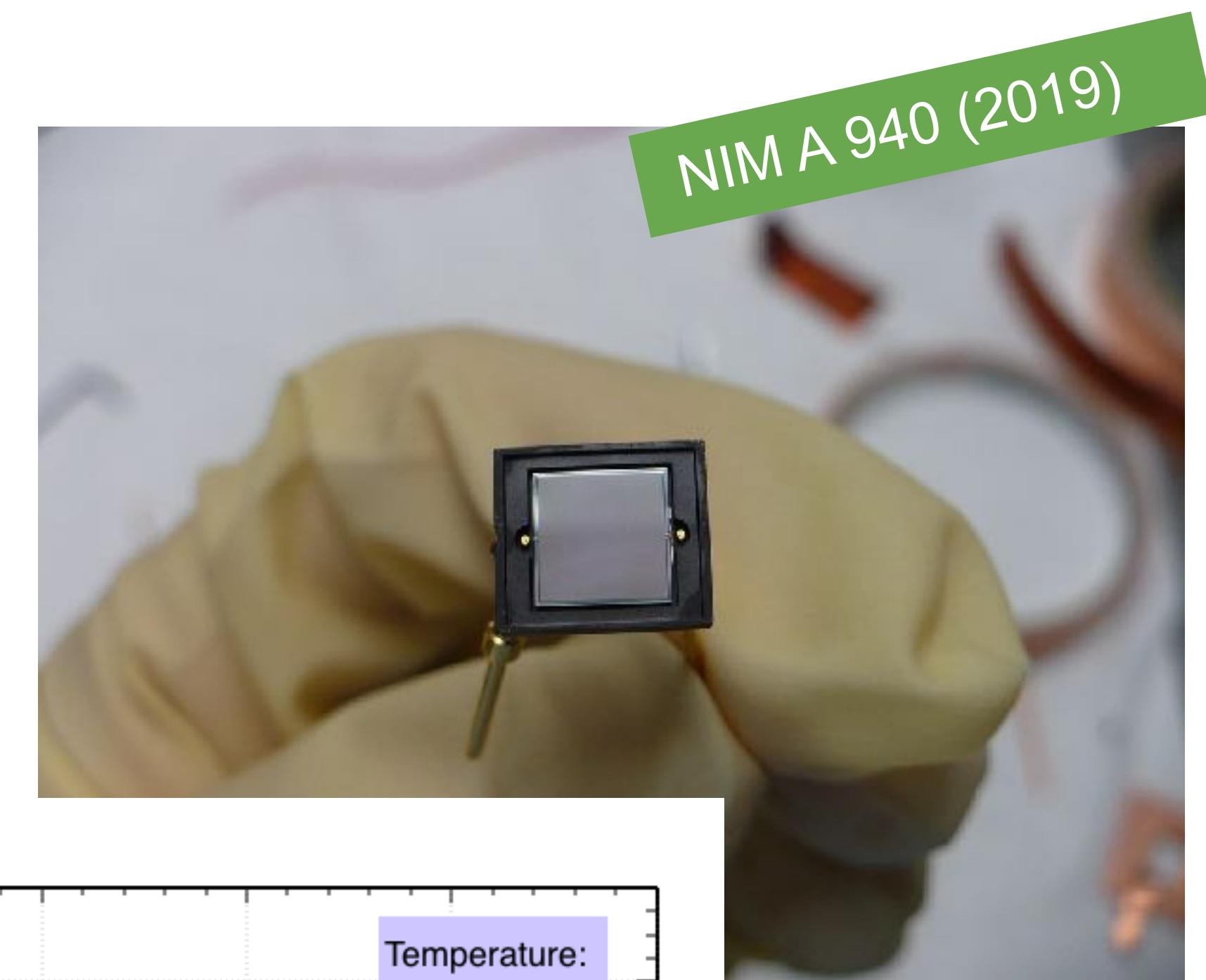
5

Main Characteristics :

- SPADs connected in parallel operated in reverse bias mode
- Incoming photon triggers charge avalanche
- Single pixel is discharged

Advantages:

- High gain at low bias voltage
- Single photon detection resolution
- High radio purity possible
- Suitable at cryogenic temperature
- **High Photon Detection Efficiency (PDE)**



Noise Sources in SiPMs

Uncorrelated Avalanche Noise

- Dark Count Rate (DCR)

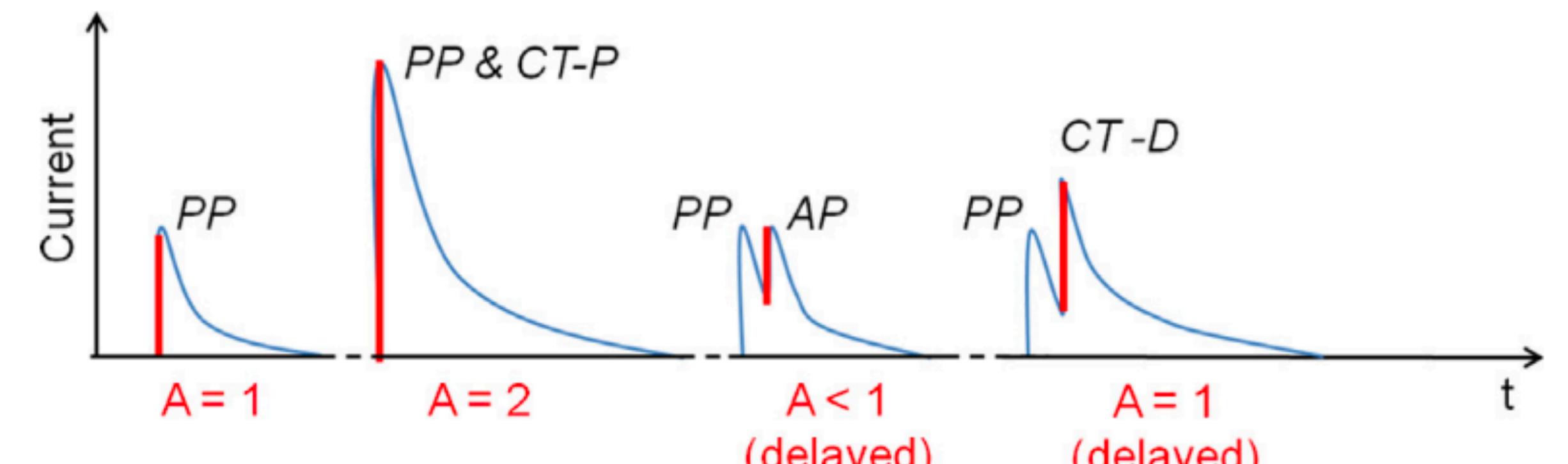
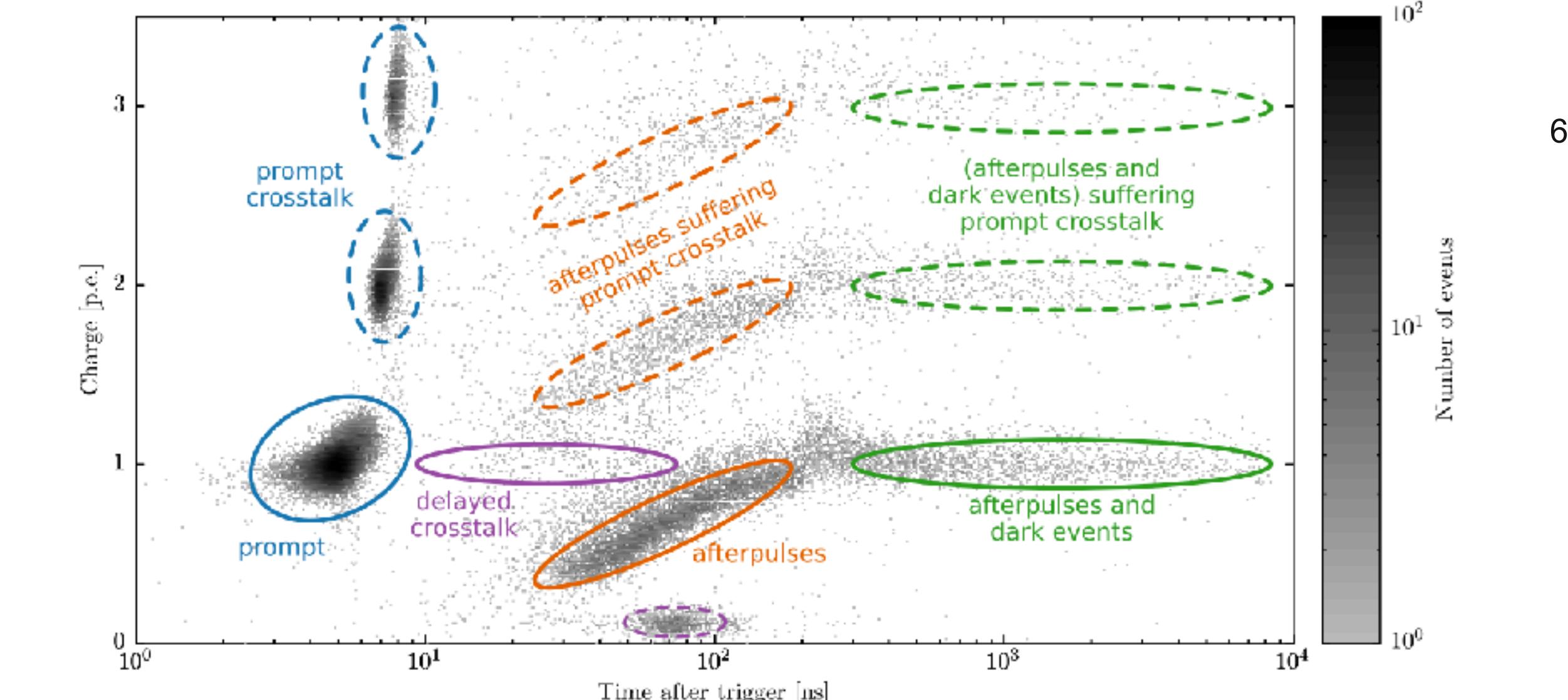
Correlated Avalanche Noise

- Afterpulse (AP)
- Internal Cross talk (CT)
- External CT

For Internal Cross Talk an additional discrimination is based on timing :

CT-P : Cross-Talk Prompt ($<< 1$ ns)

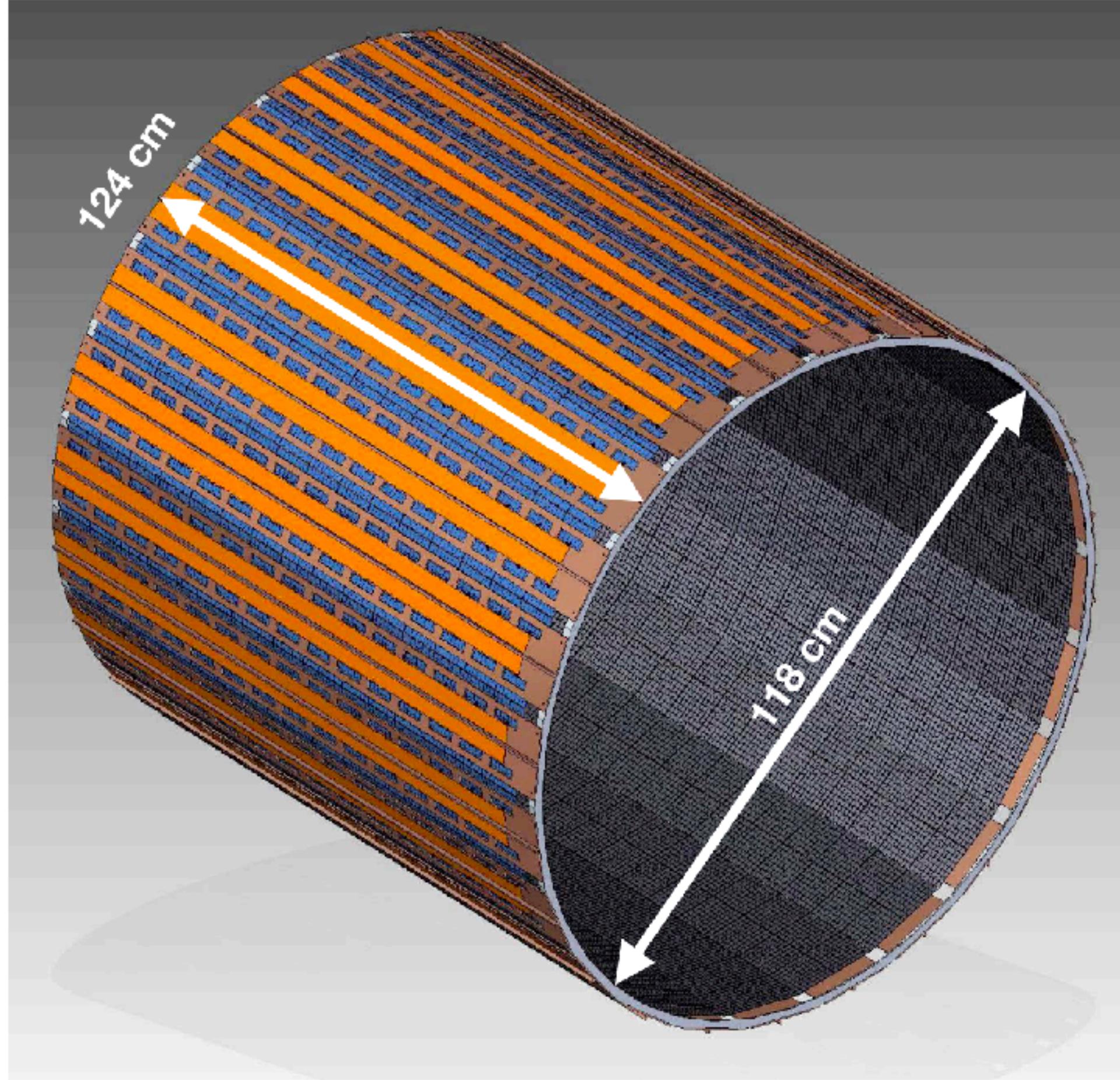
CT-D : Cross-Talk Delayed ($>$ ns)



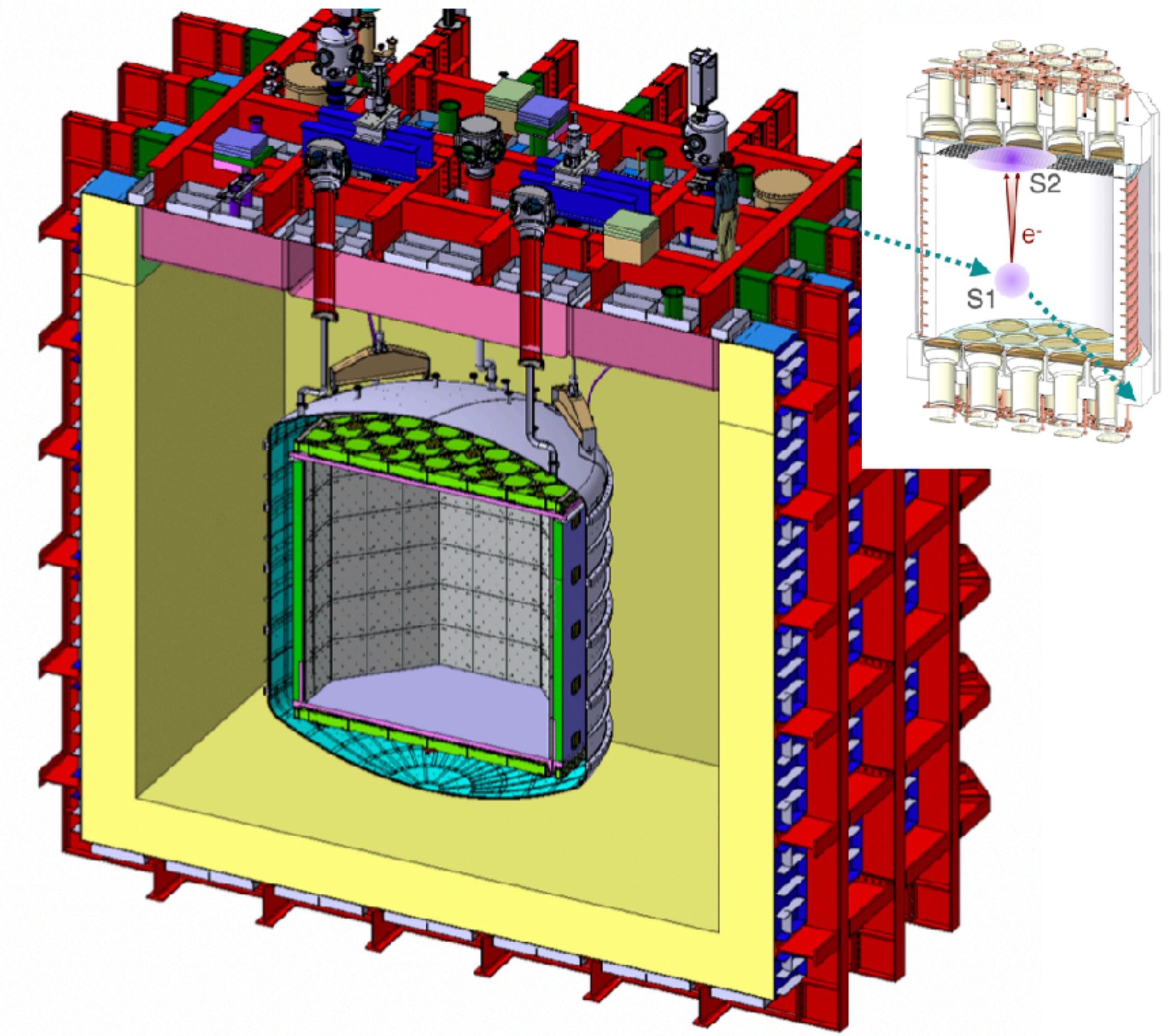
Primary pulses (PP) with different types of correlated pulses such as prompt CT (CT-P), afterpulse (AP) and delayed CT (CT-D).

SiPM are the technology of choice in nEXO and DS-20k!

The nEXO and the Darkside-20k experiment



>4.5 m² covered with VUV-sensitive SiPMs

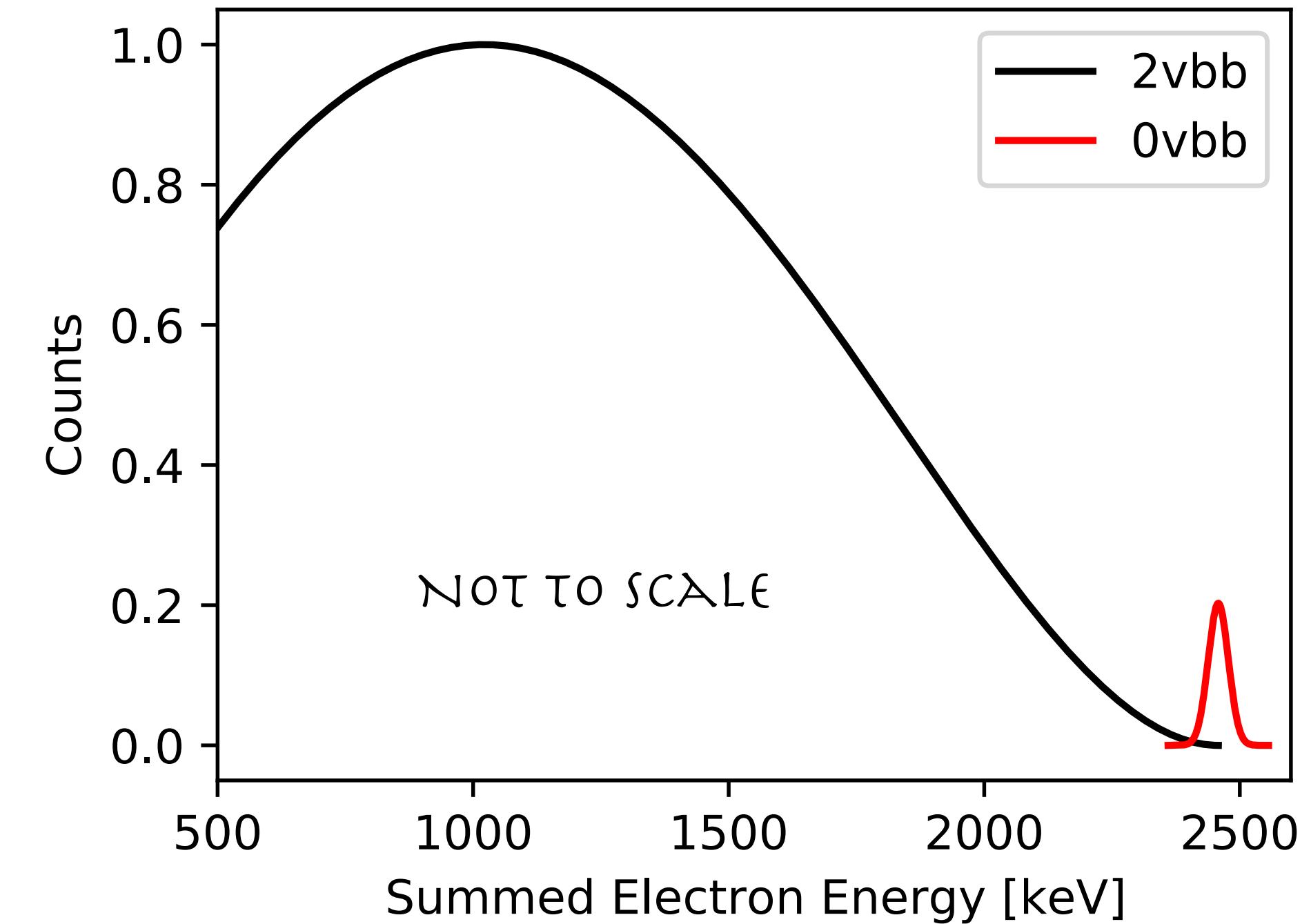
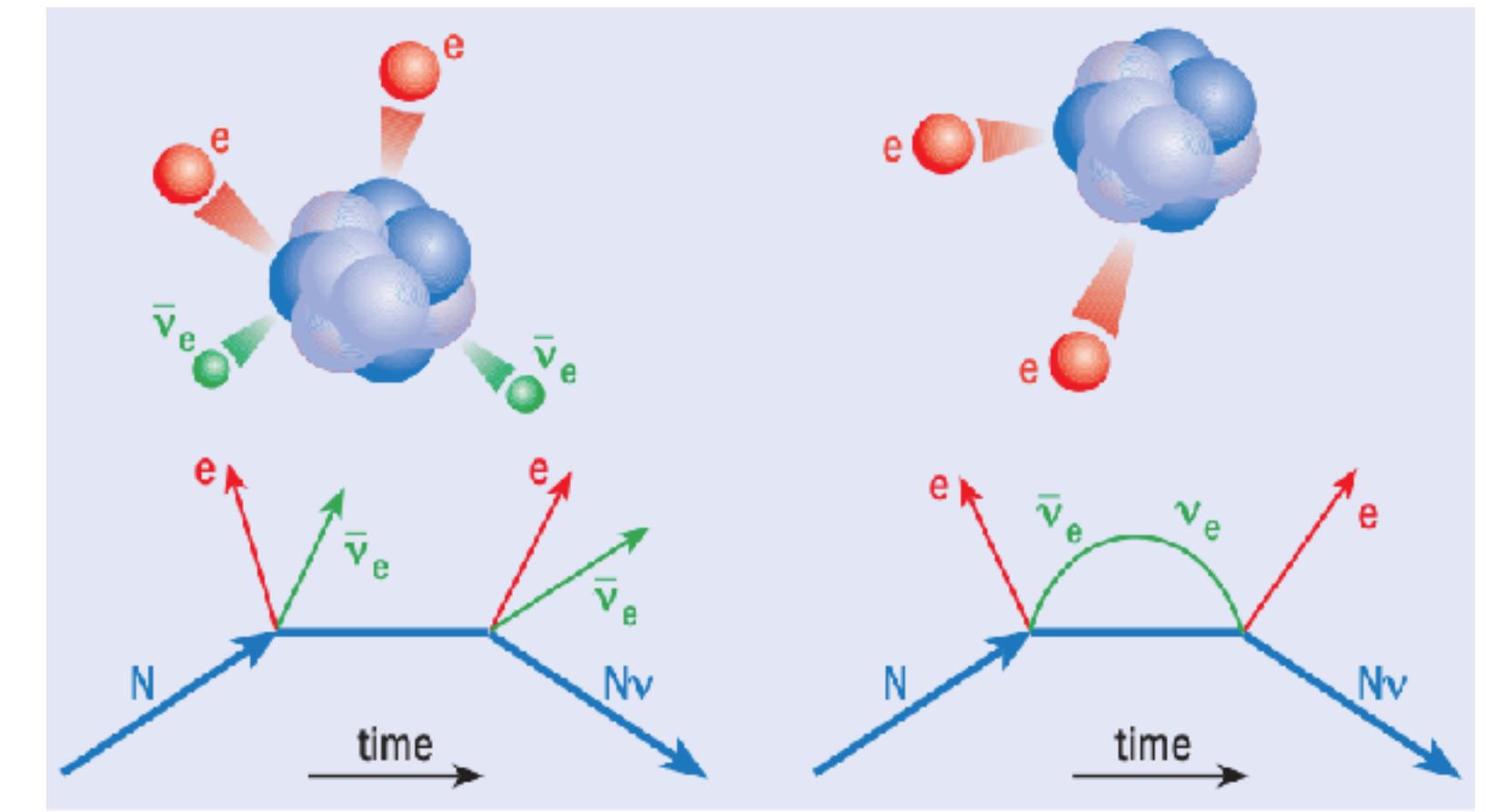


>20 m² covered with NUV-sensitive SiPMs

SiPM Technology in nEXO

Motivation for ^{136}Xe Neutrinoless Double Beta Decay

- Finding $0\nu\beta\beta$ always implies new physics
 - Lepton number violation
 - Neutrinos are Majorana fermions ($\nu \equiv \bar{\nu}$)
 - Origin of neutrino masses
 - Insight into absolute neutrino mass scale
 - Possibly linked to matter and anti-matter asymmetry
- Experimental signature is a peak at the Q-value (2458 keV for ^{136}Xe)



nEXO: Liquid Xenon Detector for $0\nu\beta\beta$



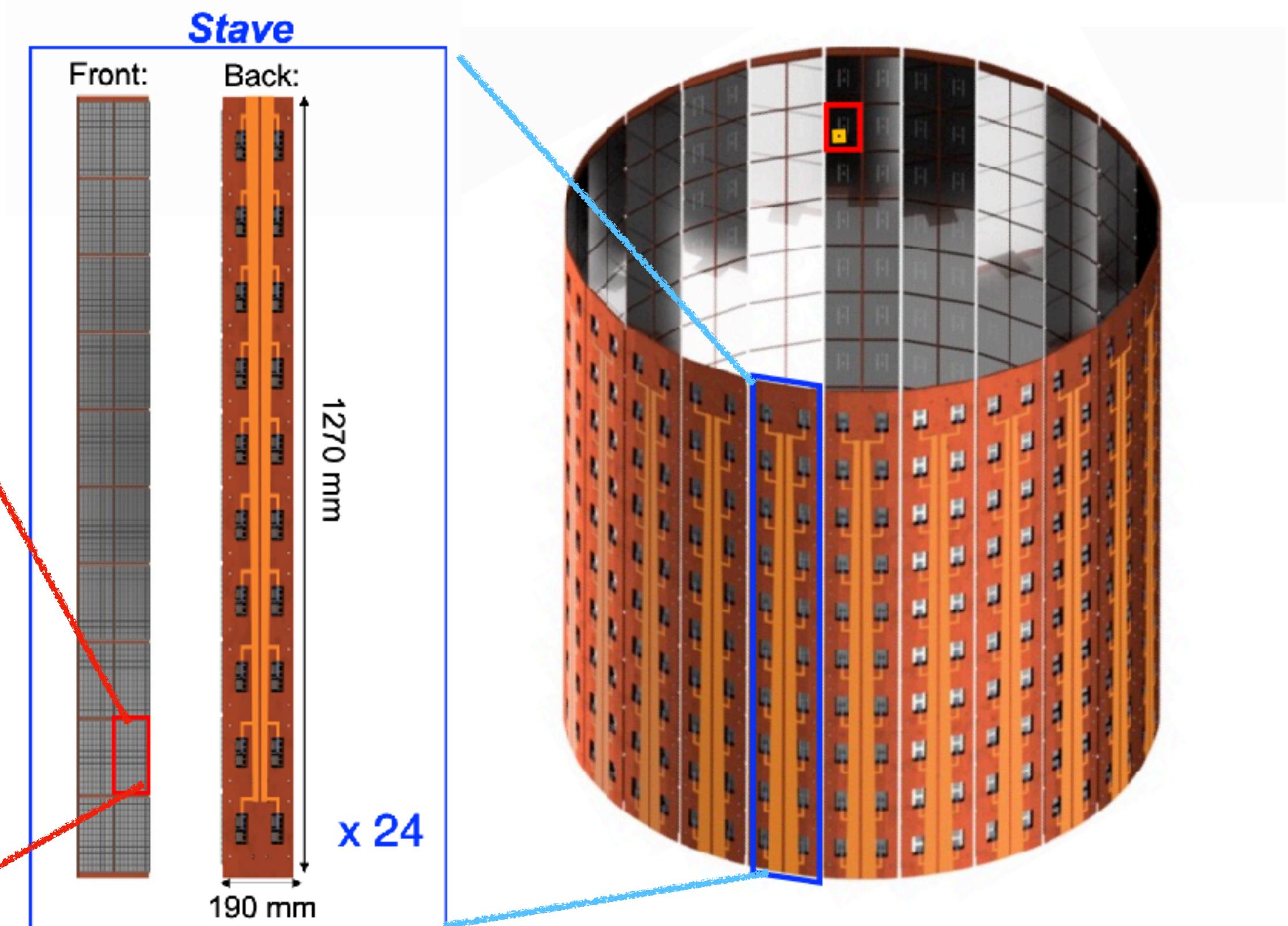
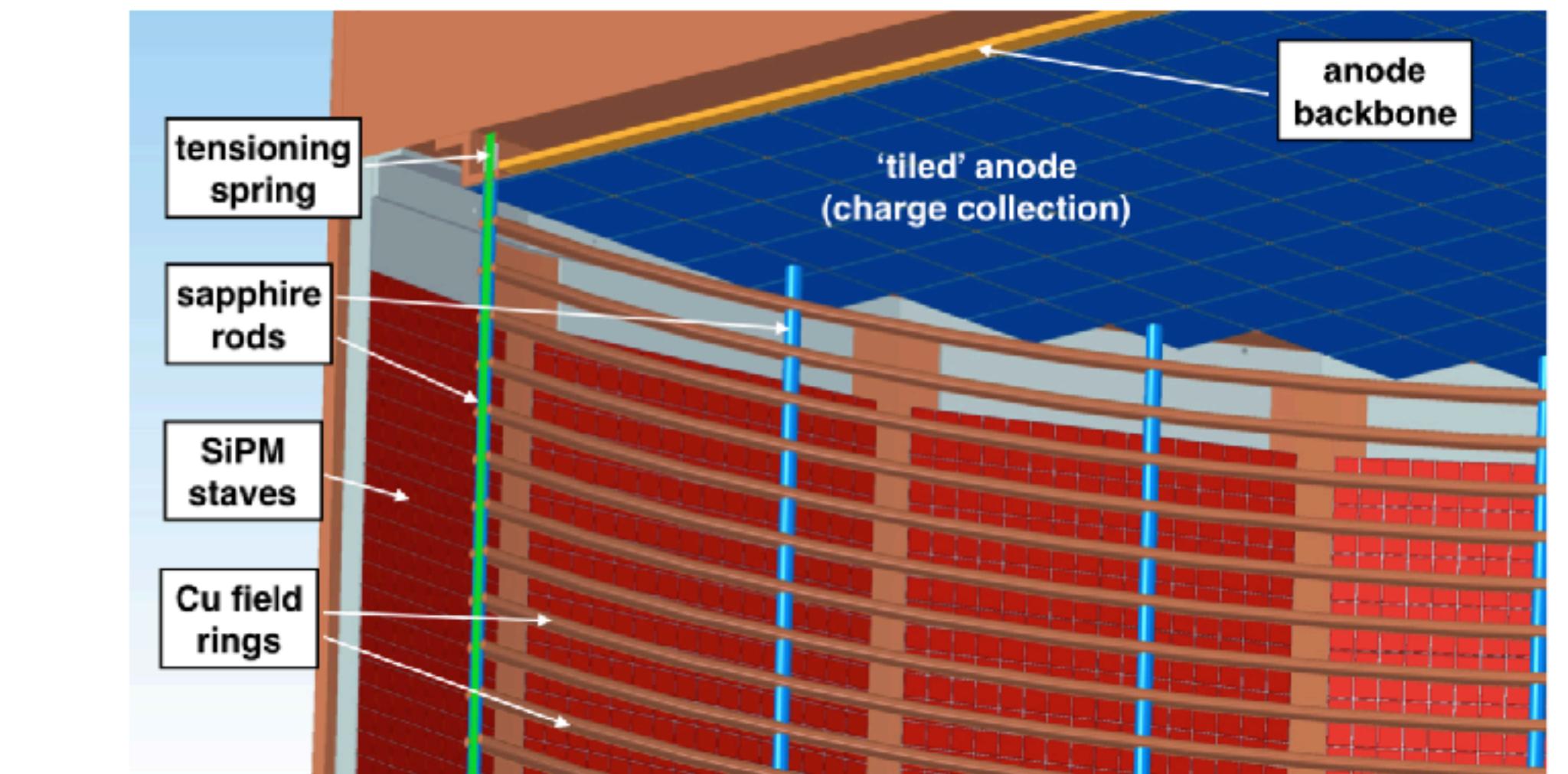
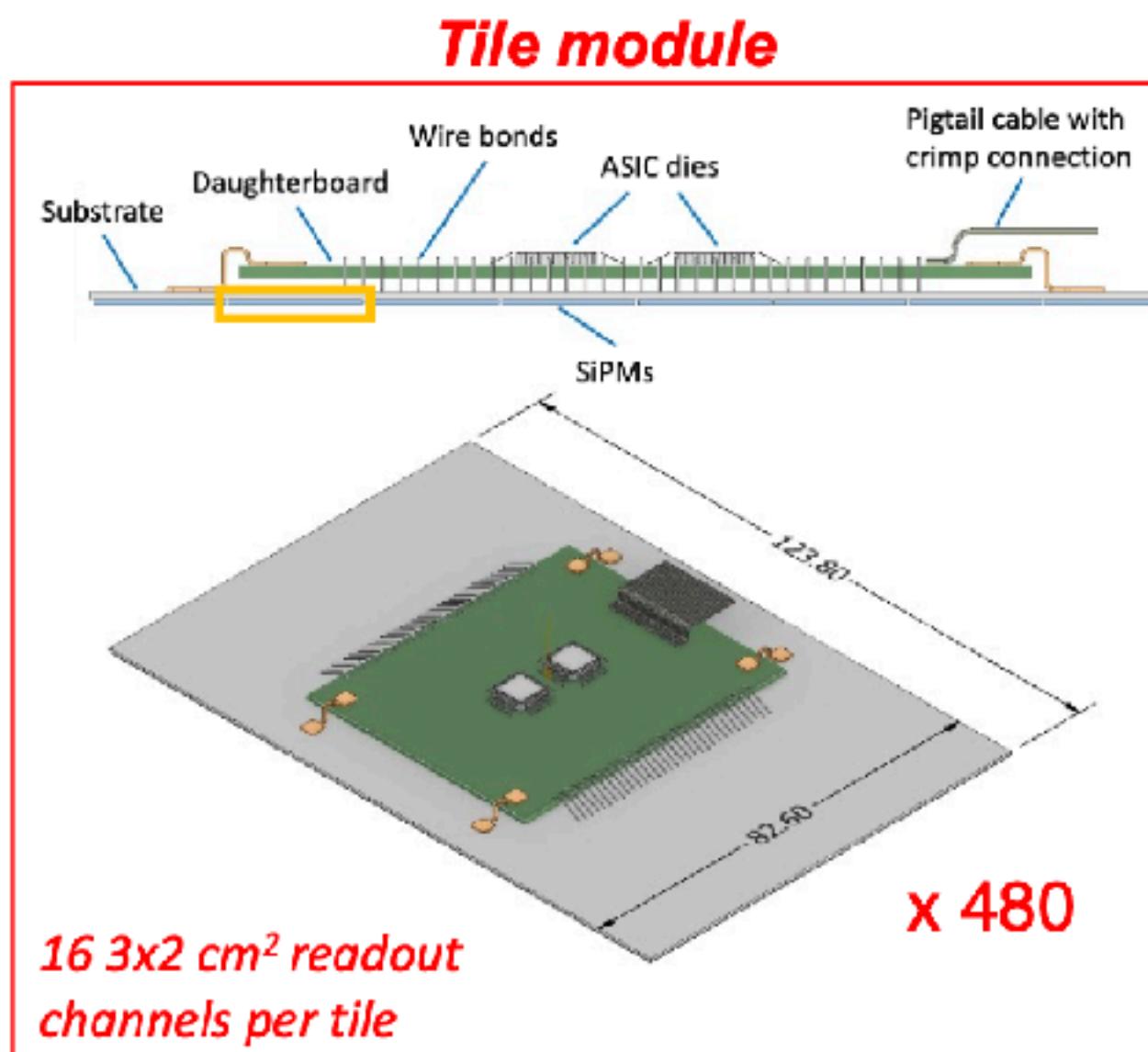
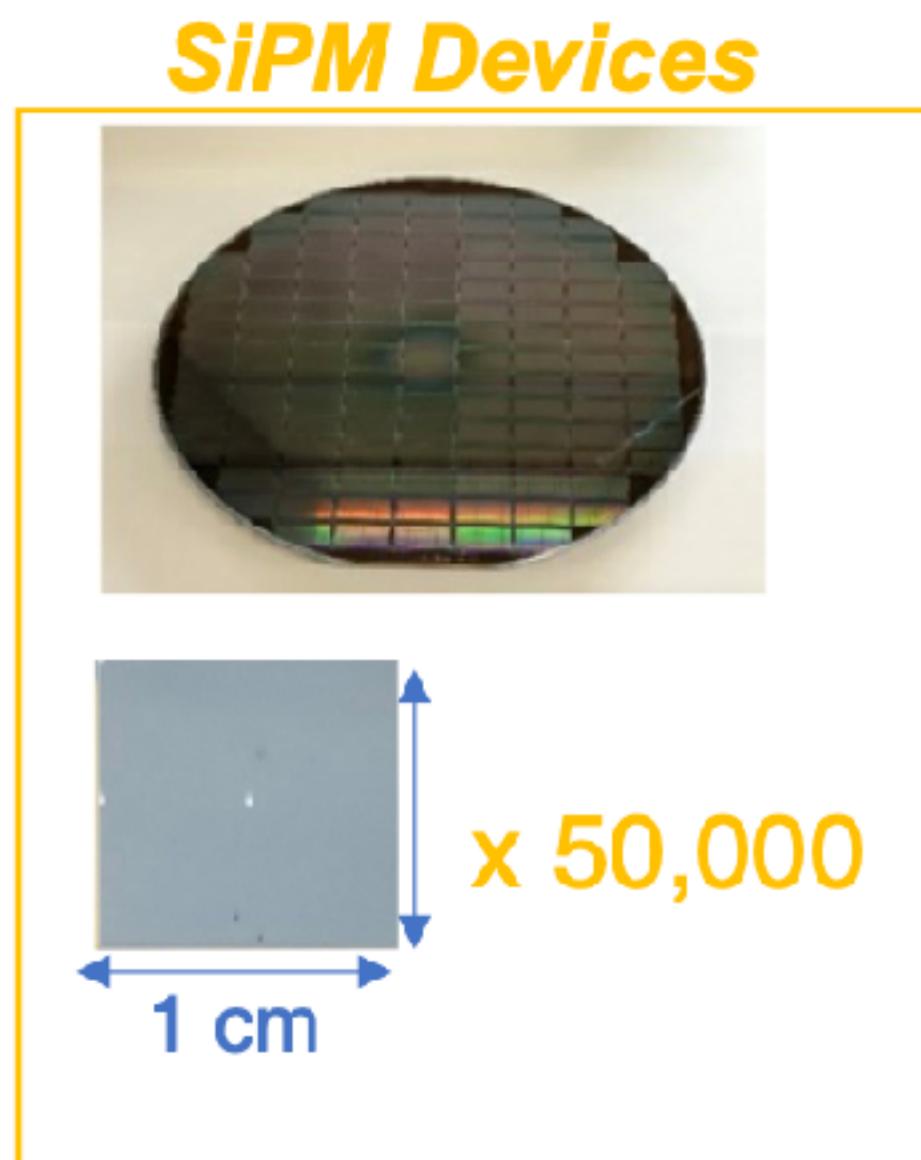
SiPM technology in nEXO

In nEXO we plan to use $\sim 4.5 \text{ m}^2$ covered with VUV-sensitive SiPMs

- 5 t of liquid xenon
- Improved charge (tiles) and light (SiPM) readout
- Projected Sensitivity: $T_{1/2}^{0\nu} \geq 1.35 \times 10^{28} \text{ yr}$

Photon Detector (PD) consists of 4.6m^2 of SiPMs

- $\sim 46,000$ 1cm x 1cm VUV sensitive SiPMs (grouped into 7680 6cm² readout channels)
- Basic integrated element is “tile module” (96 cm²) with ASIC
- 24 “staves” contain 20 tile modules each



Energy Resolution and photodetector requirements

arXiv: 1908.04128

Rotated energy resolution is dominated by light collection efficiency

- Unlike charge, only <10 % of photons are collected
- Statistical fluctuation in collection drives overall nEXO resolution
- Understanding system level collection efficiency is key to accurately projection nEXO resolution
- Sub-dominant (but not negligible) contribution from fluctuation in correlated avalanches (CA)

Collection efficiency

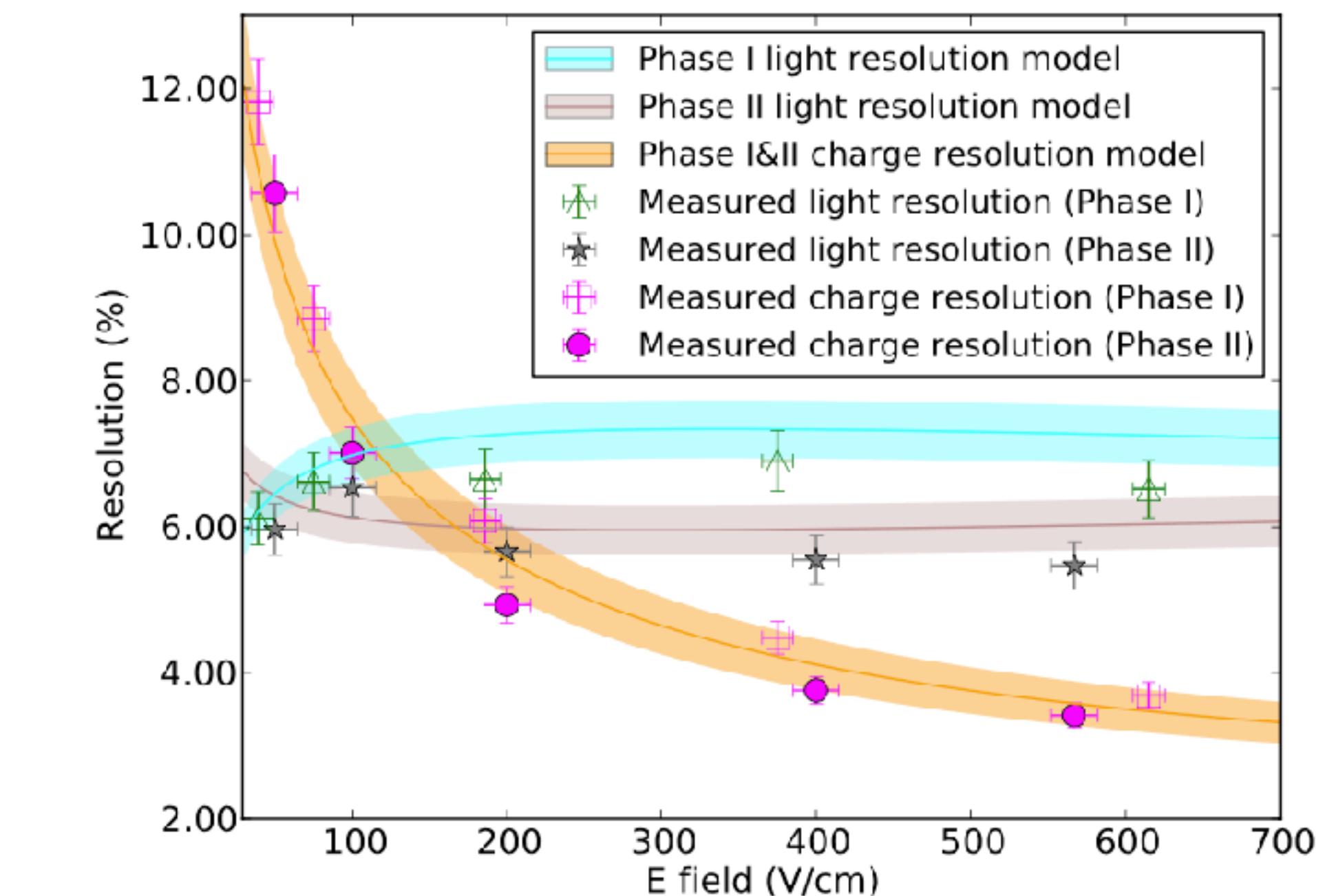
$$\epsilon_P = \text{PTE} \times \text{CE} = \text{PTE} \times \frac{\text{PDE}}{1-R}$$

Photon transport efficiency

Photon collection efficiency

Reflectivity (R)

Photon Detection efficiency (PDE)



Energy resolution measured with EXO-200
APDs at 2615 keV

Correlated avalanches

$$\frac{\sigma_\Lambda}{1 + \langle \Lambda \rangle}$$

RMS of CA charge per PE

Uncorrelated avalanches

DCR

Mean Charge in CA per primary PE

nEXO SiPM Requirements at 163 K

$$\text{CAF} \equiv \frac{\sigma_\Lambda}{1 + \langle \Lambda \rangle}$$

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Parameters	Value
Photo-detection efficiency (PDE) at 175-178 nm in liquid Xenon	$\geq 15\%$
Radio purity: contribution of photo-detectors on the overall background	< 1%
Dark noise rate at -110 °C	$\leq 10 \text{ Hz/mm}^2$
Correlated Avalanches fluctuation (CAF) per pulse in 1μs at -110 C	≤ 0.4
Single photo-detector active area	$\geq 1\text{cm}^2$
Operational gain	$\geq 1.5 \times 10^6 \text{ e}^-$
Capacitance per area	< 50 pF/mm ²
Equivalent noise charge	< 0.1 PE r.m.s

Three SiPMs analysed in this work: 2 Hamamatsu VUV4 MPPCs and FBK VUVHD3 SiPM

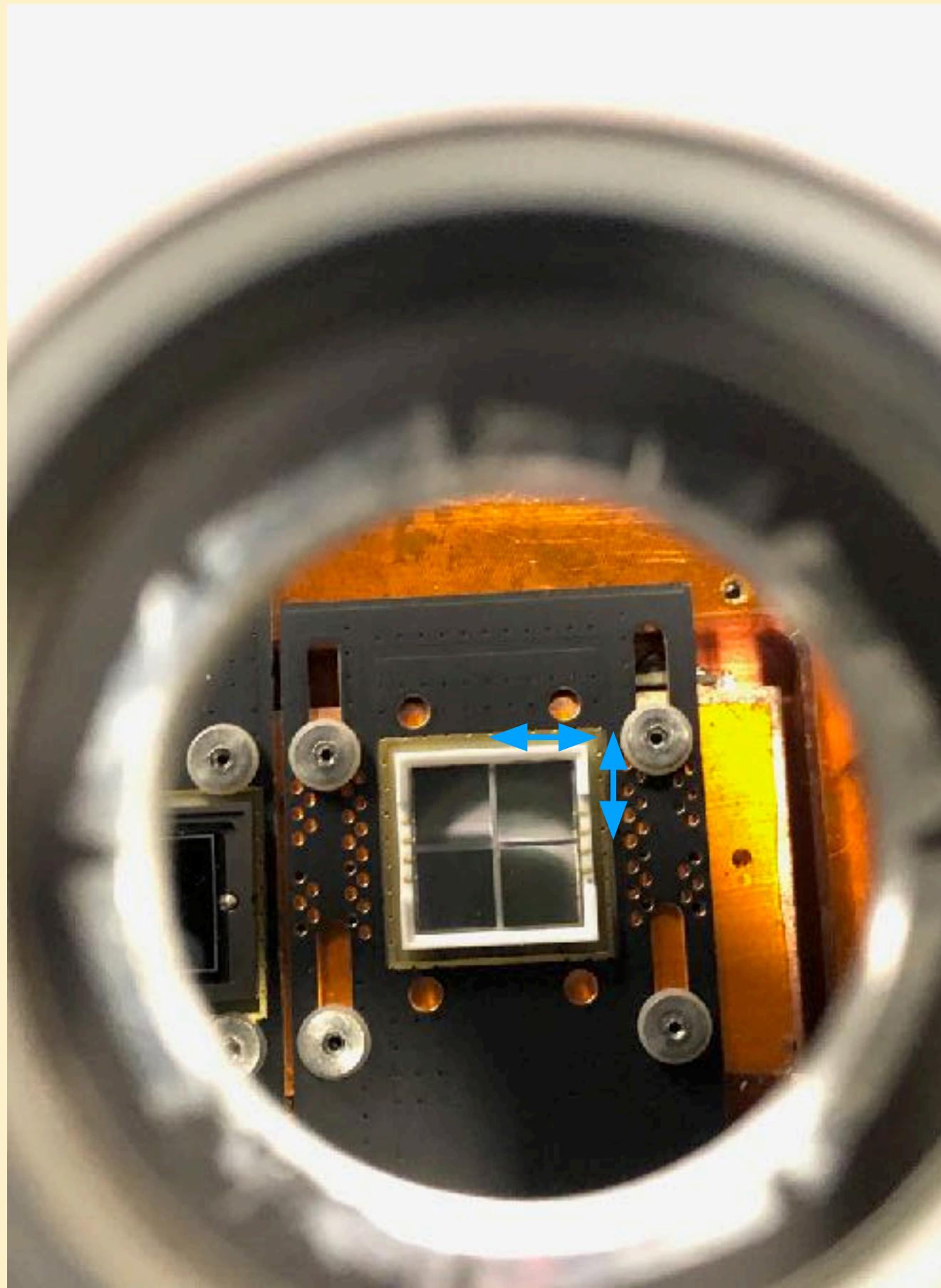
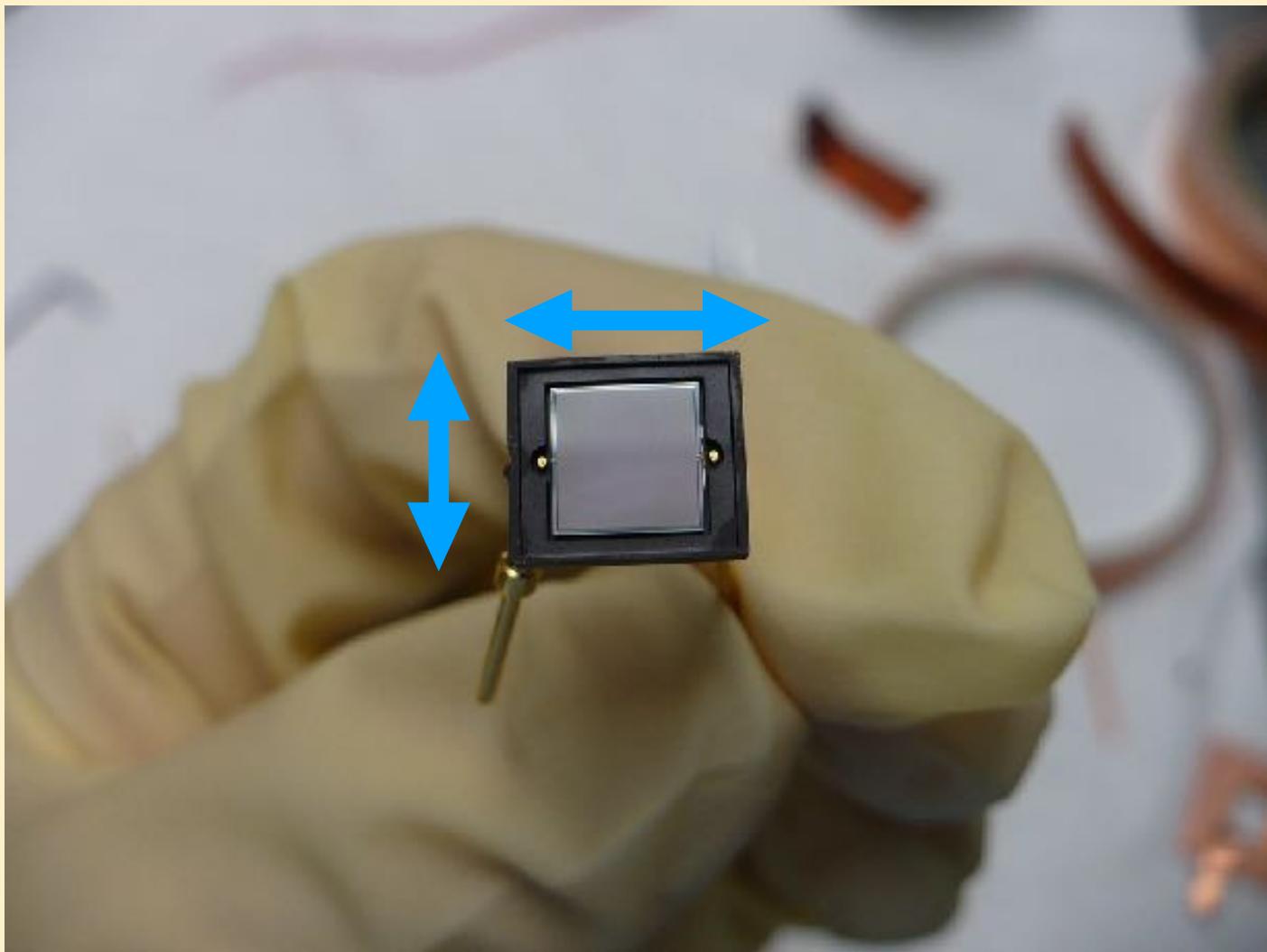
nEXO 6x6 mm² SiPMs candidates

IEEE Trans.Nucl.Sci. 65 (2018)

FBK SiPM

Hamamatsu MPPCs

NIM A 940 (2019)



HPK VUV4-50
Single devices
50 um pitch

HPK VUV4-Q-50
Quad devices.
50 um pitch



FBK VUVHD3
substitutes
its previous generation
FBK VUVHD1

The nEXO photodetector team

15

- **This work** is part of a joint effort of the photodetector group where several institutions contributed to data taking and analysis
- It is the end of more than 2 years of data taking/analysis and comparison !

TRIUMF

G. Gallina, F. Retiere, P. Margetak,
N. Massacret, M. Mahtab et al.

IHEP

G. Cao, Y. Guan et al.

YALE

A. Jamil, A. Bhat,
D. Moore

BNL/Drexel

A. Bolotnikov,
I. Kotov, A. Kumar et al.

UMass

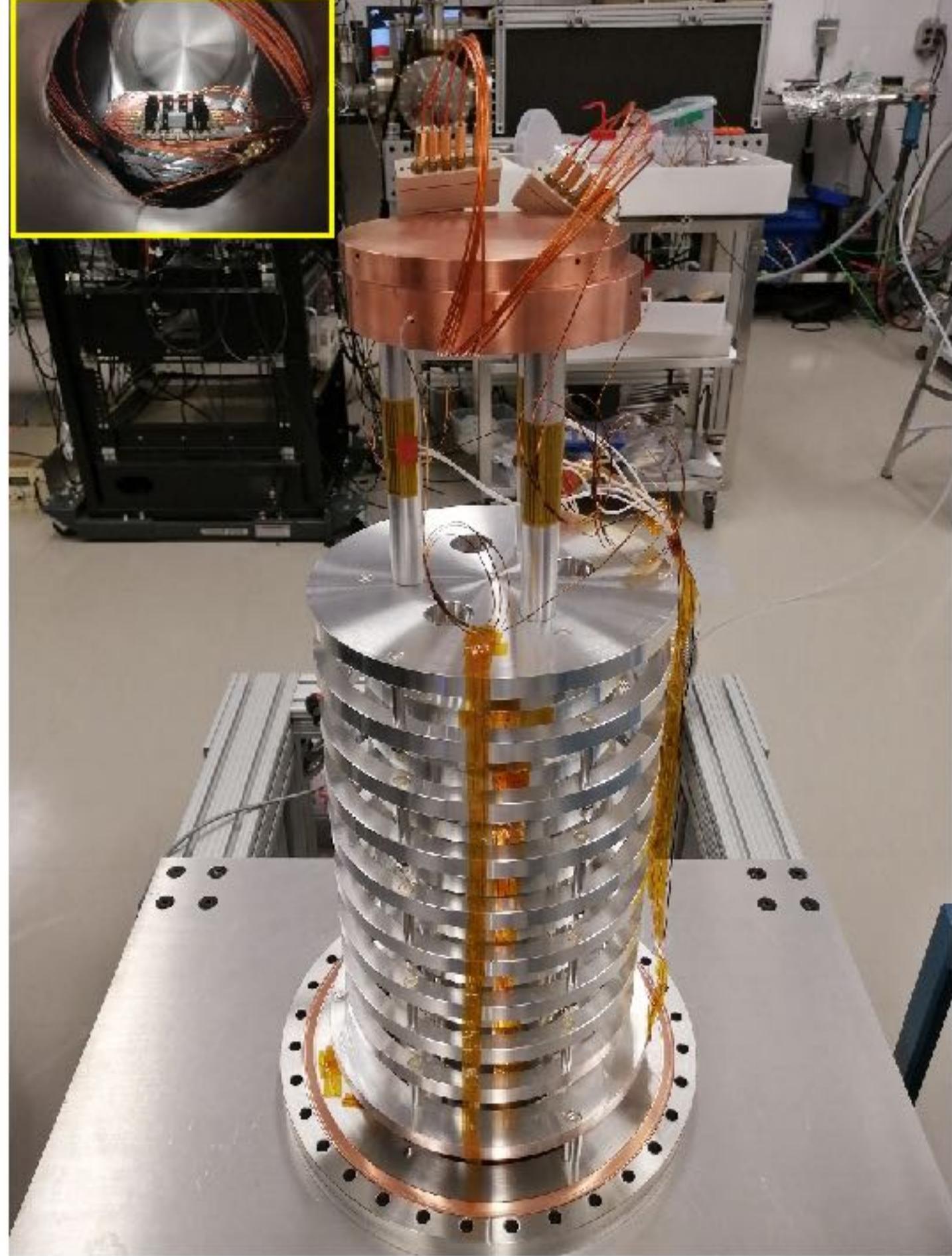
A. Pocar, W. Gillis,
Reed C. et al.

McGill

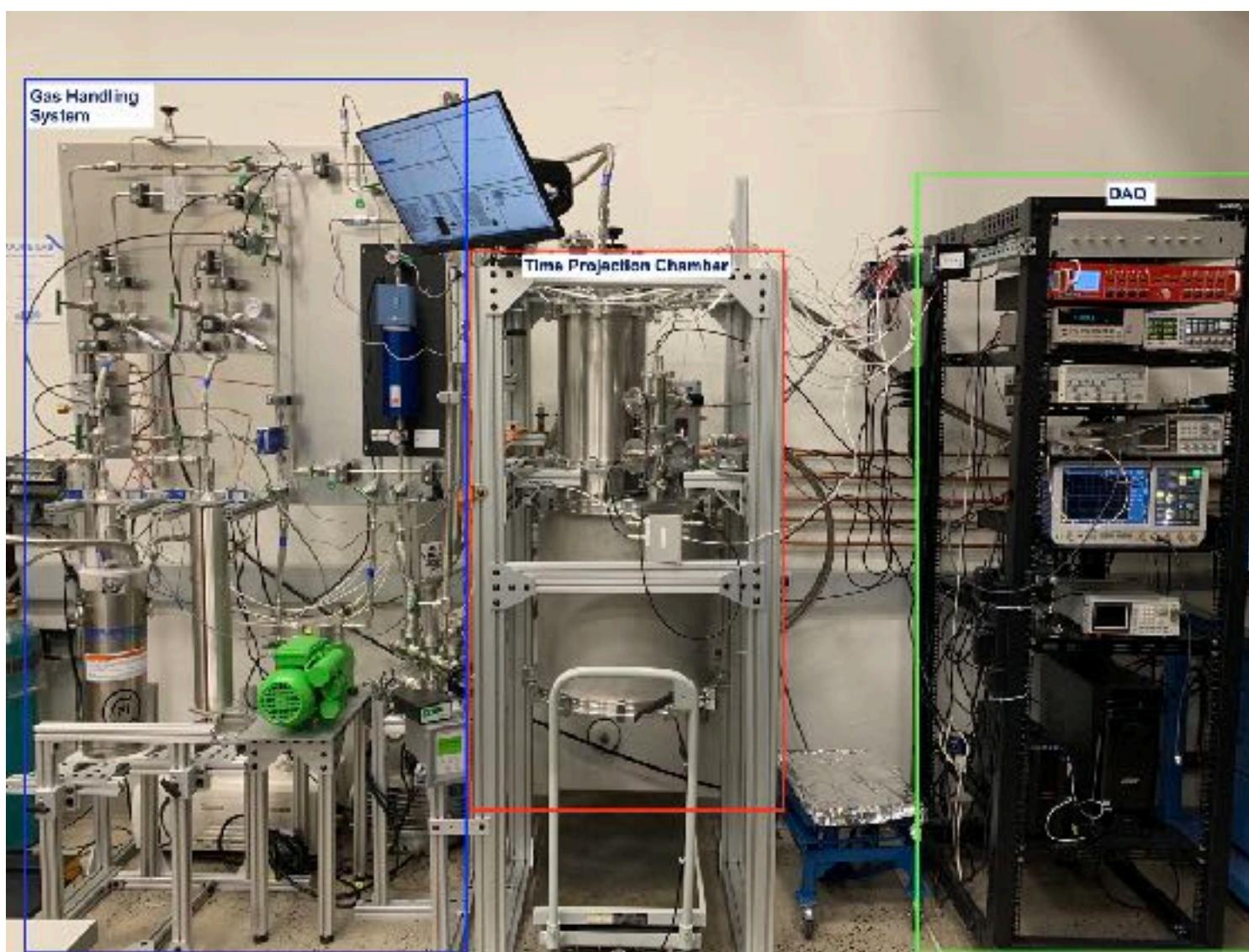
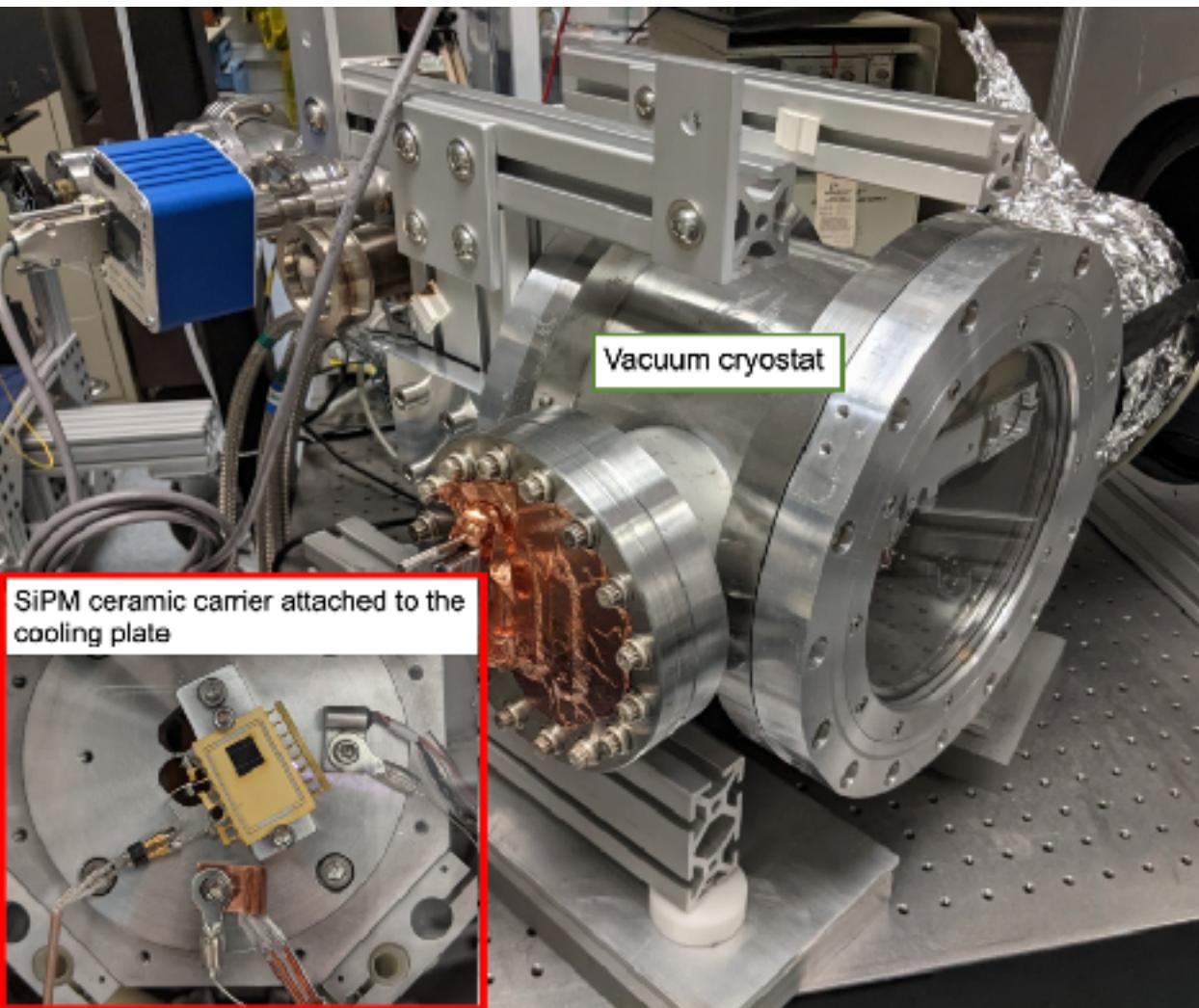
L. Darroch, T. Brunner et al.

nEXO Testing setups: Dark measurements

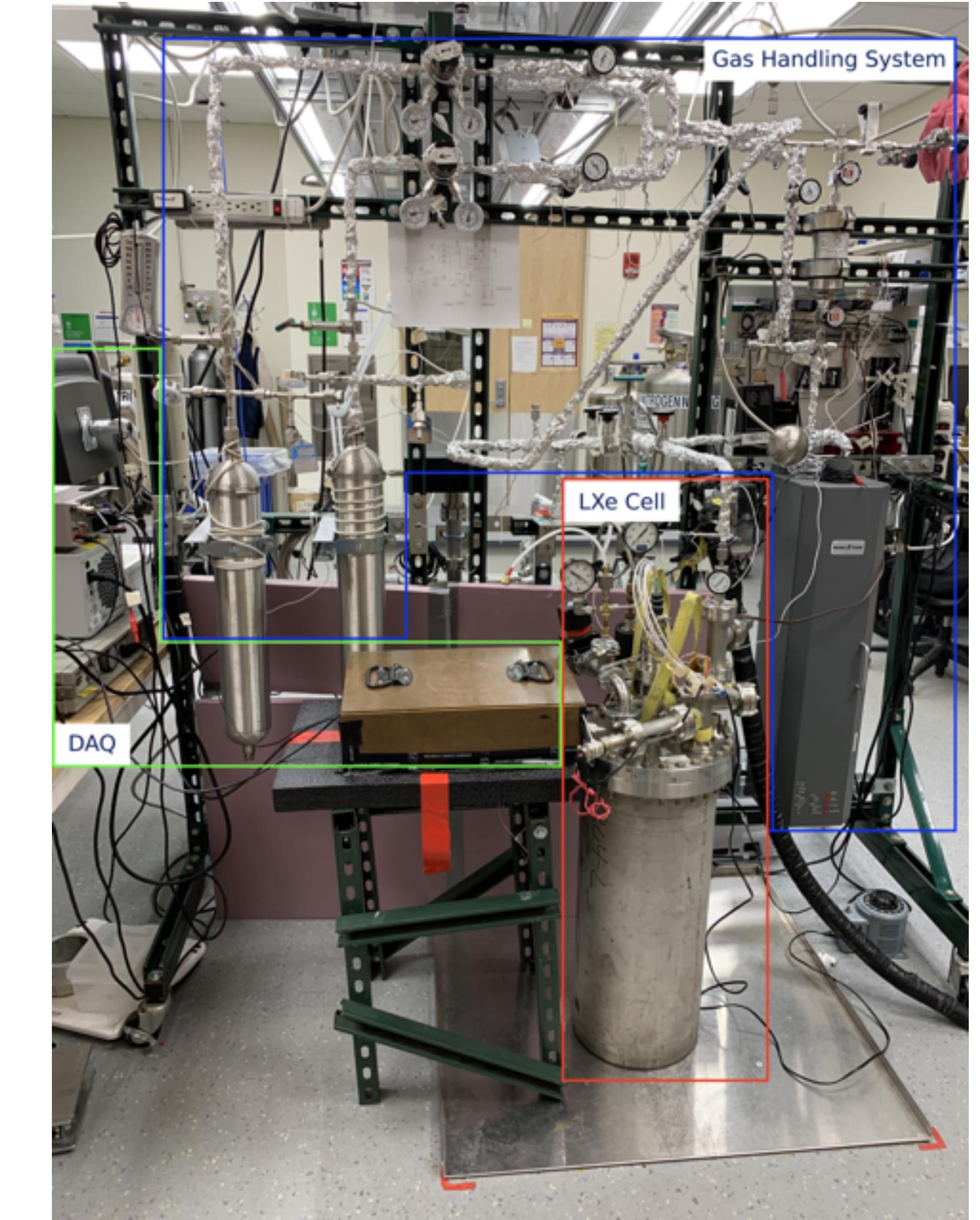
BNL Setup



McGill Setup

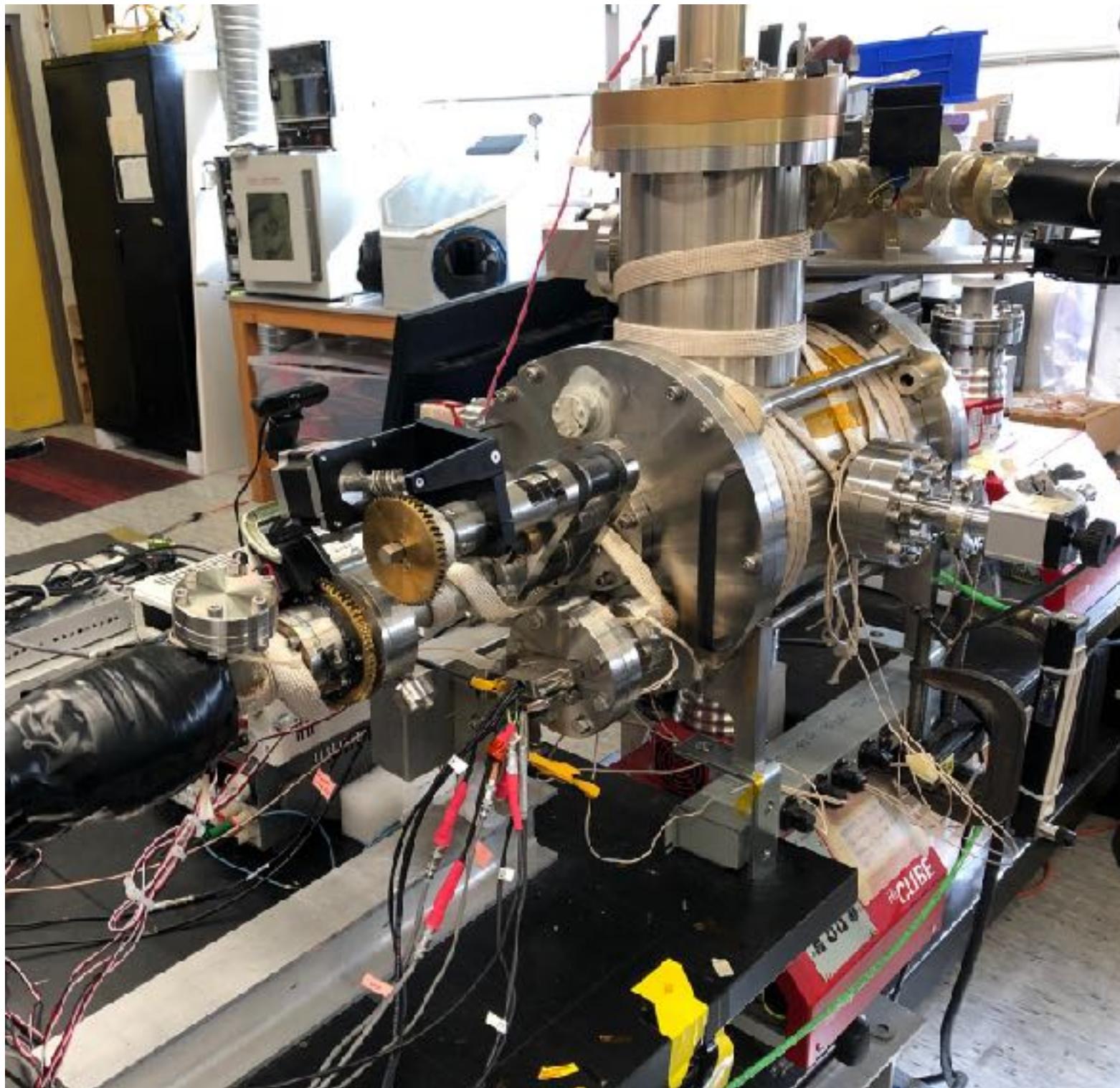


Yale LXe Setup

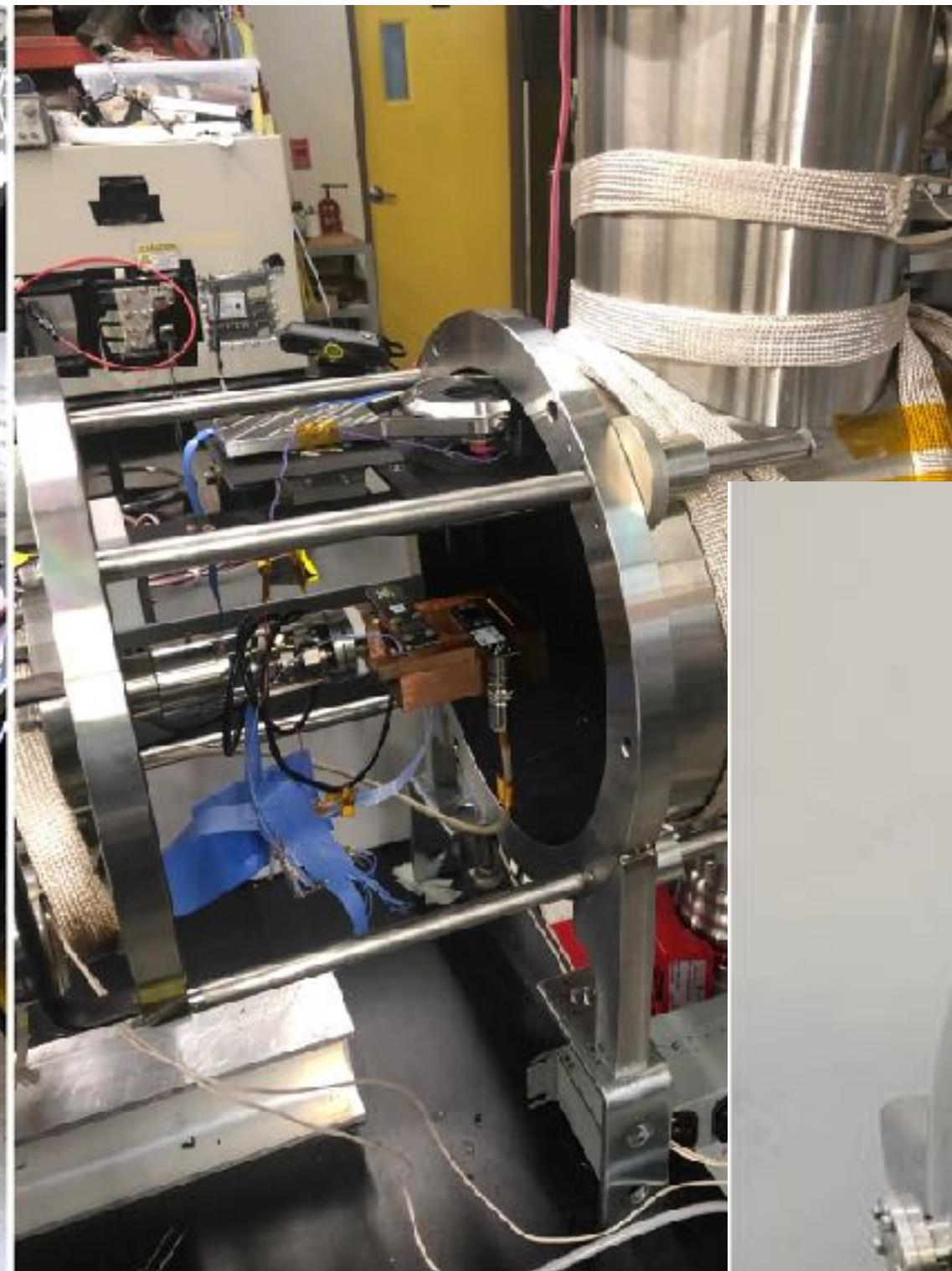


UMass LXe Setup

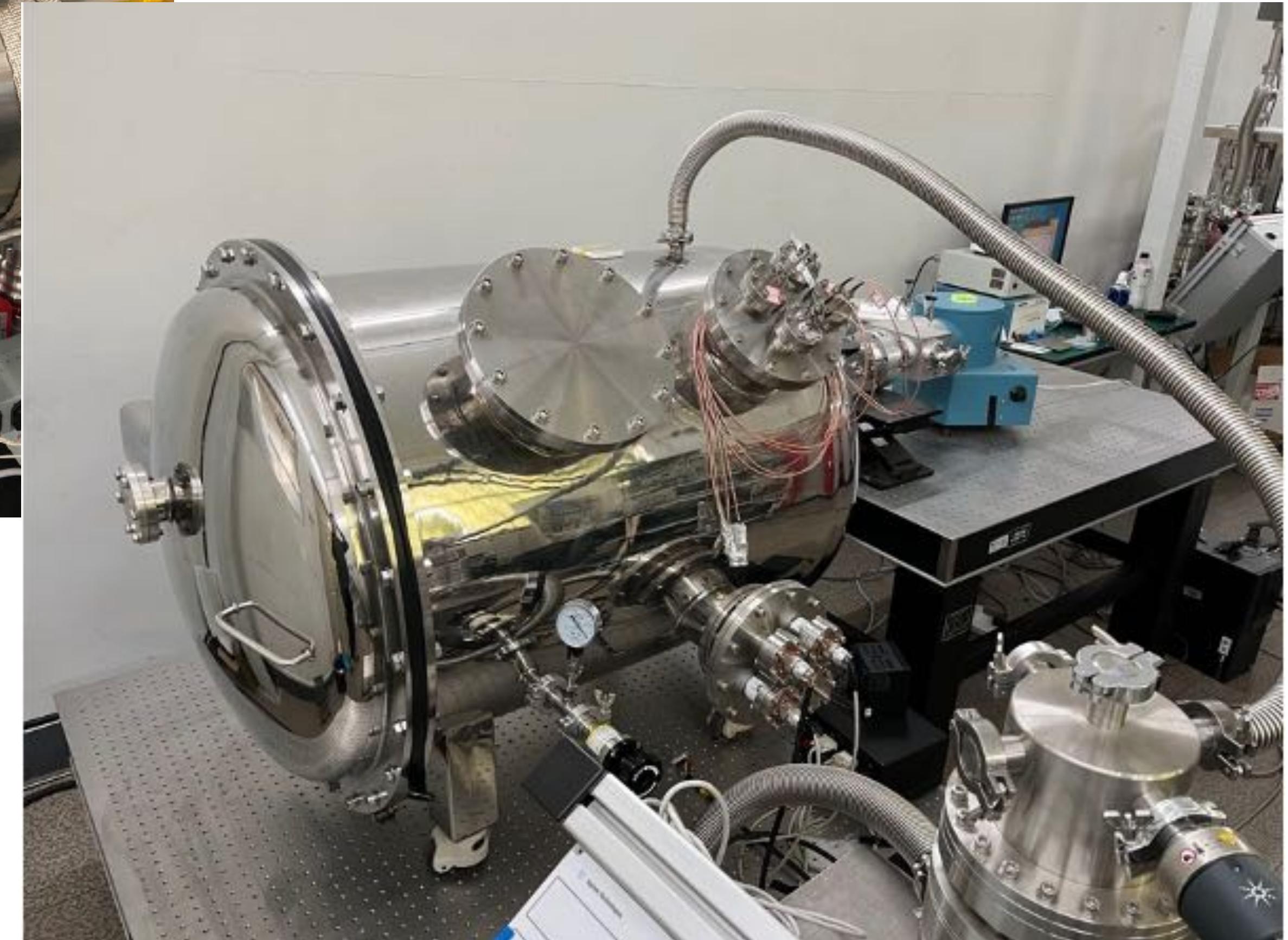
nEXO Testing setups: Dark and PDE measurements



TRIUMF Setup



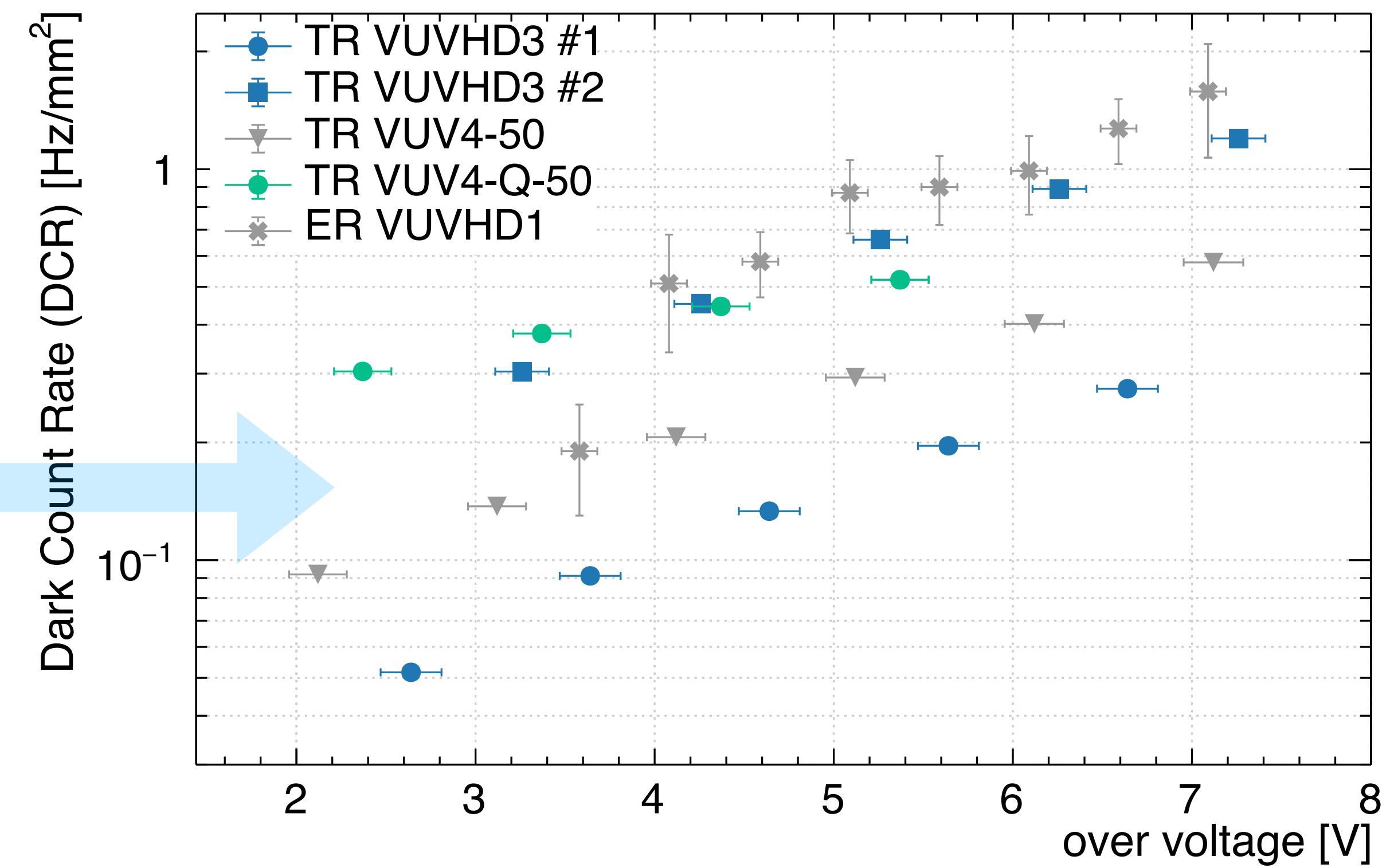
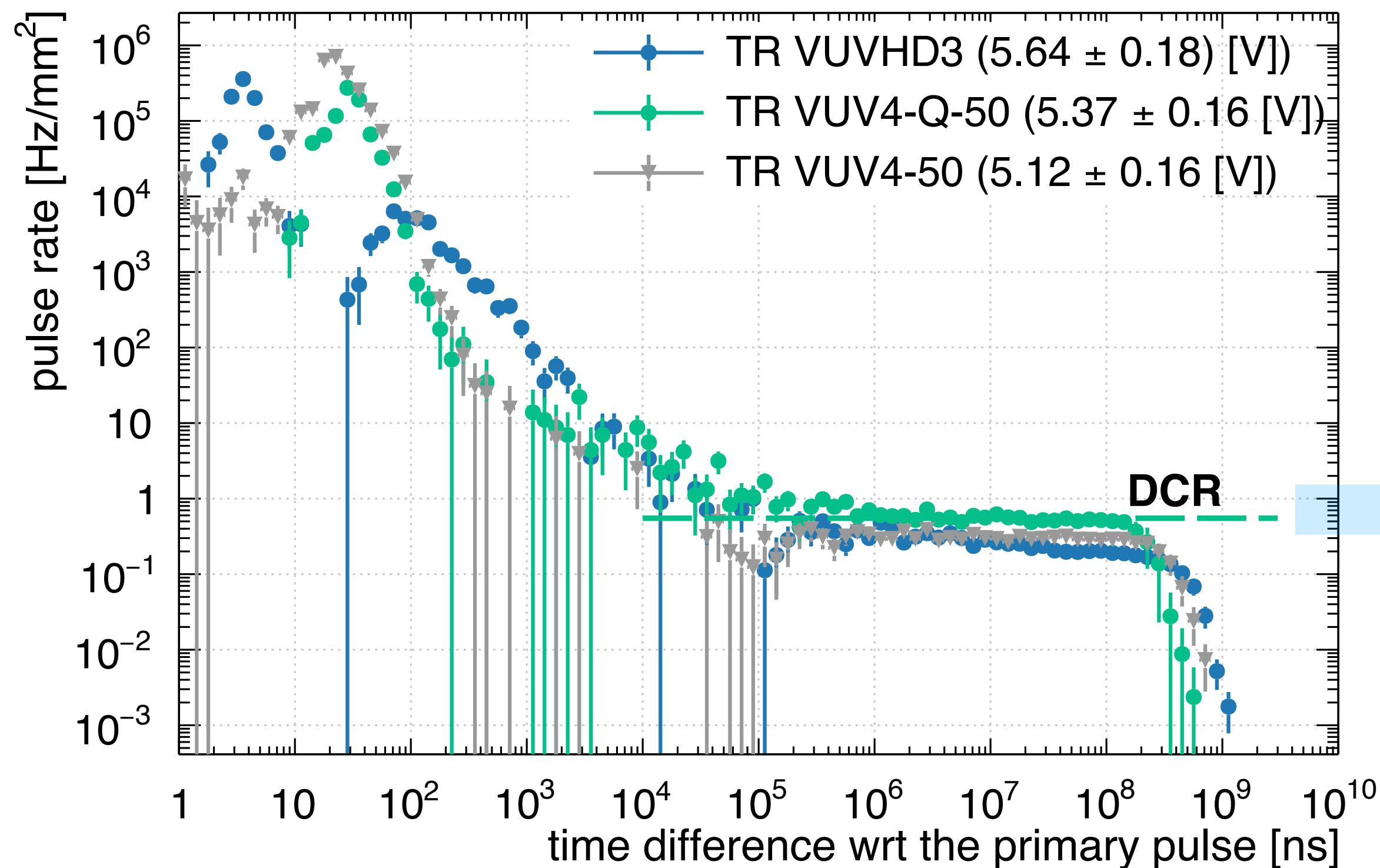
IHEP Setup



Dark Count Rate (DCR)

Grey points!

Computed using time differences between pulses as shown in 10.1016/j.nima.2017.08.035



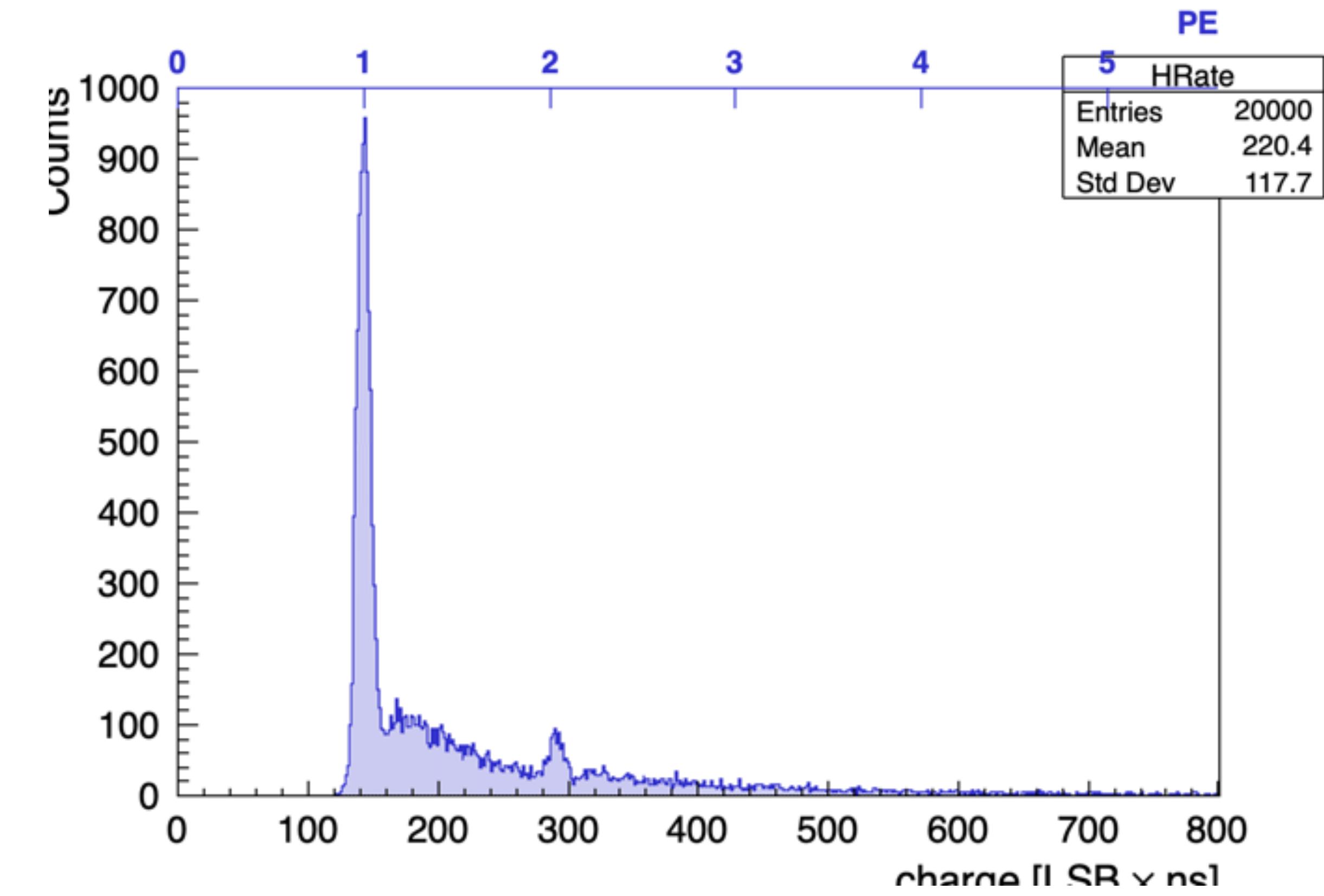
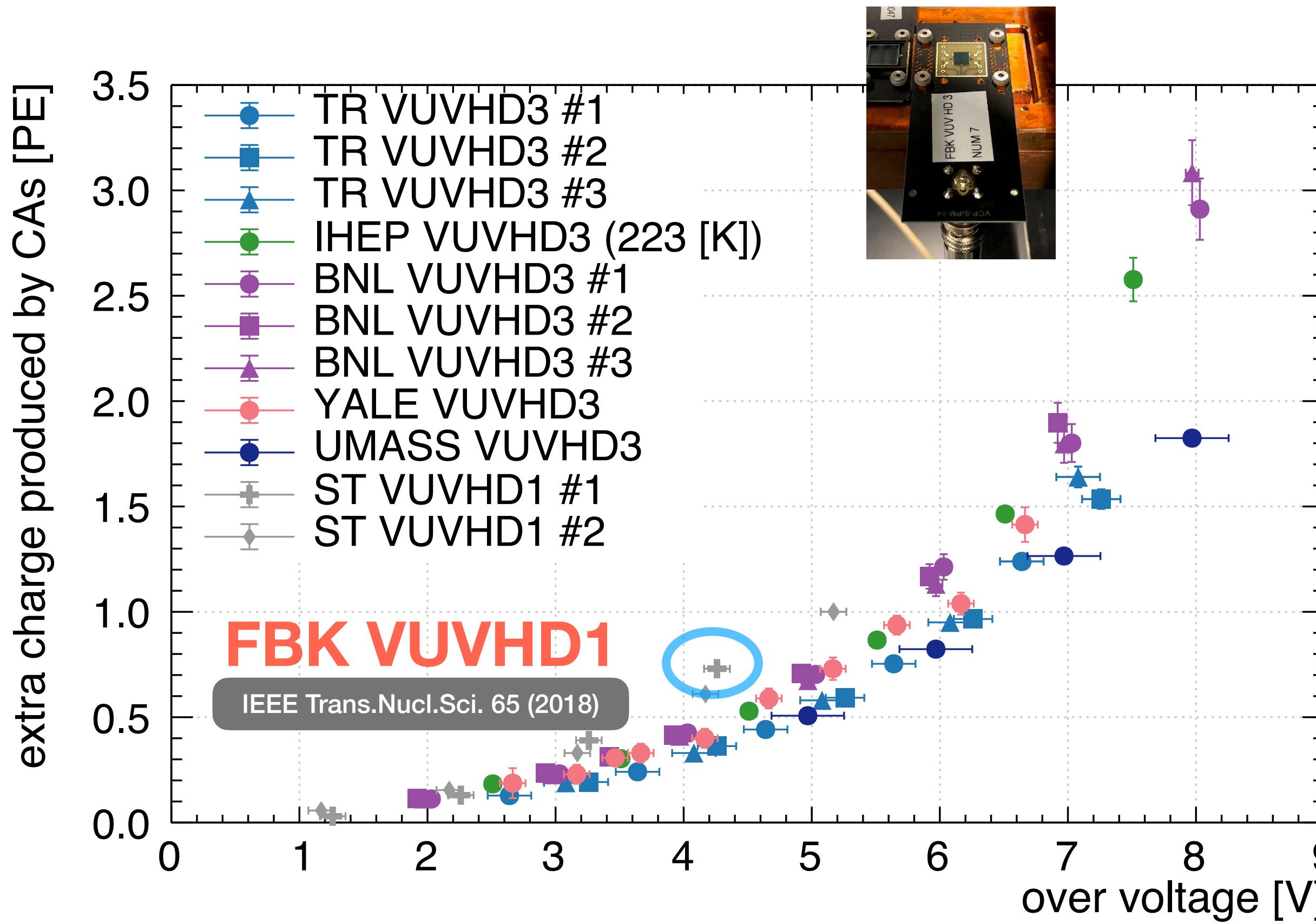
Requirement at 163 [K]: DCR < 10 Hz/mm²

- Requirement met in the entire range of OV studied!

Correlated Avalanches FBK VUVHD3

$$\text{CAF} \equiv \frac{\sigma_{\Lambda}}{1 + \langle \Lambda \rangle}$$

- Defined as the ratio between the RMS (σ_{Λ}) and the mean $\langle \Lambda \rangle$ extra charge procured by correlated avalanches (CA) per pulse

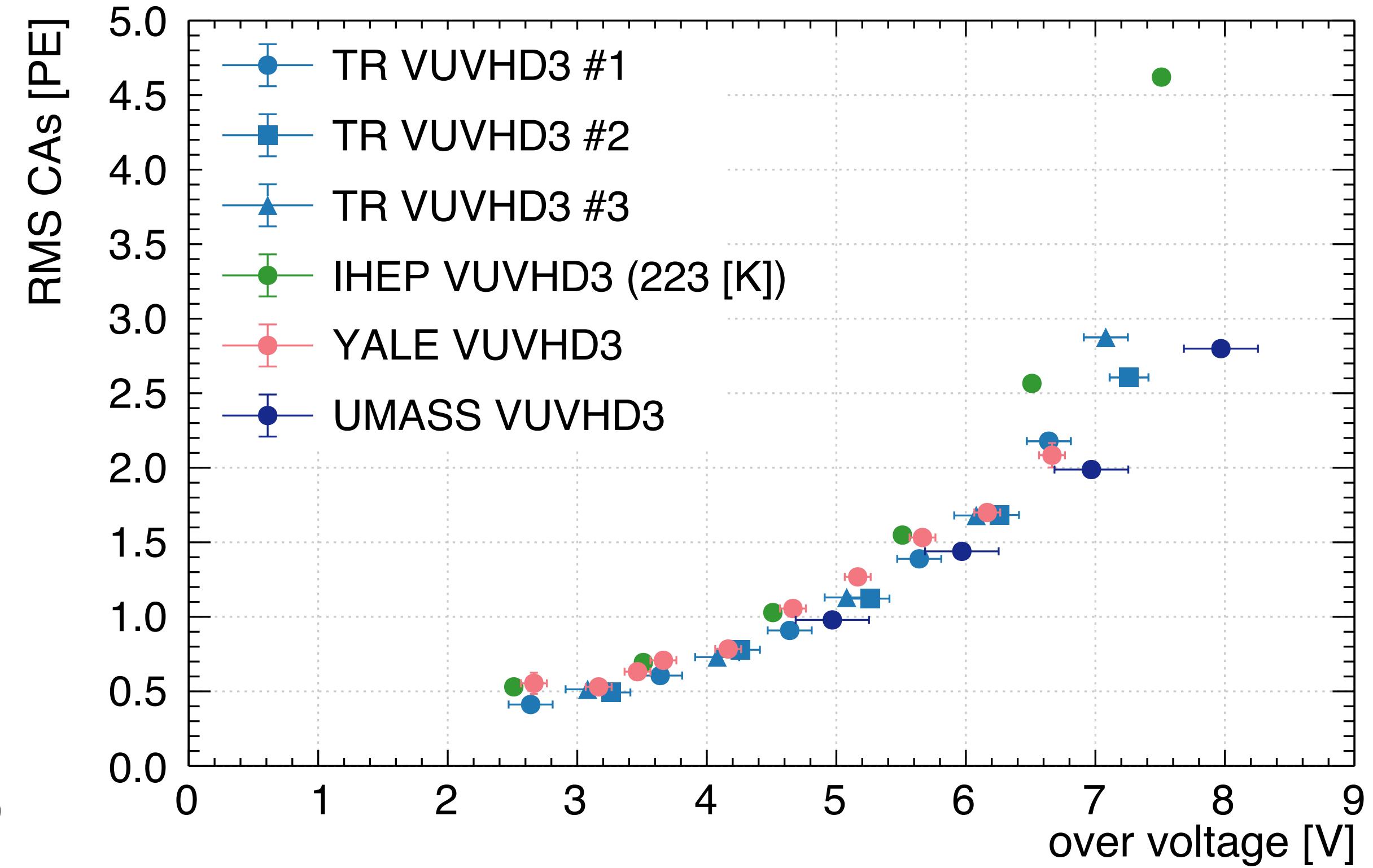
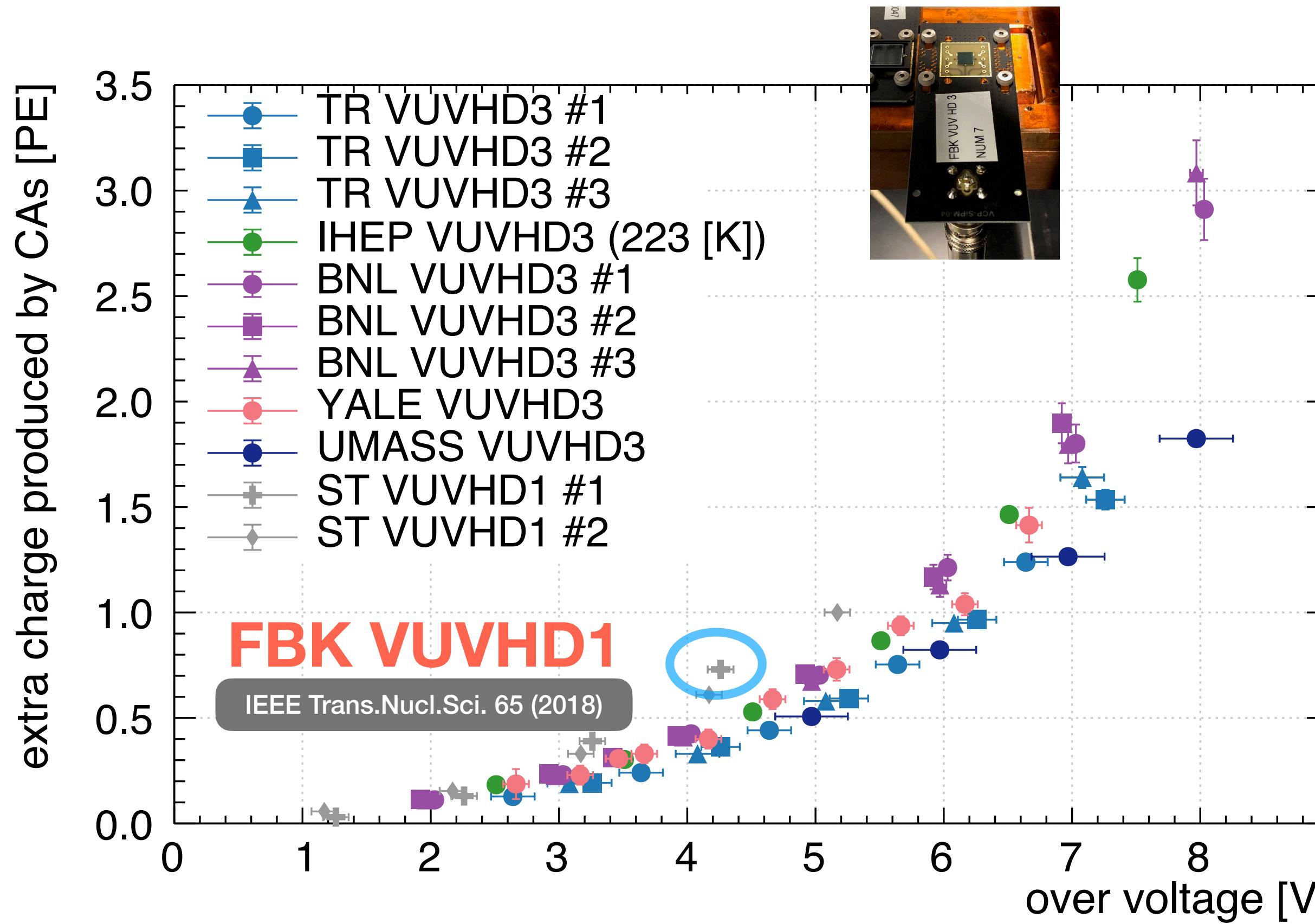


- FBK VUVHD3** is improved compare to **FBK VUVHD1**.

Correlated Avalanches FBK VUVHD3

$$\text{CAF} \equiv \frac{\sigma_{\Lambda}}{1 + \langle \Lambda \rangle}$$

- Defined as the ratio between the RMS (σ_{Λ}) and the mean $\langle \Lambda \rangle$ extra charge procured by correlated avalanches (CA) per pulse ²⁰

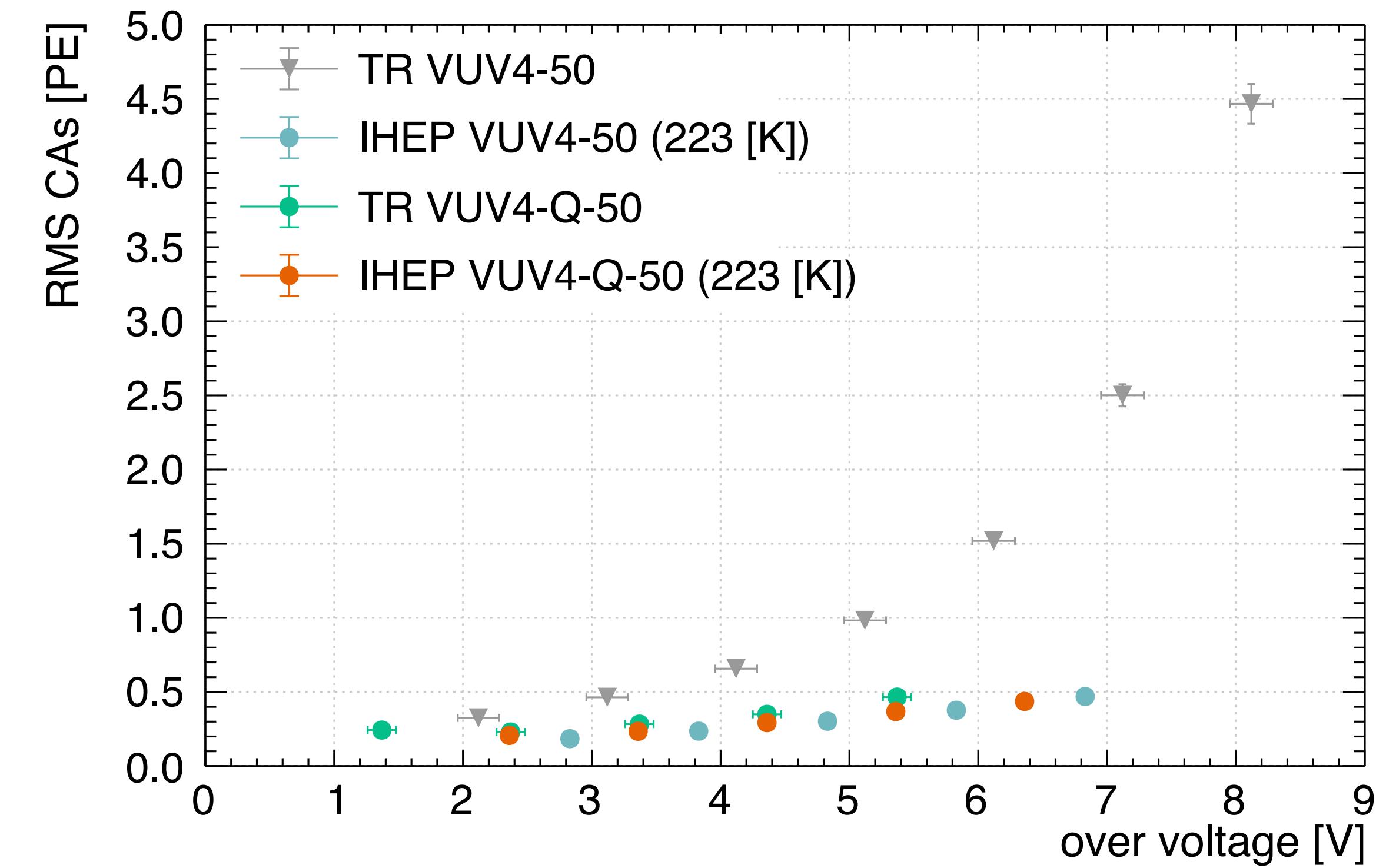
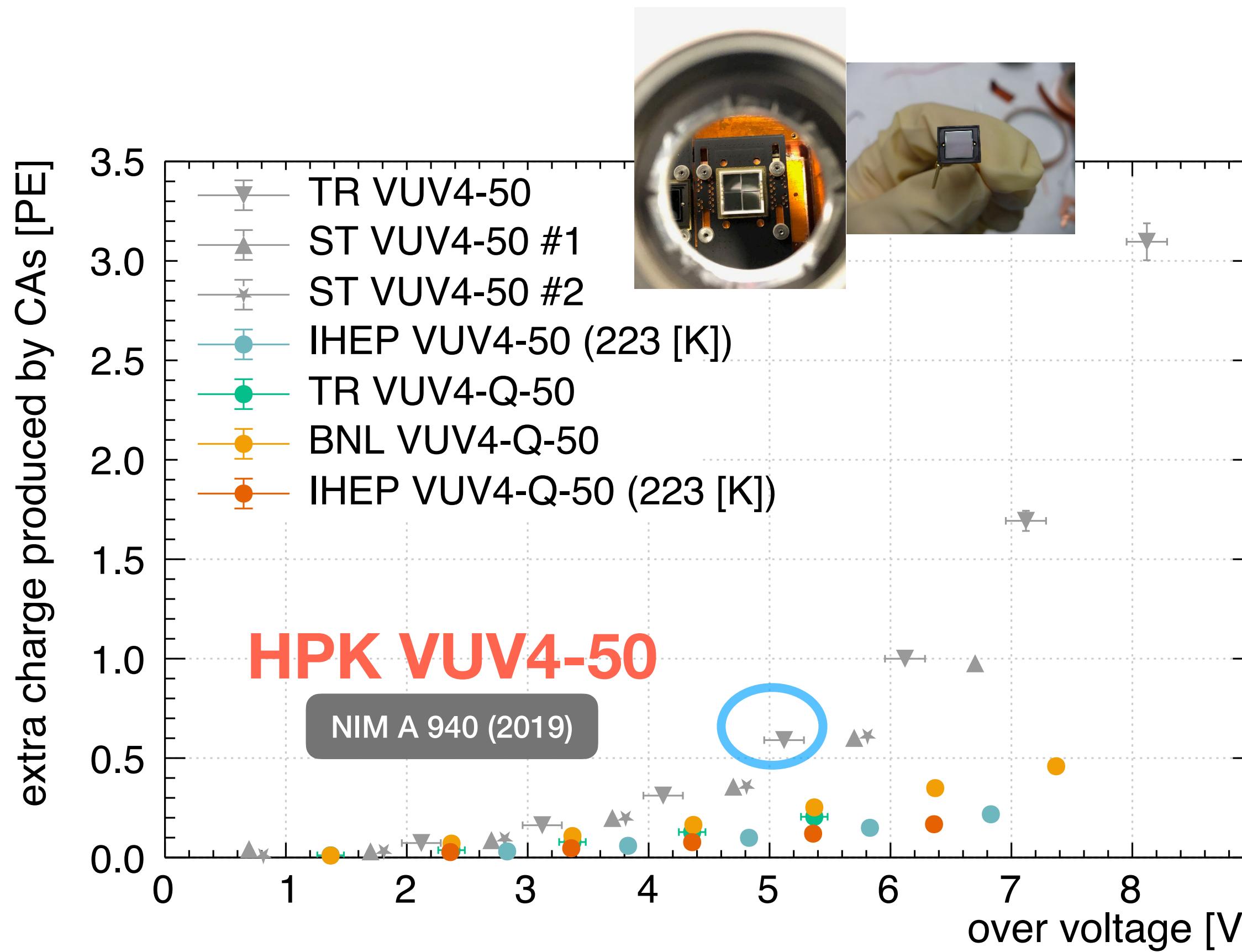


- FBK VUVHD3** is improved compare to **FBK VUVHD1**.

Correlated Avalanches HPK VUV4 MPPCs

$$\text{CAF} \equiv \frac{\sigma_{\Lambda}}{1 + \langle \Lambda \rangle}$$

- Defined as the ratio between the RMS (σ_{Λ}) and the mean $\langle \Lambda \rangle$ extra charge procured by correlated avalanches (CA) per pulse



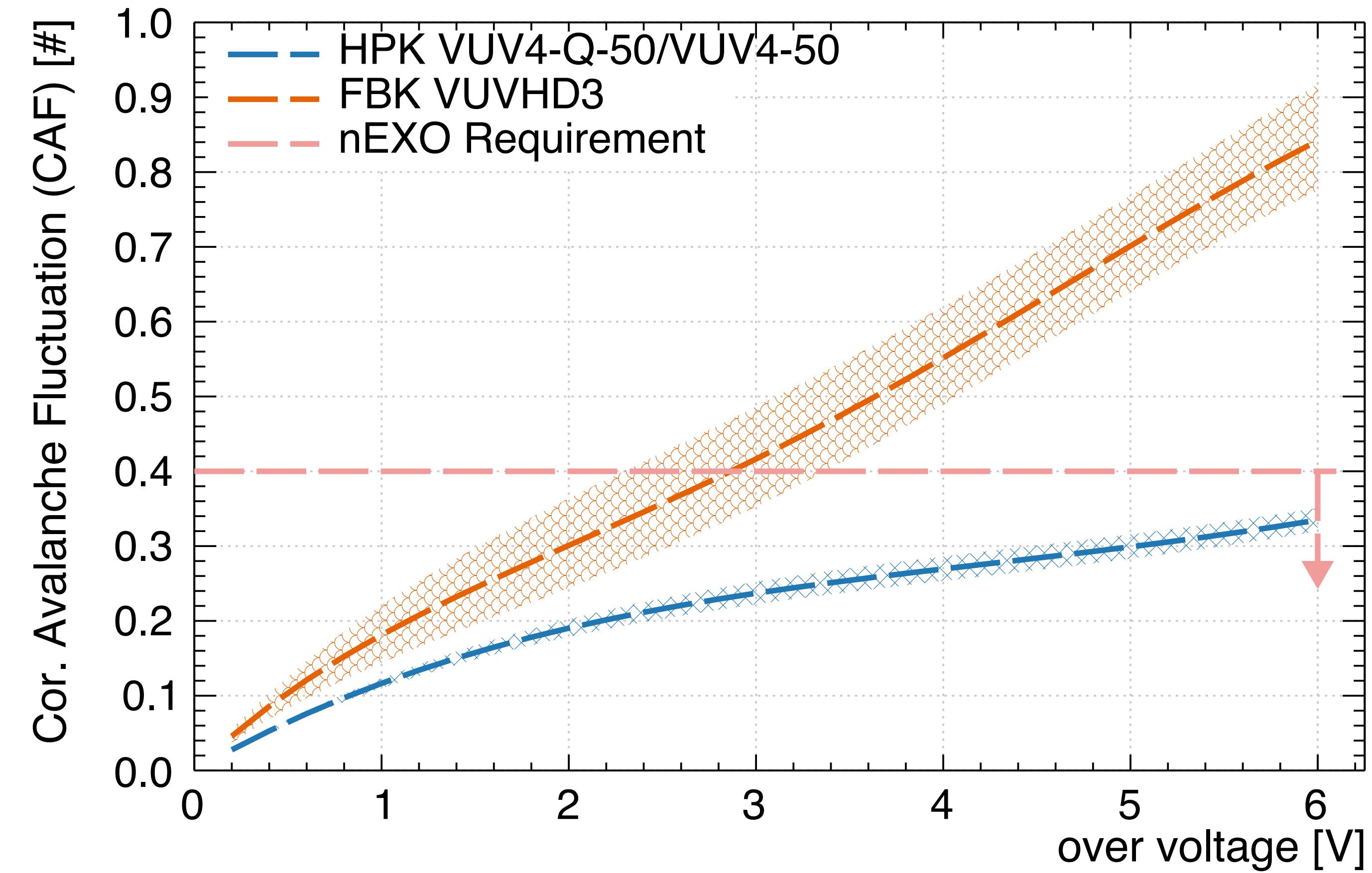
- HPK VUV4 has almost no correlated avalanches (CA) and it is significantly better than the HPK VUV4-50 tested previously

Correlated Avalanche Fluctuation (CAF)

- Defined as the ratio between the RMS (σ_{Λ}) and the mean $\langle \Lambda \rangle$ extra charge procured by correlated avalanches (CA) per pulse

$$\text{CAF} \equiv \frac{\sigma_{\Lambda}}{1 + \langle \Lambda \rangle} < 0.4$$

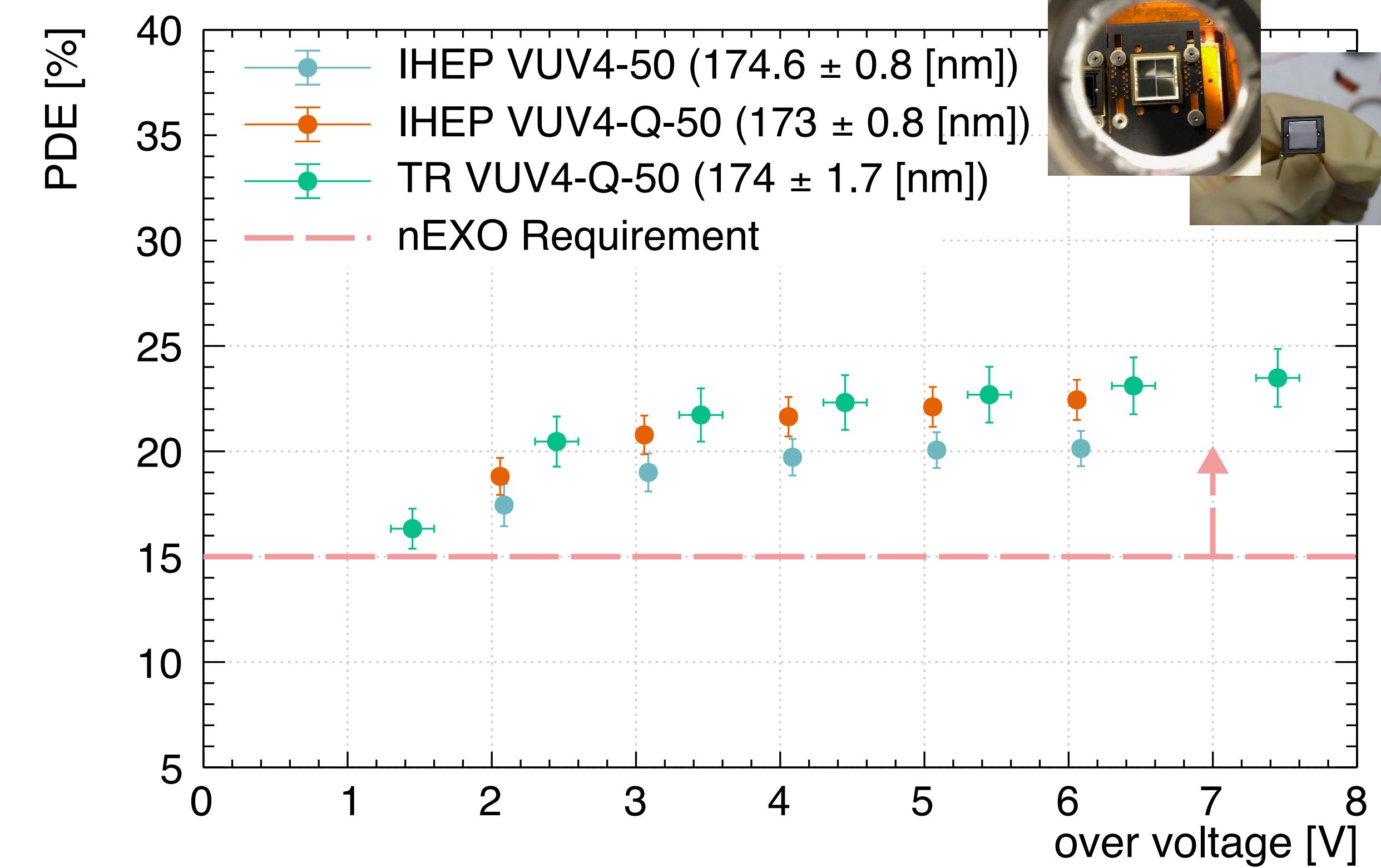
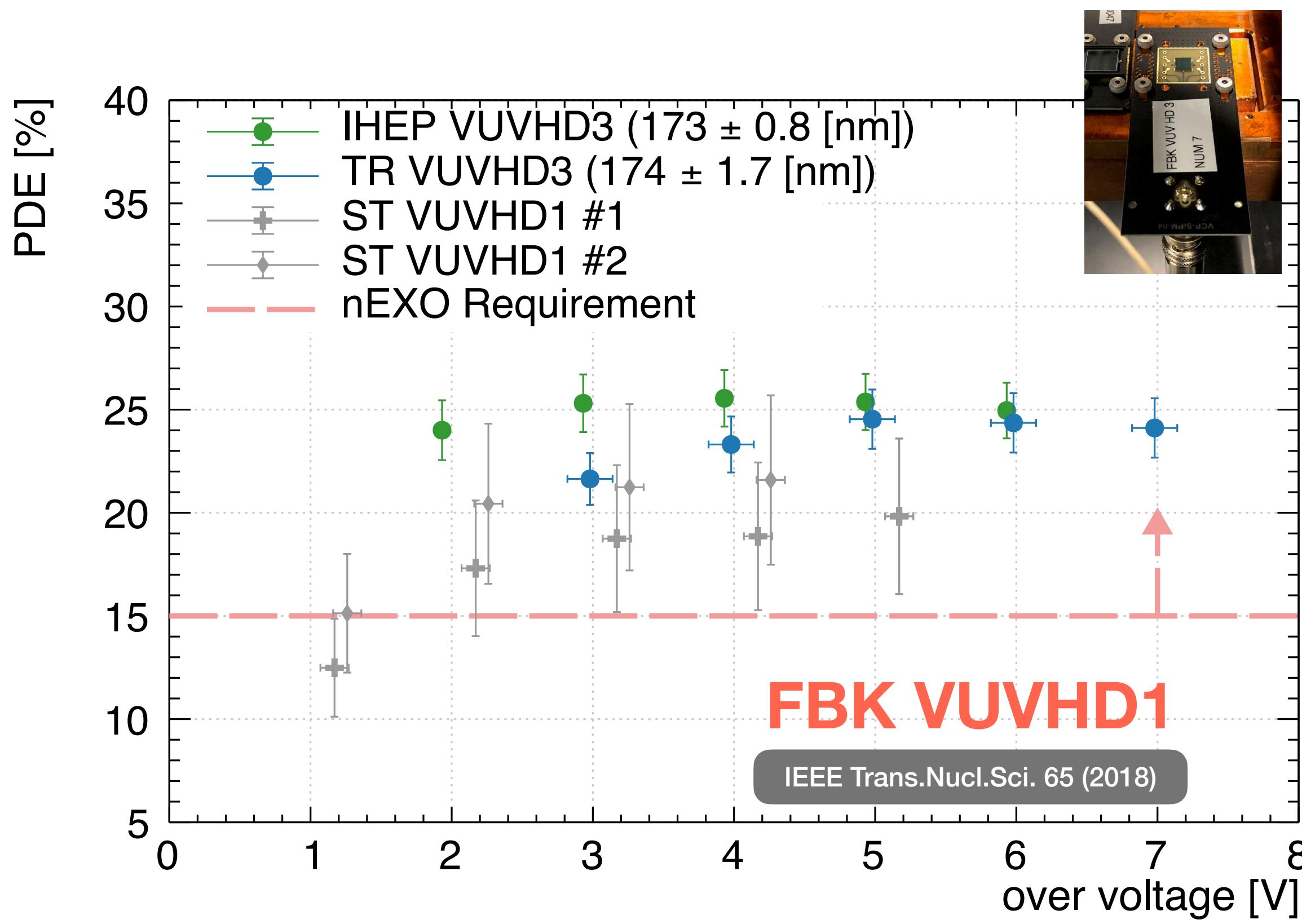
- The error bars **account for the spread** between different measurements
- HPK MPPCs **satisfies the requirement** in the entire range of OV studied
- FBK VUVHD3 **satisfies the requirement up to 3/3.5 V** of OV



Requirement at 163 [K]: CAF < 0.4

Photon Detection Efficiency (PDE) at 174 nm at 163 K

- PDE has been measured by TRIUMF and IHEP at 163 K and 233 K, respectively as a function of over voltage and wavelength²³

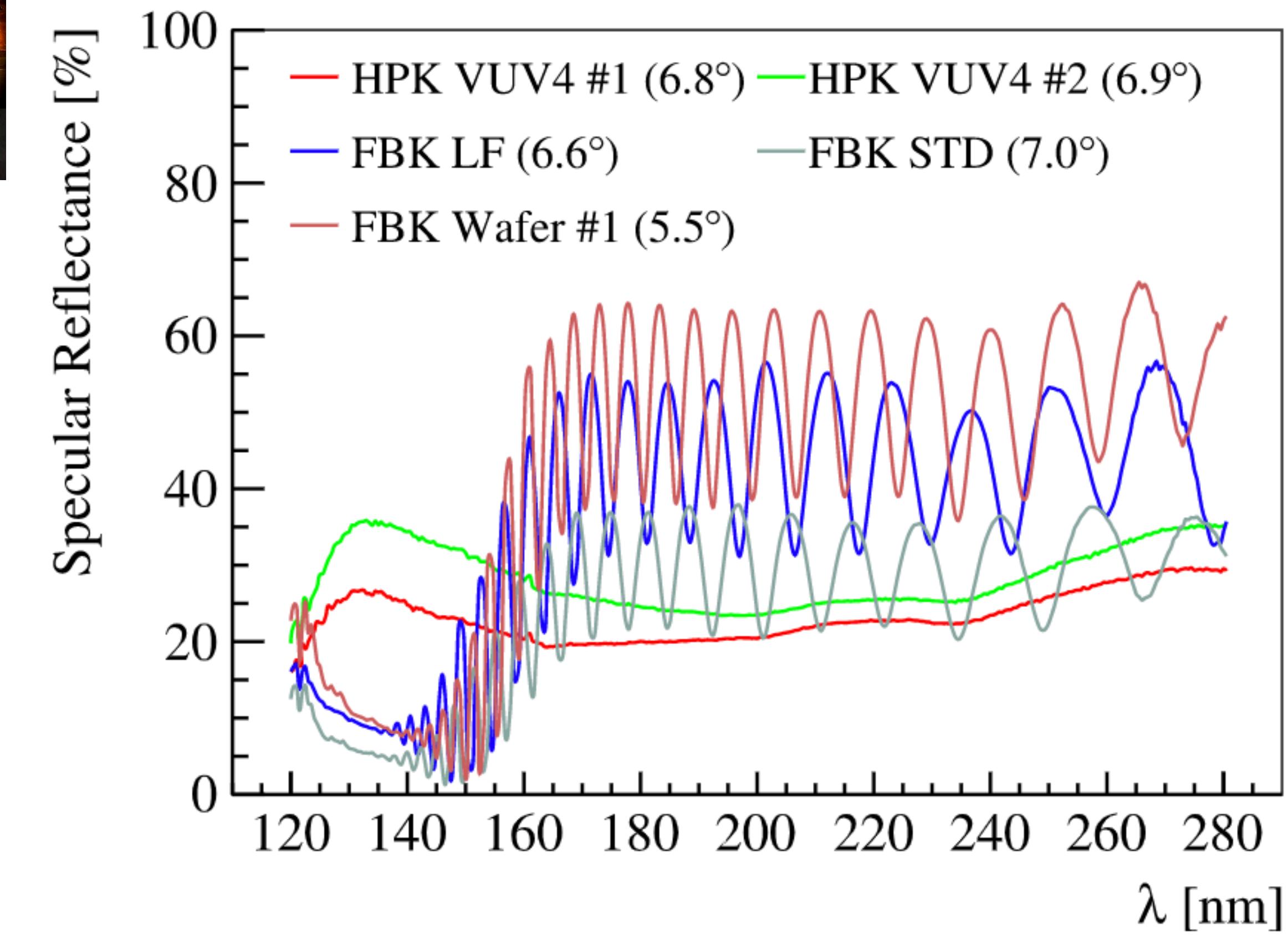
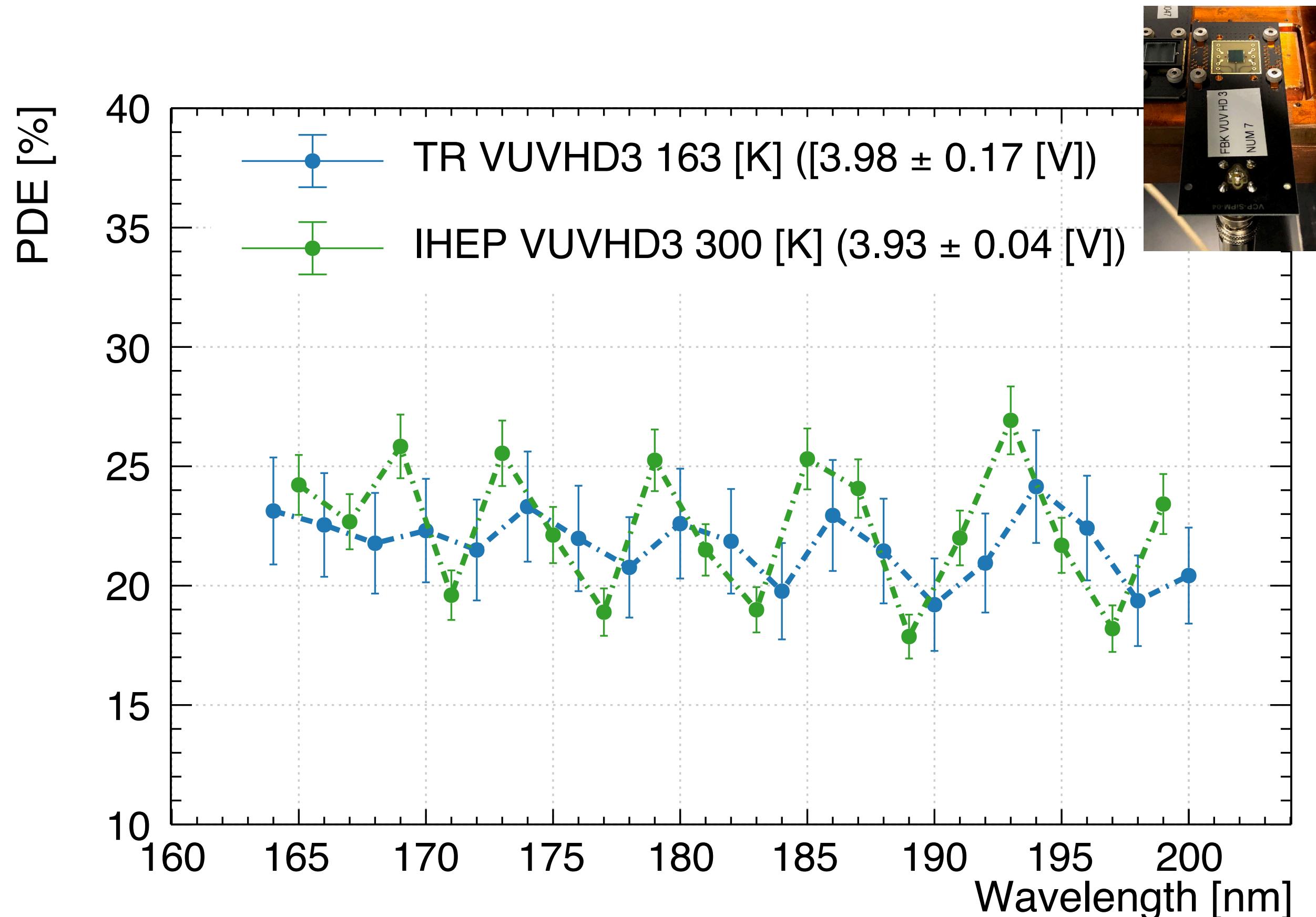


Requirement > 15% at ~ 175 nm

Requirement met from 1.5 V of OV !

Photon Detection Efficiency (PDE) Wavelength Dependence

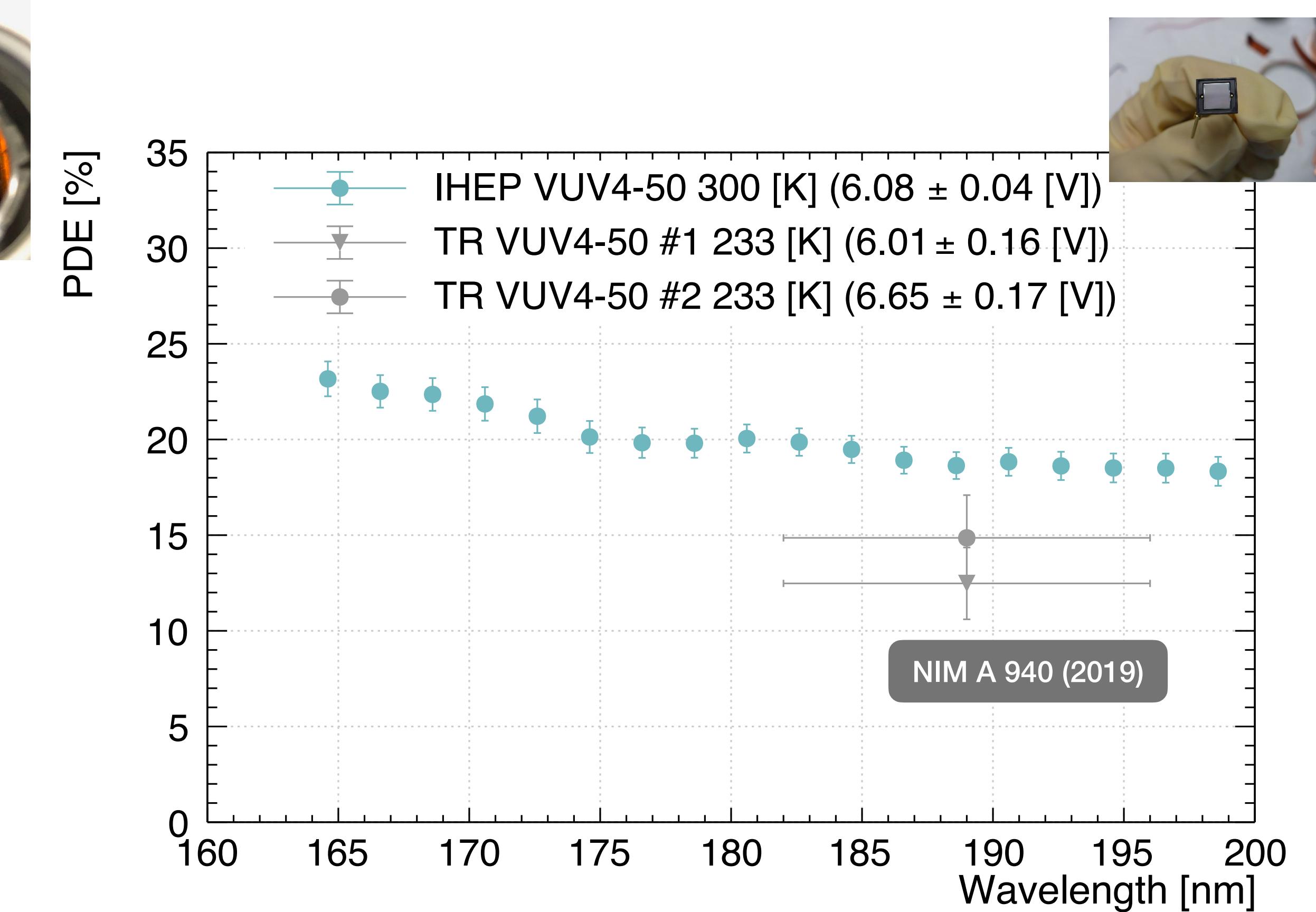
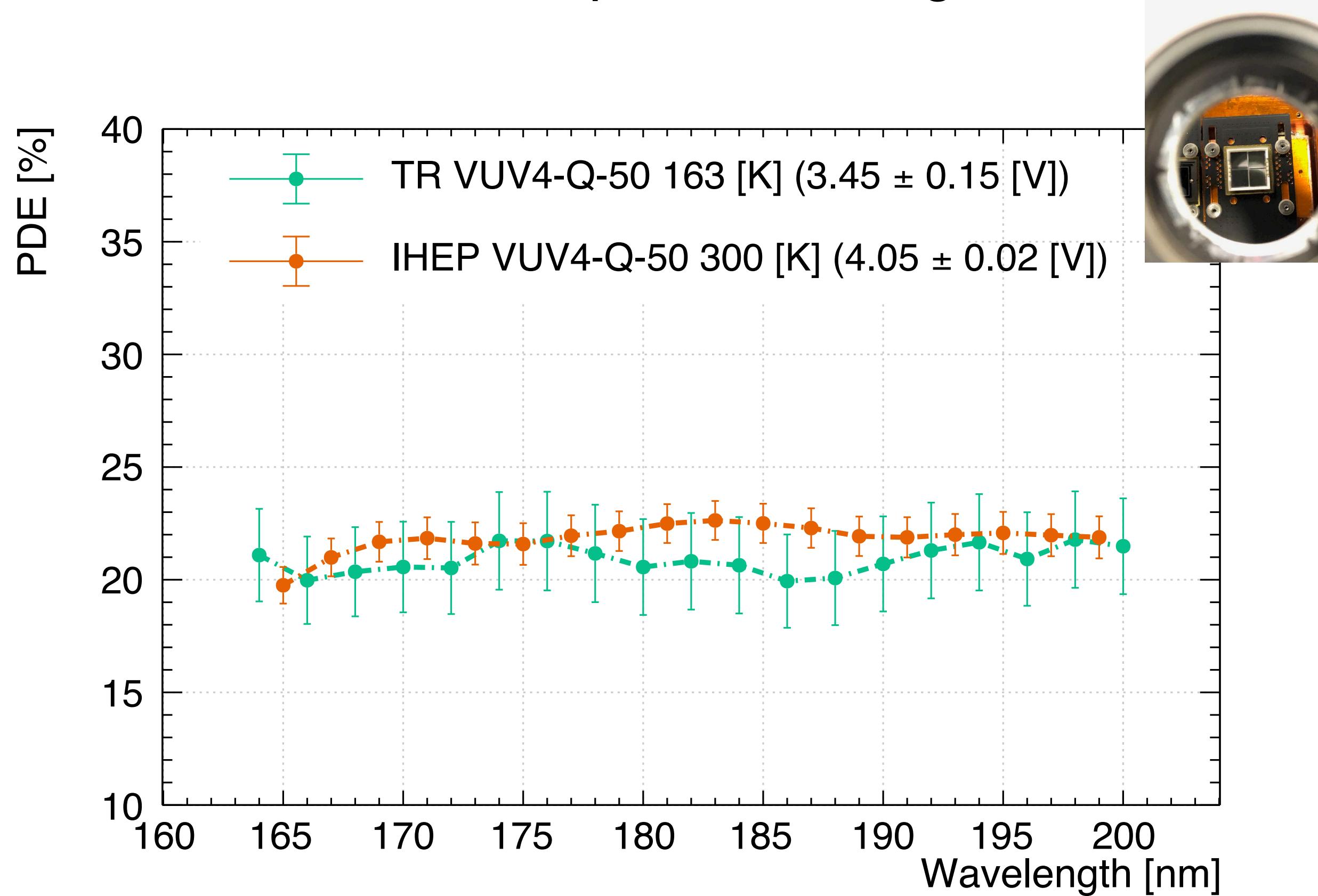
- LXe scintillation spectrum is a gaussian with a mean of 174.8 nm and a STD of 4.33 nm²⁴



- FBK thin film interference in the SiO₂ top layer. Compatible with specular reflectivity measurements done at IHEP and published in 10.1109/TNS.2020.3035172

Photon Detection Efficiency (PDE) Wavelength Dependence

- LXe scintillation spectrum is a gaussian with a mean of 174.8 nm and a STD of 4.33 nm



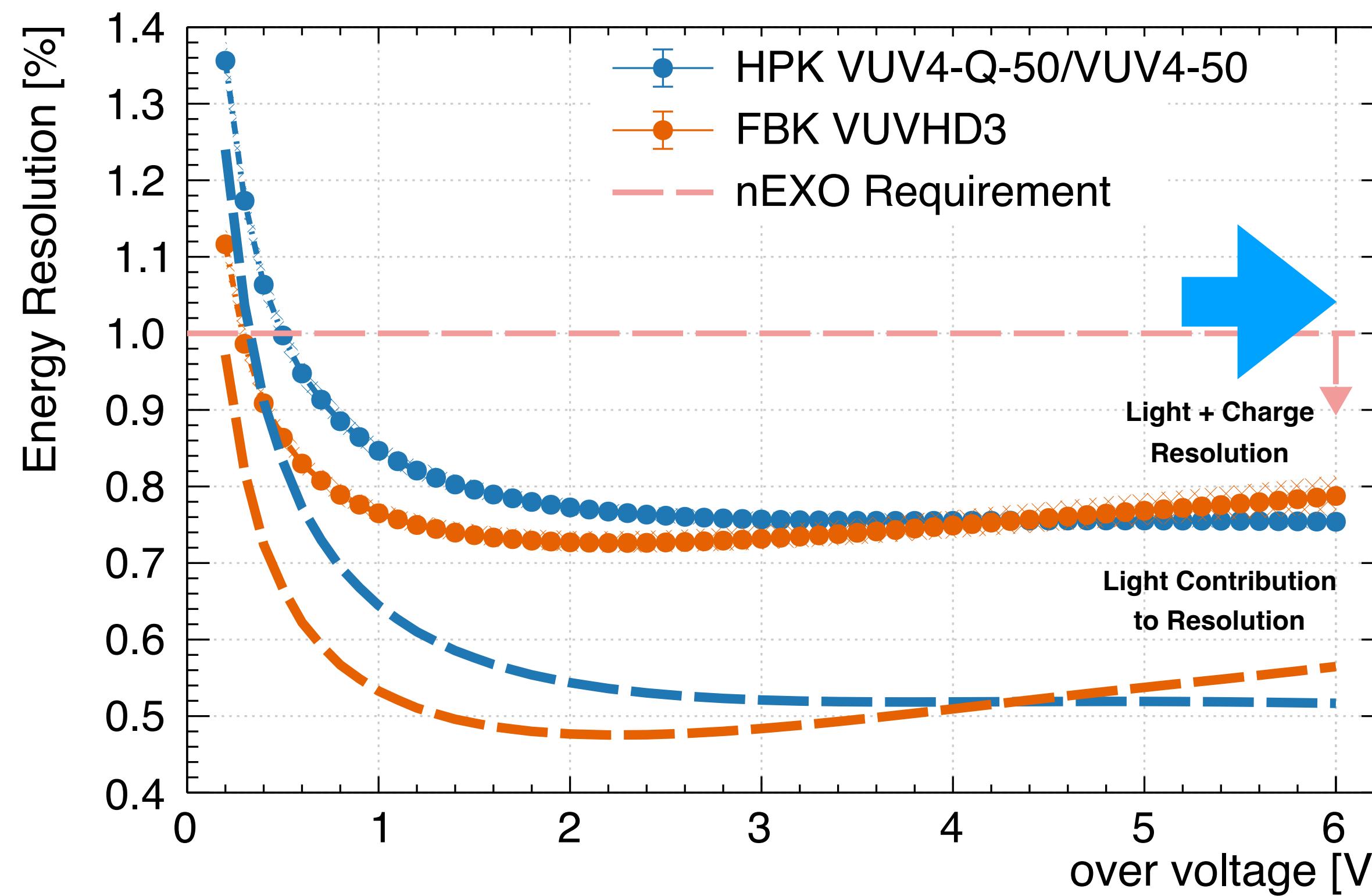
- HPK MPPCs Quad devices have an efficiency higher of the corresponding single package 50um pitch device

nEXO Energy Resolution at (2458 keV for ^{136}Xe)

arXiv:2209.07765

26

$$\frac{\sigma_n}{\langle n \rangle} = \sqrt{\left(\frac{(1 - \epsilon_p)n_p}{\epsilon_p} + \frac{n_p}{\epsilon_p} \cdot \frac{\sigma_{\Lambda}^2}{(1 + \langle \Lambda \rangle)^2} + n_p^2 \sigma_{lm}^2 \right) + \left(\frac{n_q t}{\tau} + \frac{\sigma_{q,noise}^2}{\epsilon_q^2} \right)}$$



PDE drives the minimum. **Need to better understand SiPM PDE**
eCT is not yet accounted . **See talk on Thursday**

nEXO Requirement: $\frac{\sigma_n}{\langle n \rangle} \leq 1 \%$

Fluctuation due to number
of photons detected (PDE)

Fluctuation Due to
Correlate Avalanche Noise
(CA/RMS)

Residual Calibration
Uncertainty

Fluctuation due to the
number of charges detected

Fluctuation due to
electronic noise in charge
channel

Understanding SiPM PDE

SiPM Photon-Detection Efficiency

28

The Photo-Detection-Efficiency (PDE) is defined as the probability for a photon (of a given wavelength) to be detected and produce a measurable signal in the SiPM.

Usually PDE is defined as

$$\text{PDE} = \text{FF} \cdot \text{QE}(\lambda) \cdot T_p(V, \lambda)$$

The diagram shows the formula for PDE enclosed in a blue box. Three arrows point from below the box to the words "Fill-Factor", "Quantum Efficiency", and "Avalanche-Triggering-Probability" respectively, indicating they are the factors multiplied together to get the PDE.

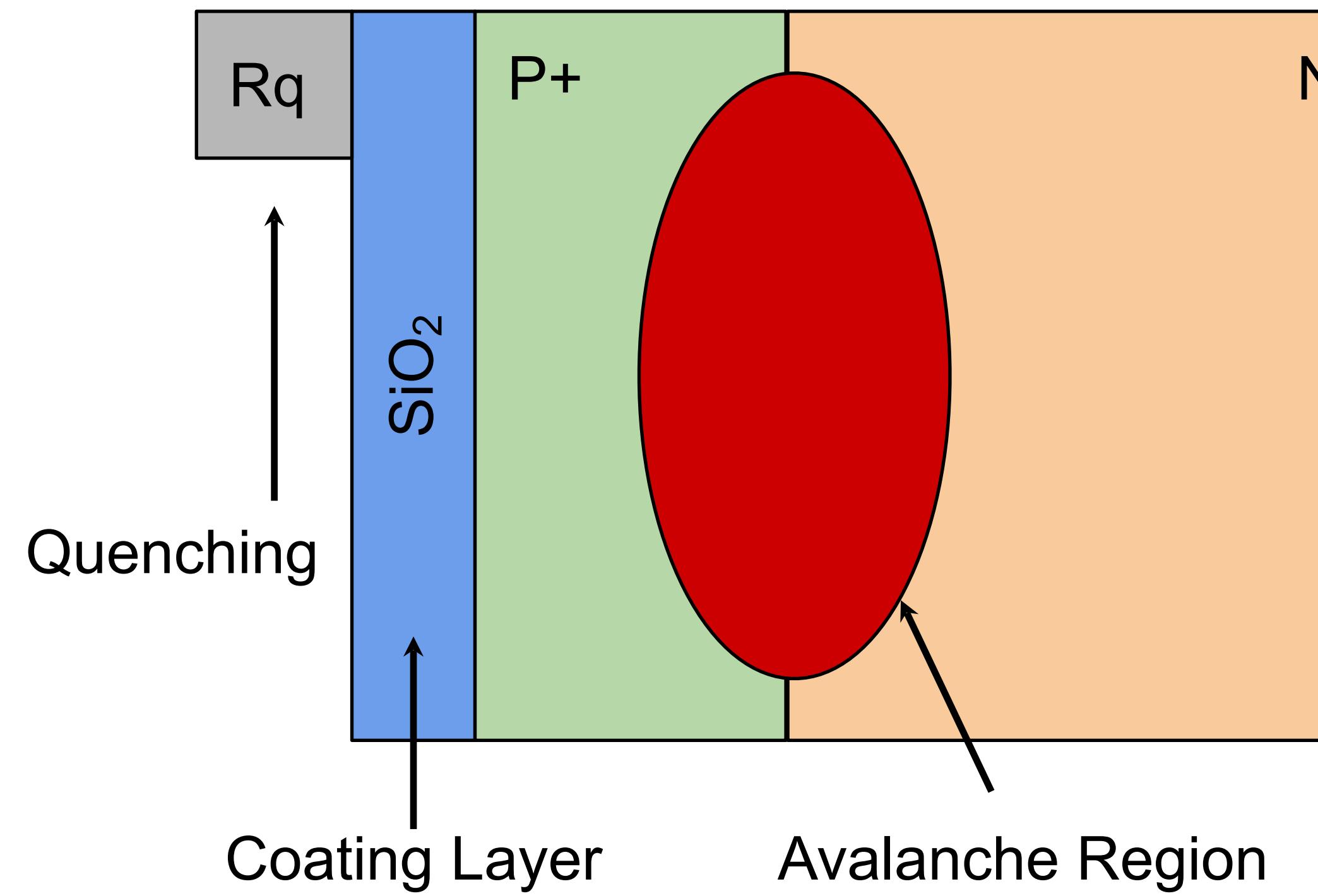
Fill-Factor Quantum Efficiency Avalanche-Triggering-Probability



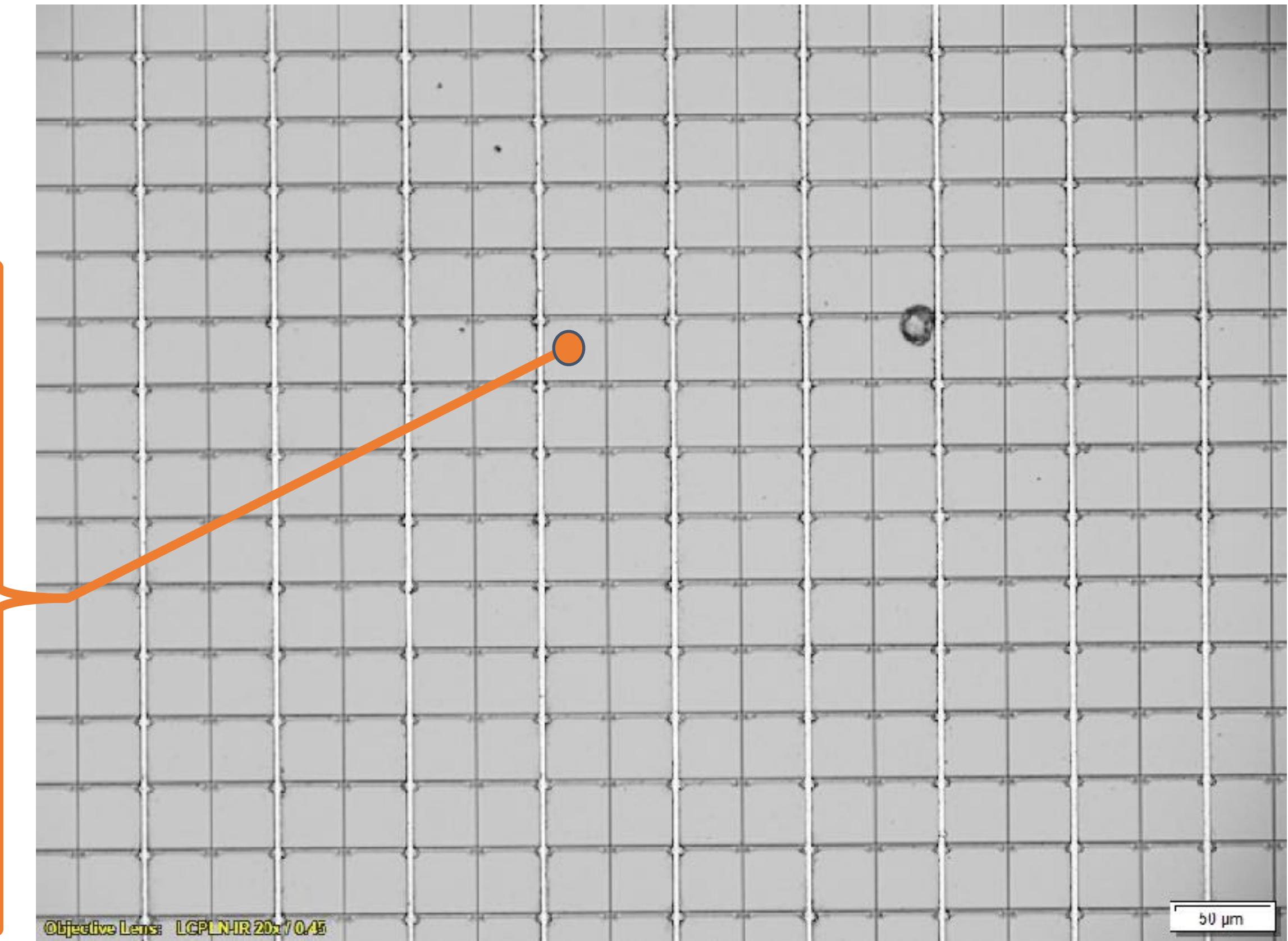
- 1) lack of formal separation between the different processes that define the total PDE.
- 2) lack of an analytical expression

How Do SiPMs work ?

p-n junctions micro-cells operated in Geiger-mode, with an added quenching resistor. Each SiPM is composed by multiple micro-cells.

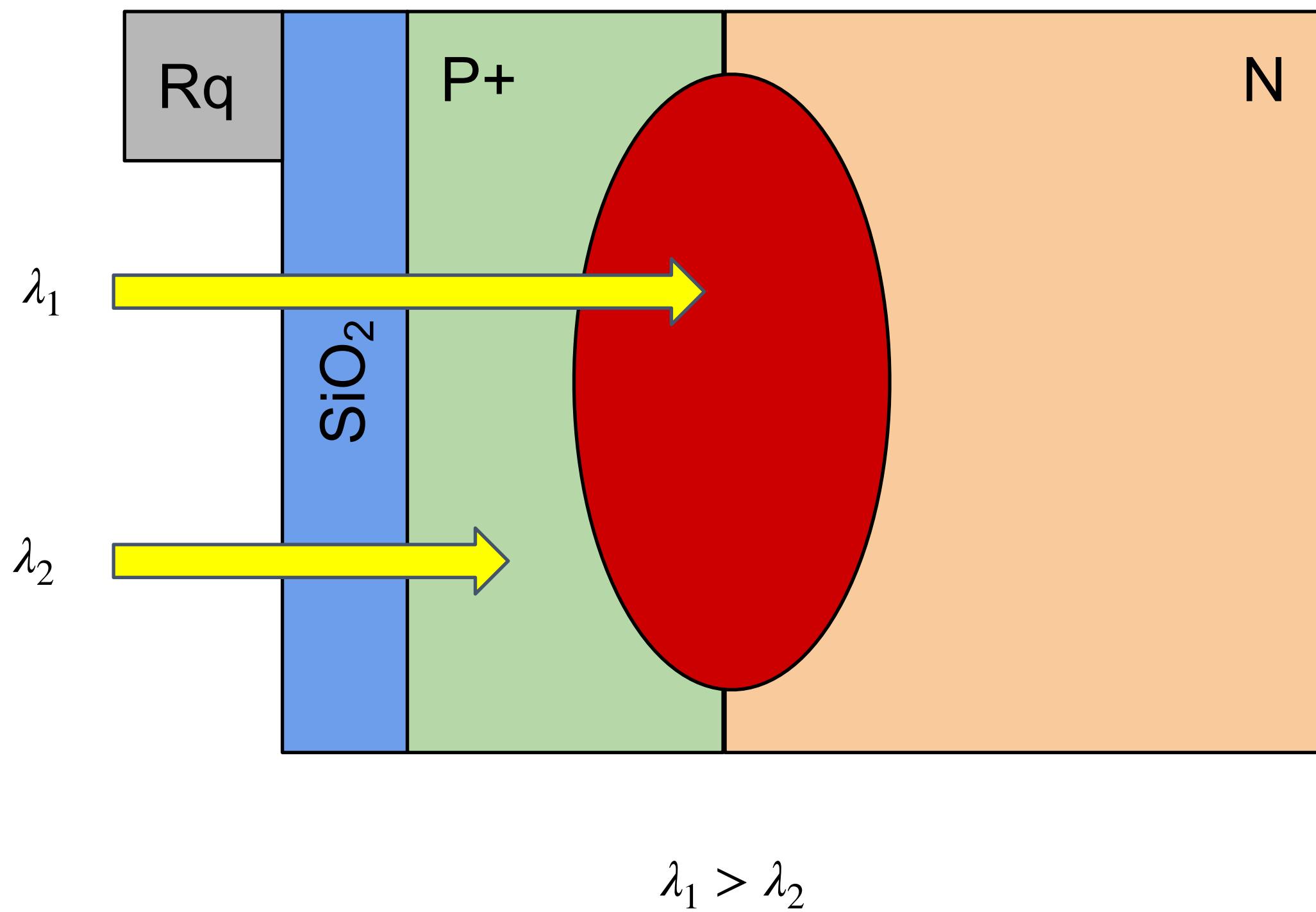


Single Micro-Cell

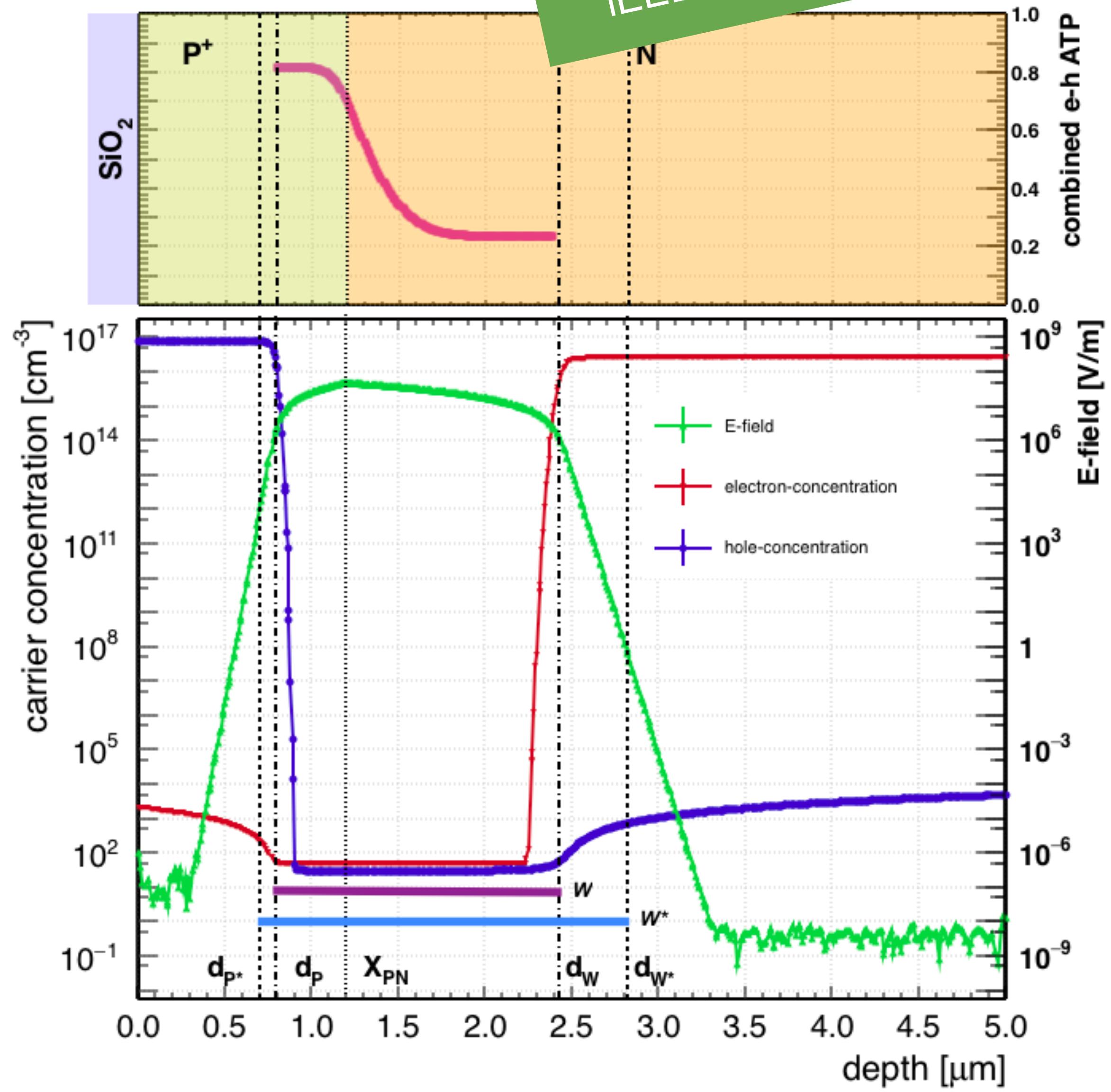


How Do SiPMs work ?

An incoming photon enters the junction and it is absorbed (wavelength dependent process : λ).

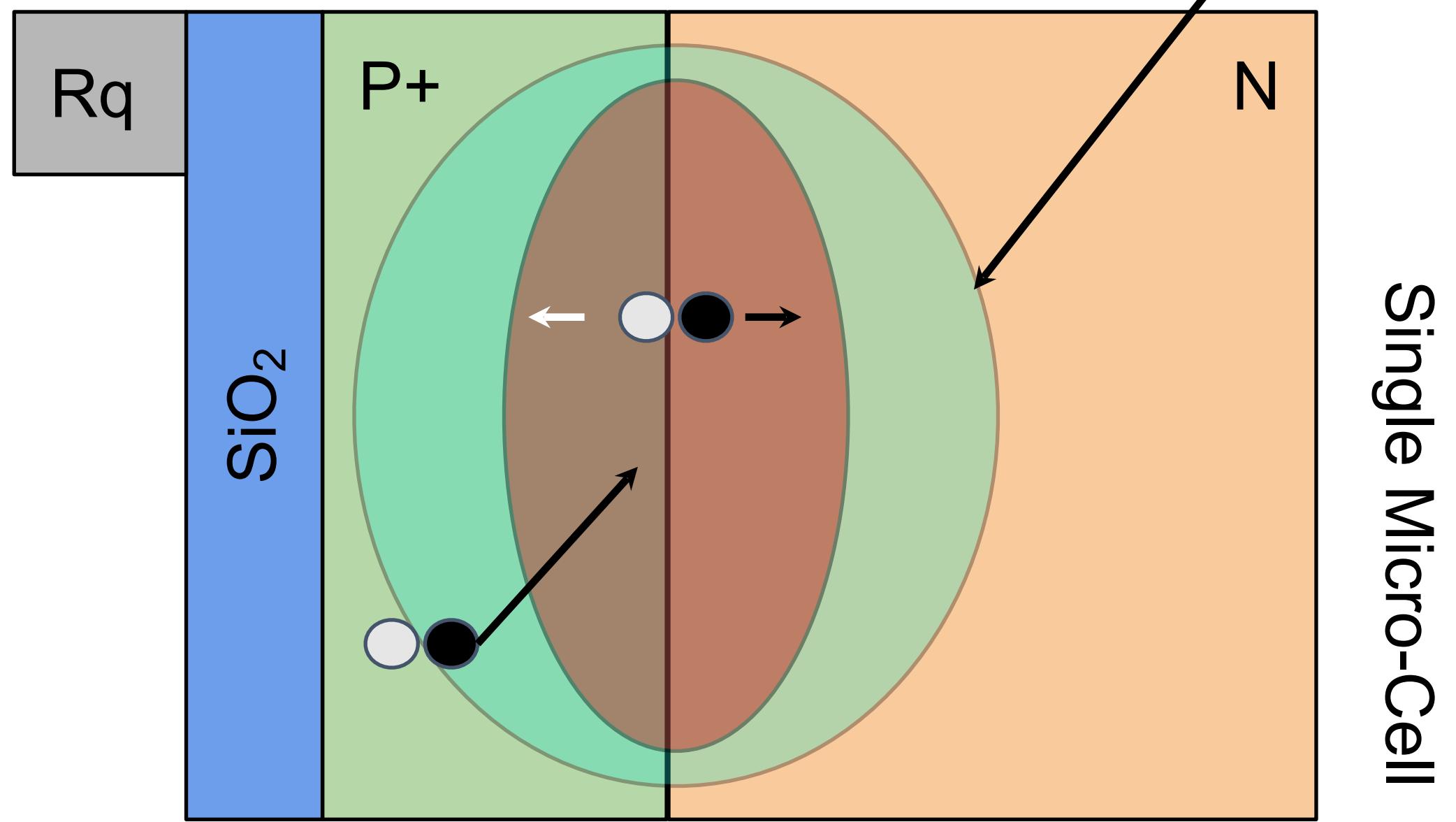


Single Micro-Cell



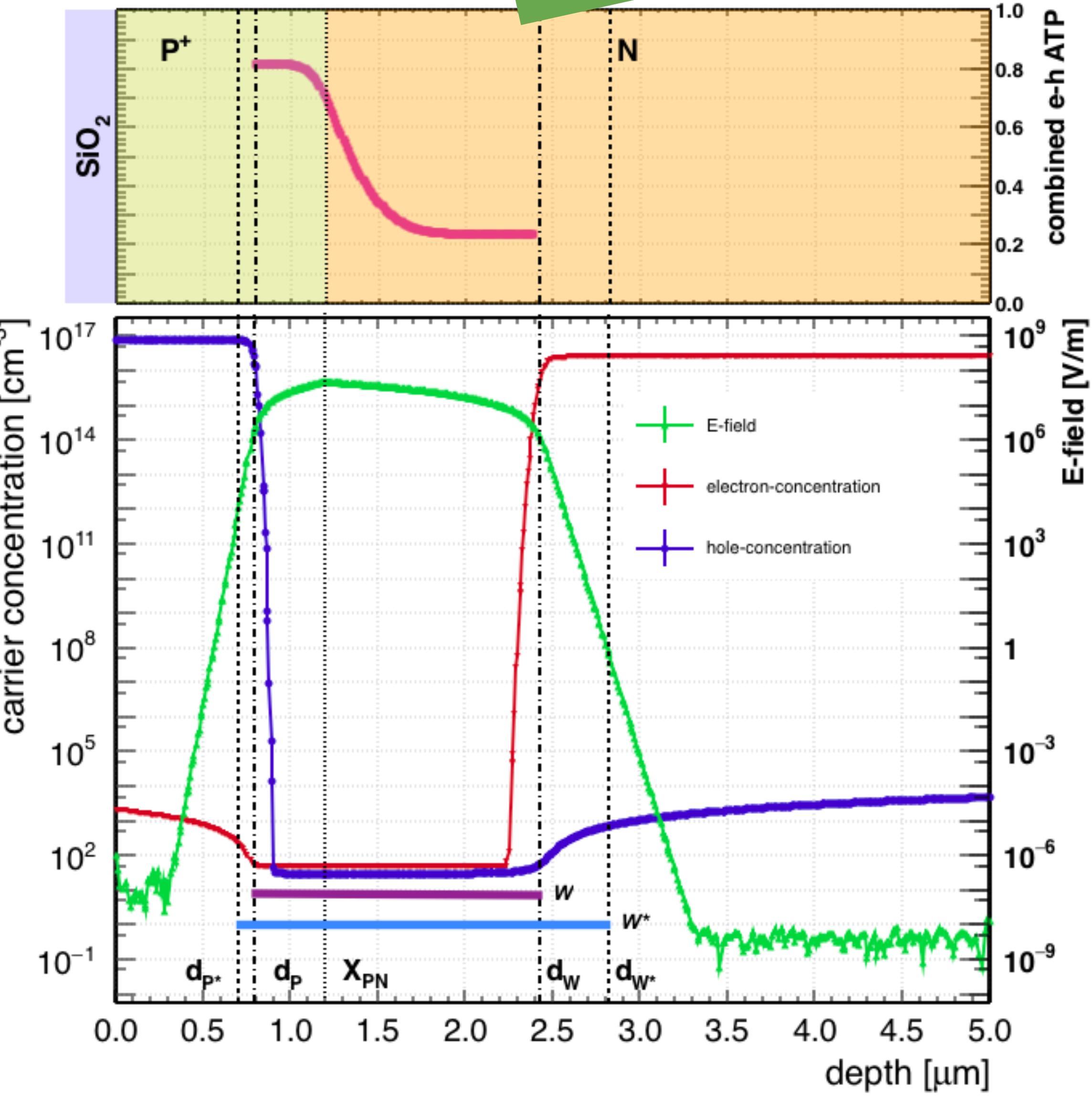
How Do SiPMs work ?

The internal field of the junction brings the generated carrier (e/h) to the avalanche region.



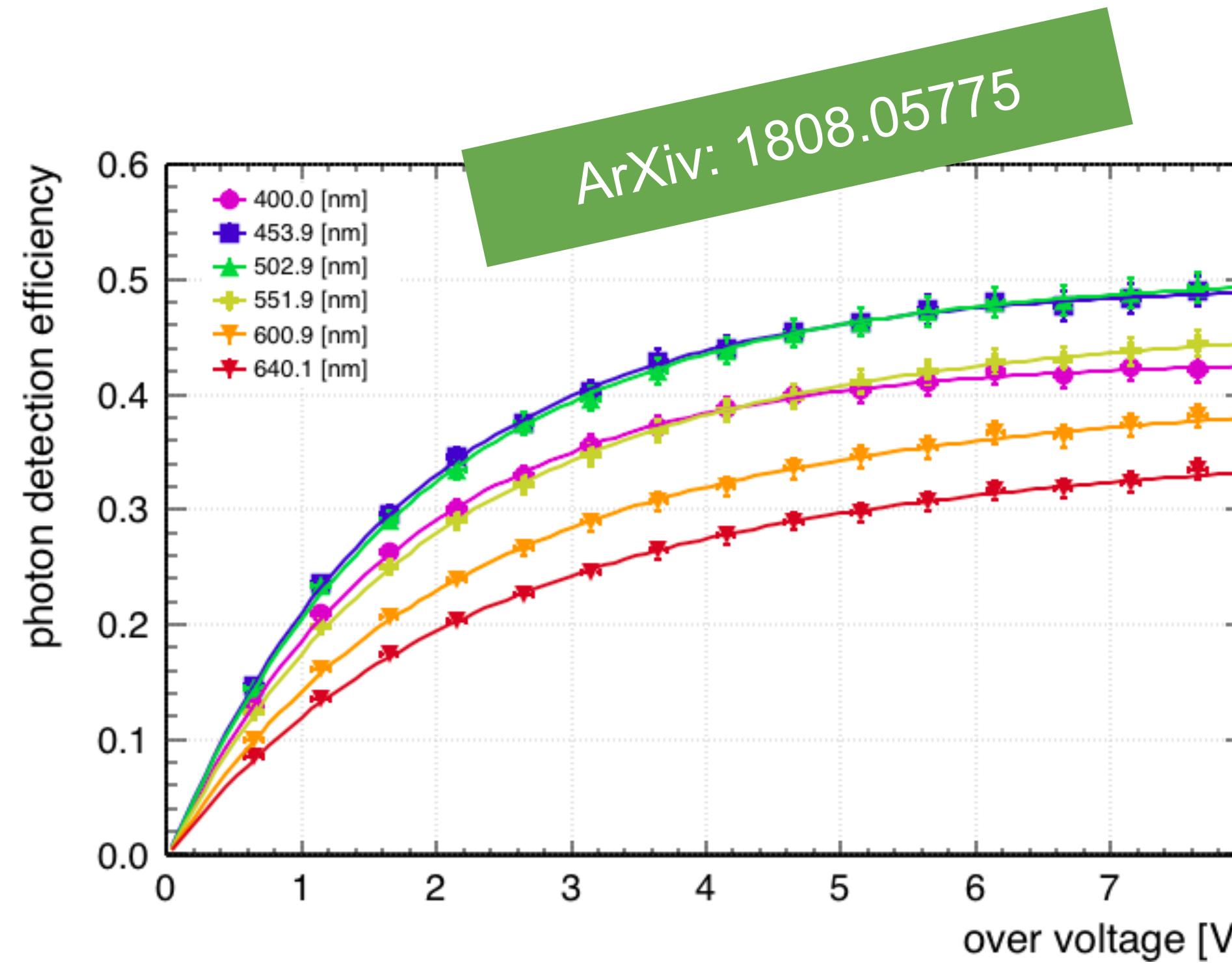
Single Micro-Cell

- 1) The e-h pair can be created or not in the depleted region.
- 2) Absorption and avalanche triggering probabilities are correlated since the latter probability depends where the photon is absorbed



Avalanche Triggering Probability

iEEE TED 66.10 (2019)

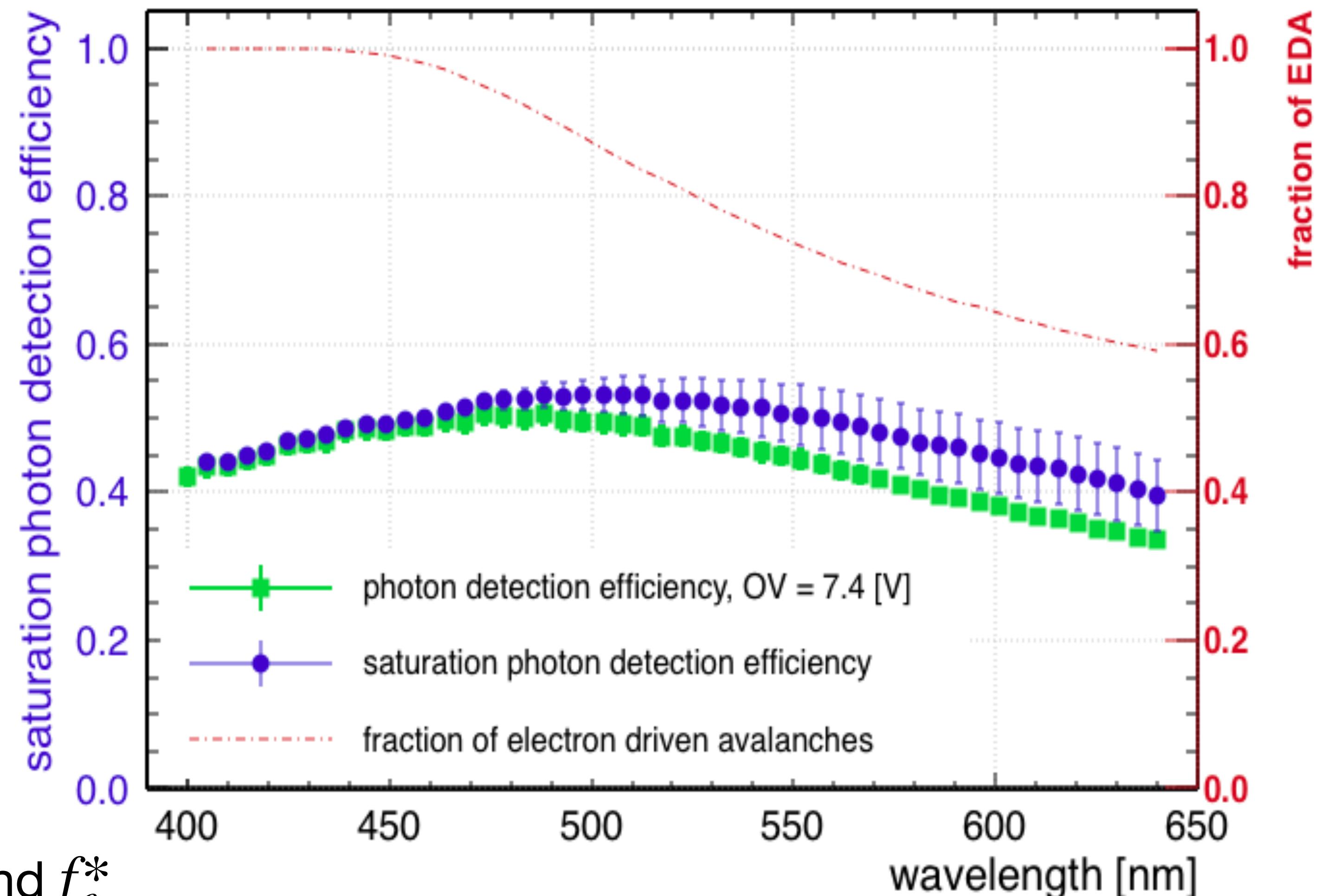


PDE data were fitted with

$$\text{PDE}_\lambda = \text{PDE}_{\text{MAX}} \cdot \left(\mathbf{P}_e(d_P) \cdot f_e^* + \mathbf{P}_h(d_W) \cdot (1 - f_e^*) \right)$$

and used to extrapolate: $P_e(d_P)$, $P_h(d_W)$ and f_e^*

EDA: Electron Drive Avalanches == f_e^*



This model is useful to infer SiPM's internal characteristics without knowing the exact internal structure and ..much more!

Dark Noise Rate (WIP)

The total SiPM Dark Noise Rate is due to several processes

$$R_{dn}(V, T) = R_{diff}^I + R_{bbt}^I + R_{trap}^I$$

Diffusion

$$R_{\text{diff}}^I \equiv \left(R_{\text{n-diff}}(d_P) P_e(d_P) + R_{\text{p-diff}}(d_W) P_h(d_W) \right)$$

Band to Band tunneling

$$R_{bbt}^I \equiv \int_{d_P}^{d_W} R_{bbt}^V(x) P_e(x) dx$$

Shockley-Read-Hall Recombination

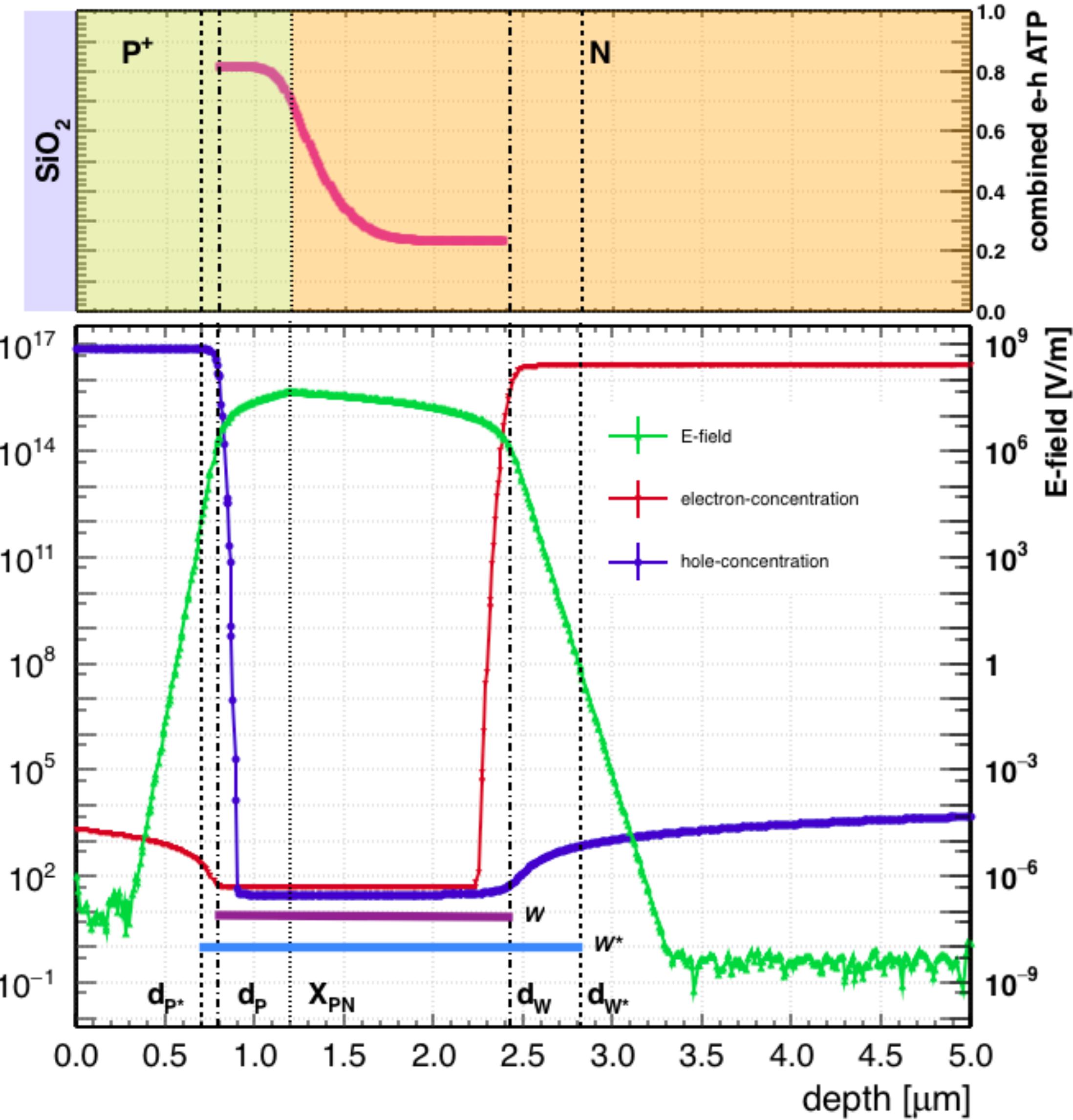
$$R_{trap}^I \equiv \int_{d_P}^{d_W} R_{trap}^V(x) P_P(x) dx$$

Several parameterisation are available for

$$R_{\text{n-diff}}(d_P), R_{\text{p-diff}}(d_W), R_{bbt}^V(x), R_{trap}^V(x)$$

DOI: [10.1016/0038-1101\(89\)90146-9](https://doi.org/10.1016/0038-1101(89)90146-9)
 DOI: [10.1109/16.155882](https://doi.org/10.1109/16.155882)

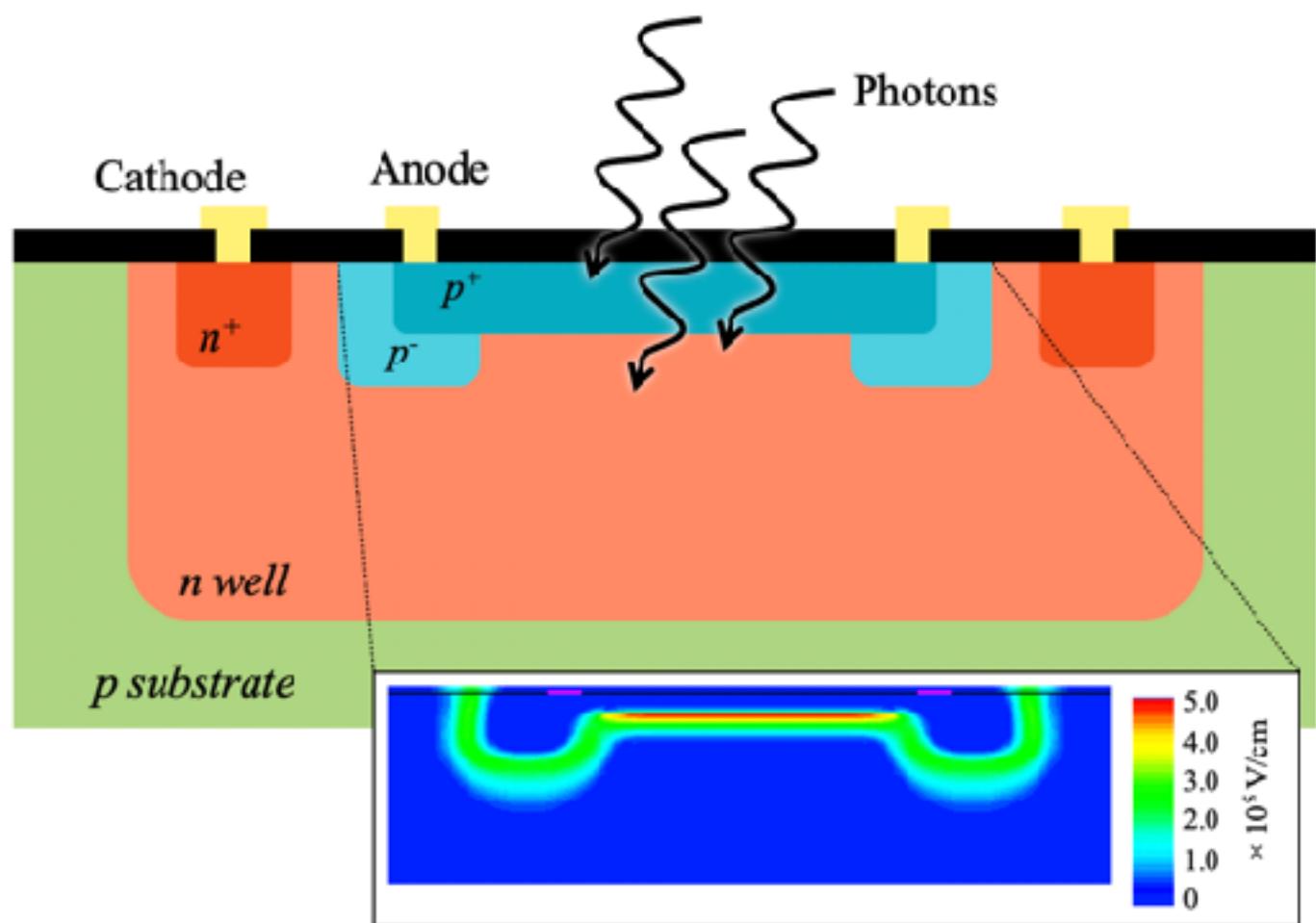
$$\mathbf{P}_P(x, V) \equiv \left(\mathbf{P}_e(x, V) + \mathbf{P}_h(x, V) - \mathbf{P}_e(x, V) \cdot \mathbf{P}_h(x, V) \right)$$



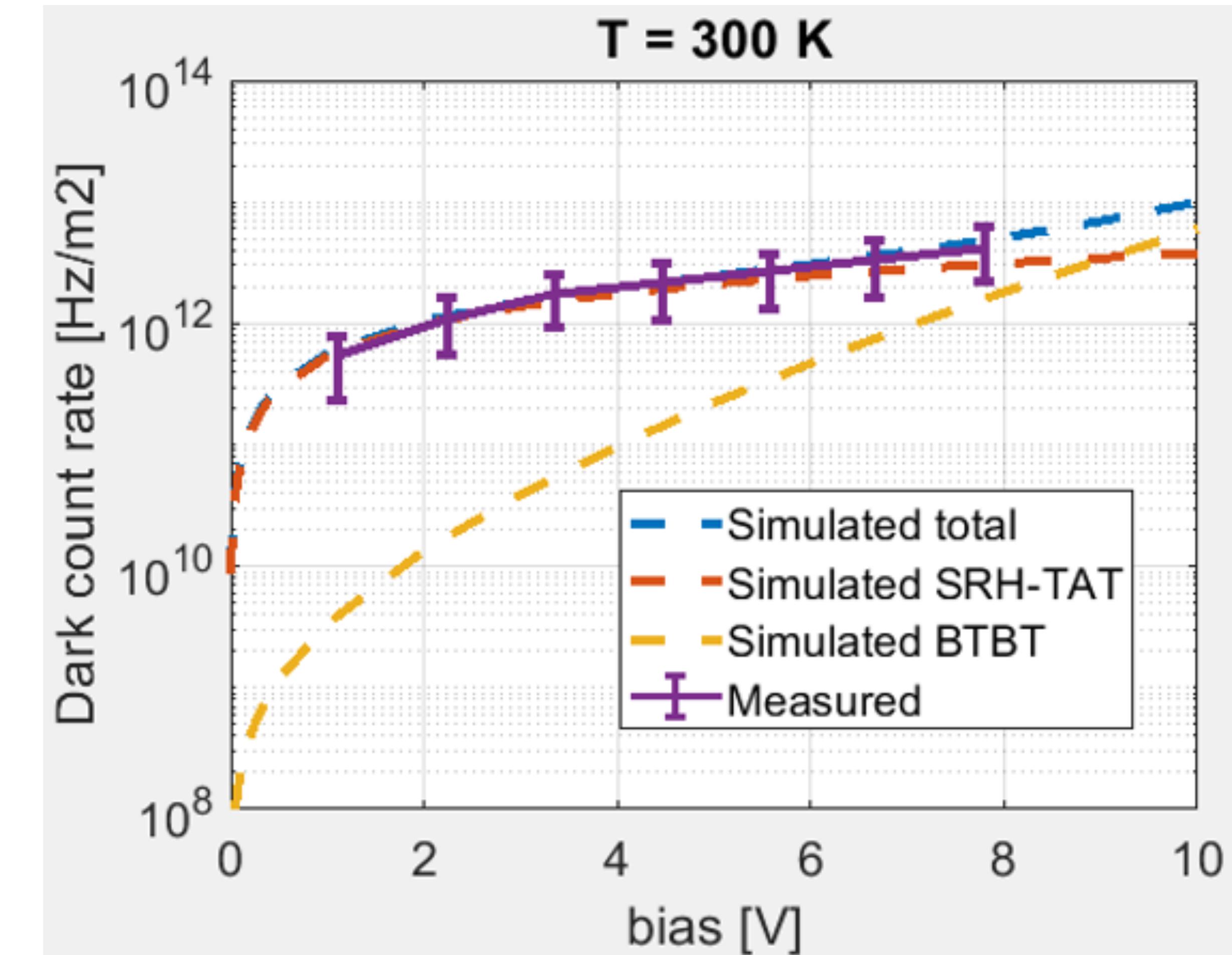
Dark Noise Rate: overvoltage dependence

Ansys Lumerical CHARGE:

- Simulate electric field on a finite element mesh given the doping profile
- Simulate thermal generation processes
- Calculate avalanche triggering probability
- **Calculate DN rate**



$$R_{dn}(V, T) = R_{diff}^I + R_{bbt}^I + R_{trap}^I$$



Dark Noise Rate (ANSYS)



Products ▾ Solutions ▾ Learn ▾ Sign in

Evaluate for Free

35

Home Ansys Optics Support > APP home

Search KB and APP

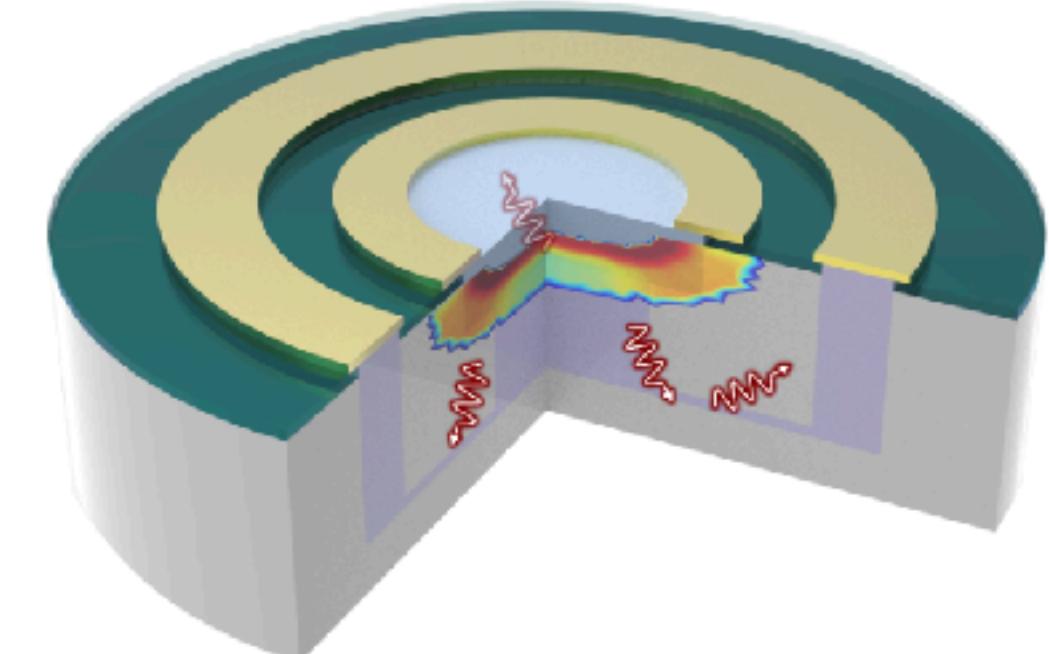
In this article

- [Overview](#)
- [Run and results](#)
- [Important model settings](#)
- [Taking the model further](#)
- [Additional resources](#)
- [Related publications](#)
- [Appendix](#)

TOP ↑

CHARGE Image Sensors

Single Photon Avalanche Detectors (SPADs) are biased above breakdown causing a large avalanche current upon detecting even a single photon due to a very high multiplication gain. However, due to the thermal generation of electron-hole pairs in semiconductors, an avalanche can be triggered even without any photons present, that is, in the dark conditions. The figure of merit characterizing this behavior is usually called the dark count rate, or sometimes the dark noise. It represents the number of dark avalanches per second. This example demonstrates how to simulate the dark count rate in a Si SPAD. We also show a benchmark against the dark count rate measurements of a proprietary Si SPAD device.



Overview

Understand the simulation workflow and key results

Step 1
Ansys CHARGE

Step 2
Ansys Script

Associated files

Login to download

Related articles

- [Optical crosstalk in SPAD due to secondary emission](#)
- [SPAD Secondary Emission and Absorption](#)
- [Small-Scale Metalens – Field Propagation](#)
- [Vertical photodetector](#)
- [Hong-Ou-Mandel Interference Between Independent Heralded Photon Sources](#)

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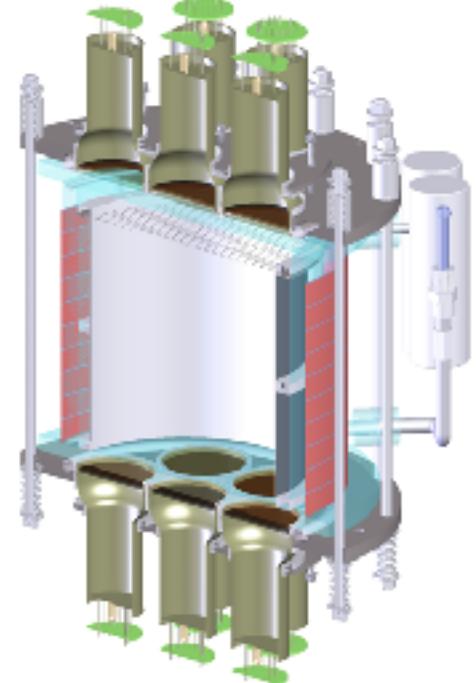
- [SPAD Secondary Emission and Absorption](#)

Stay tuned..

SiPM Technology in Darkside

A multi-stage approach

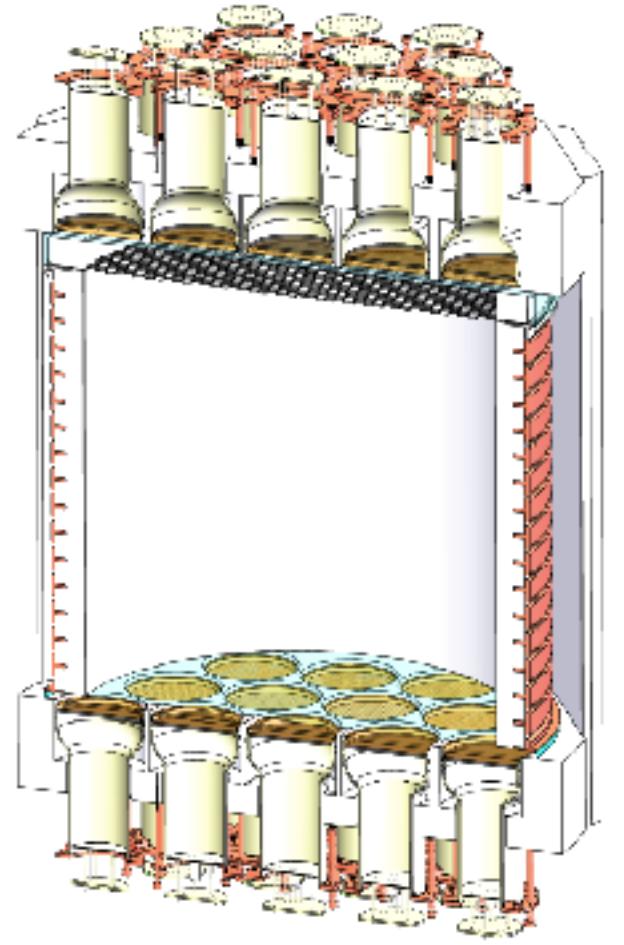
2012



DarkSide-10

- First prototype
- Helped to refine TPC design
- Demonstrated a light yield $>9\text{PE}/\text{keV}_{\text{ee}}$

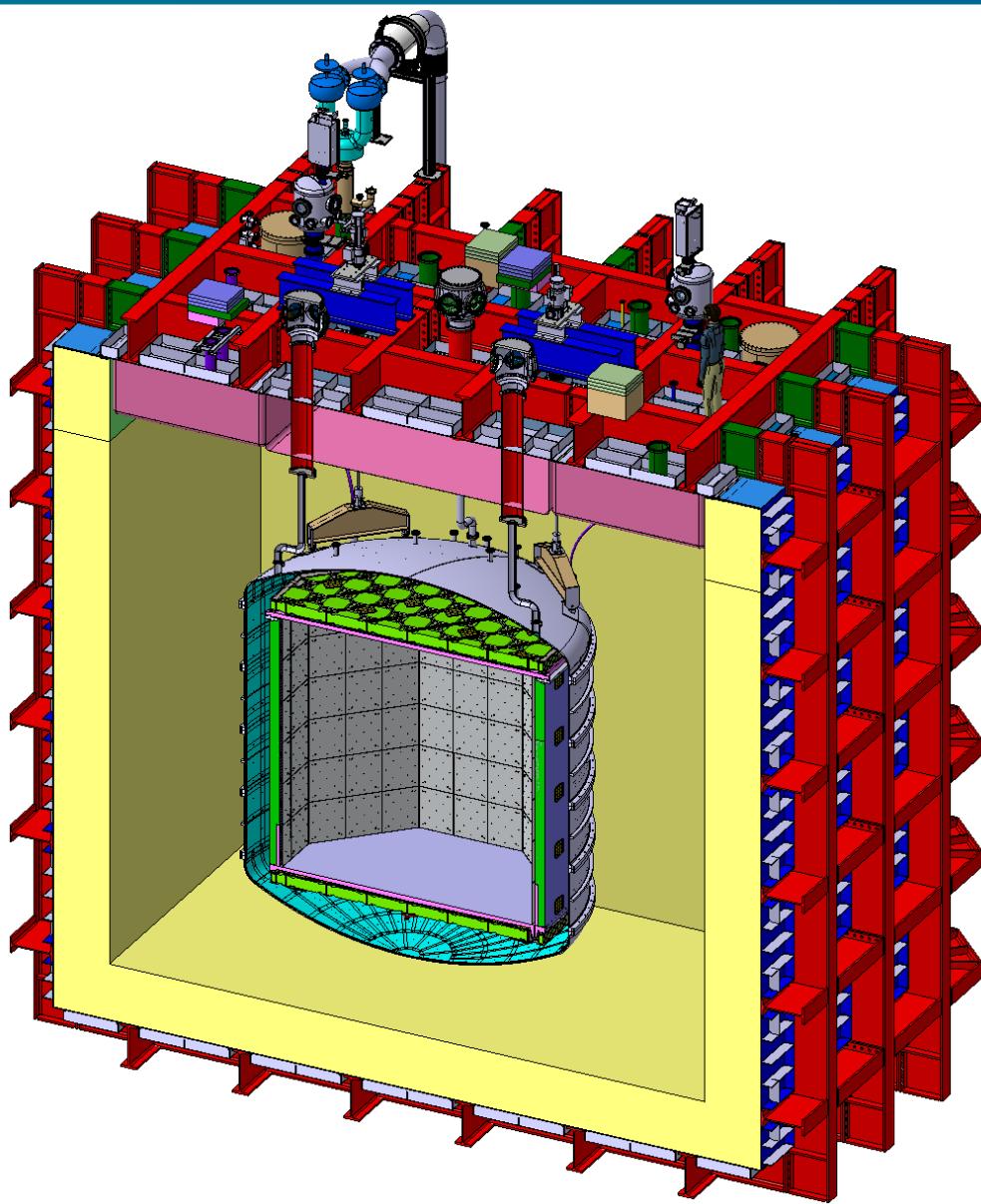
2013 - 2018



DarkSide-50

- Science detector
- Demonstrated the use of UAr
- First background-free results
- Best limits for low mass WIMP searches

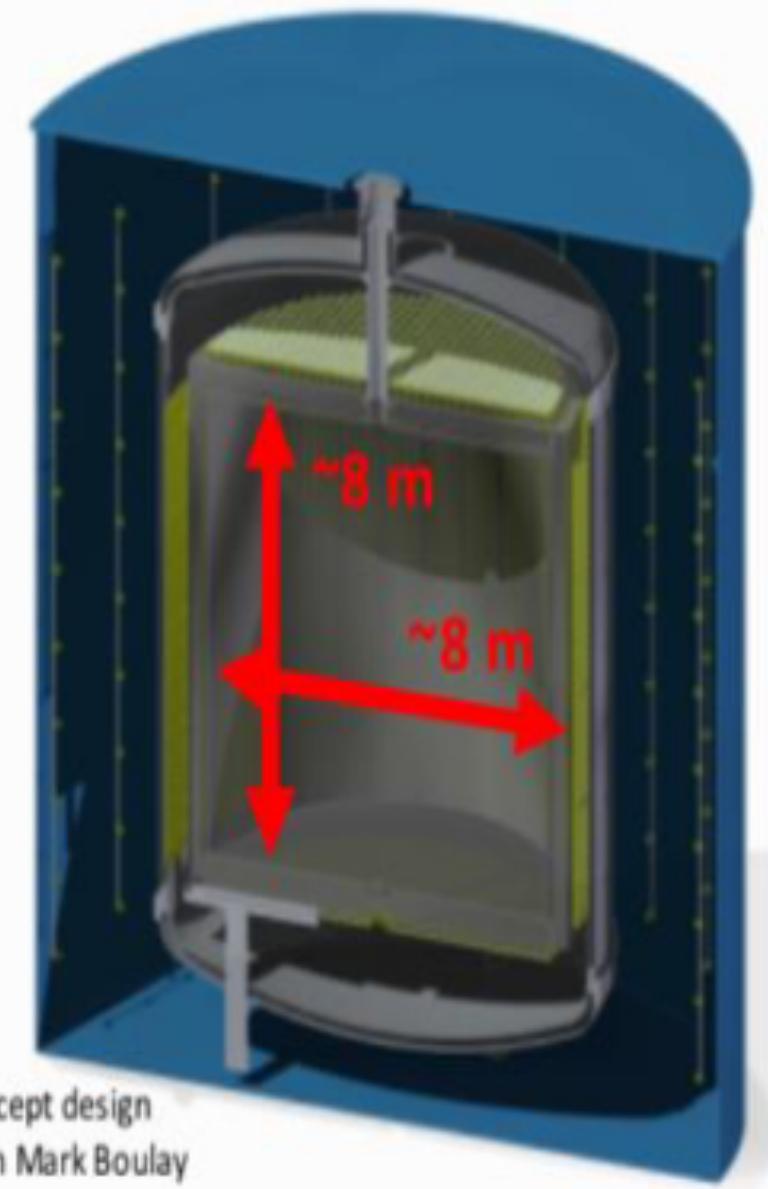
2025 - 2035



DarkSide-20k @ LNGS

- Novel technologies
- First peek into the neutrino fog
- Nominal exposure: 200 t y

2030s - ...



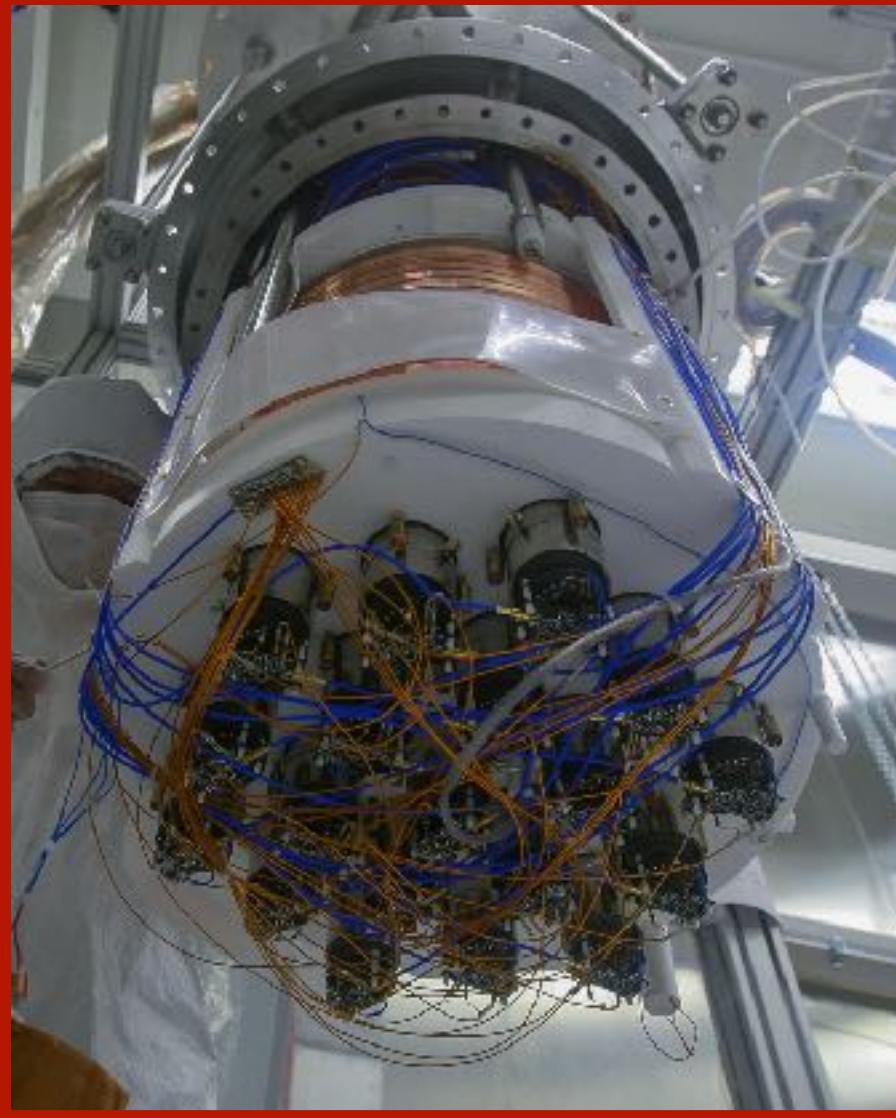
Concept design
from Mark Boulay

Argo @ SNOLAB

- Ultimate LAr DM detector
- Push well into the neutrino fog
- Nominal exposure: 3000 t y

The GADMC

DarkSide-50 @ LNGS



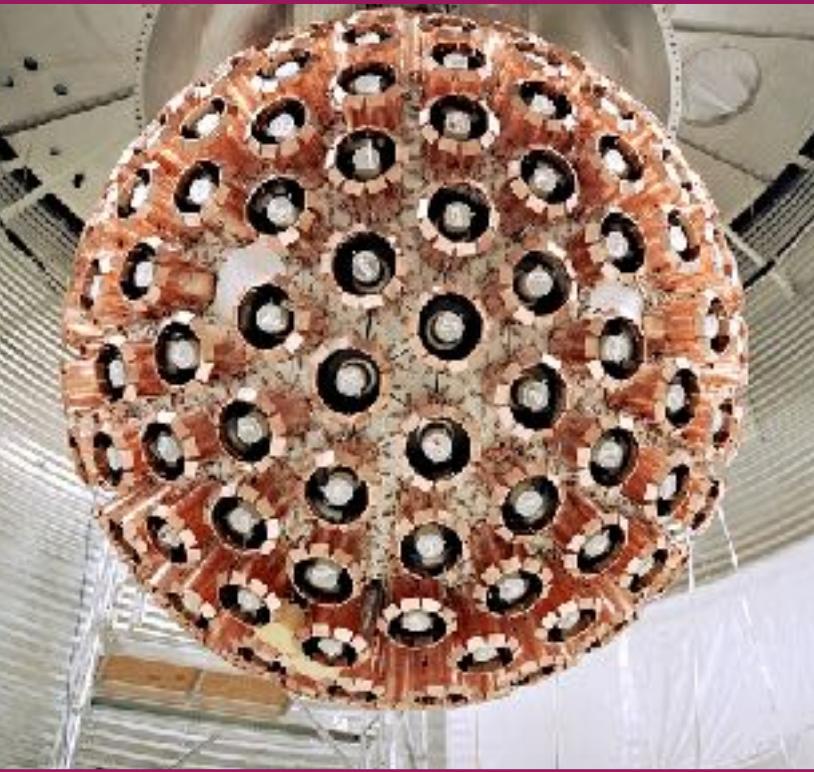
ArDM @ Canfranc



MiniClean @ Snolab



DEAP @ Snolab



>400 scientists, >100 institutions distributed across 13 countries



DarkSide-20k overview

Nested detectors structure

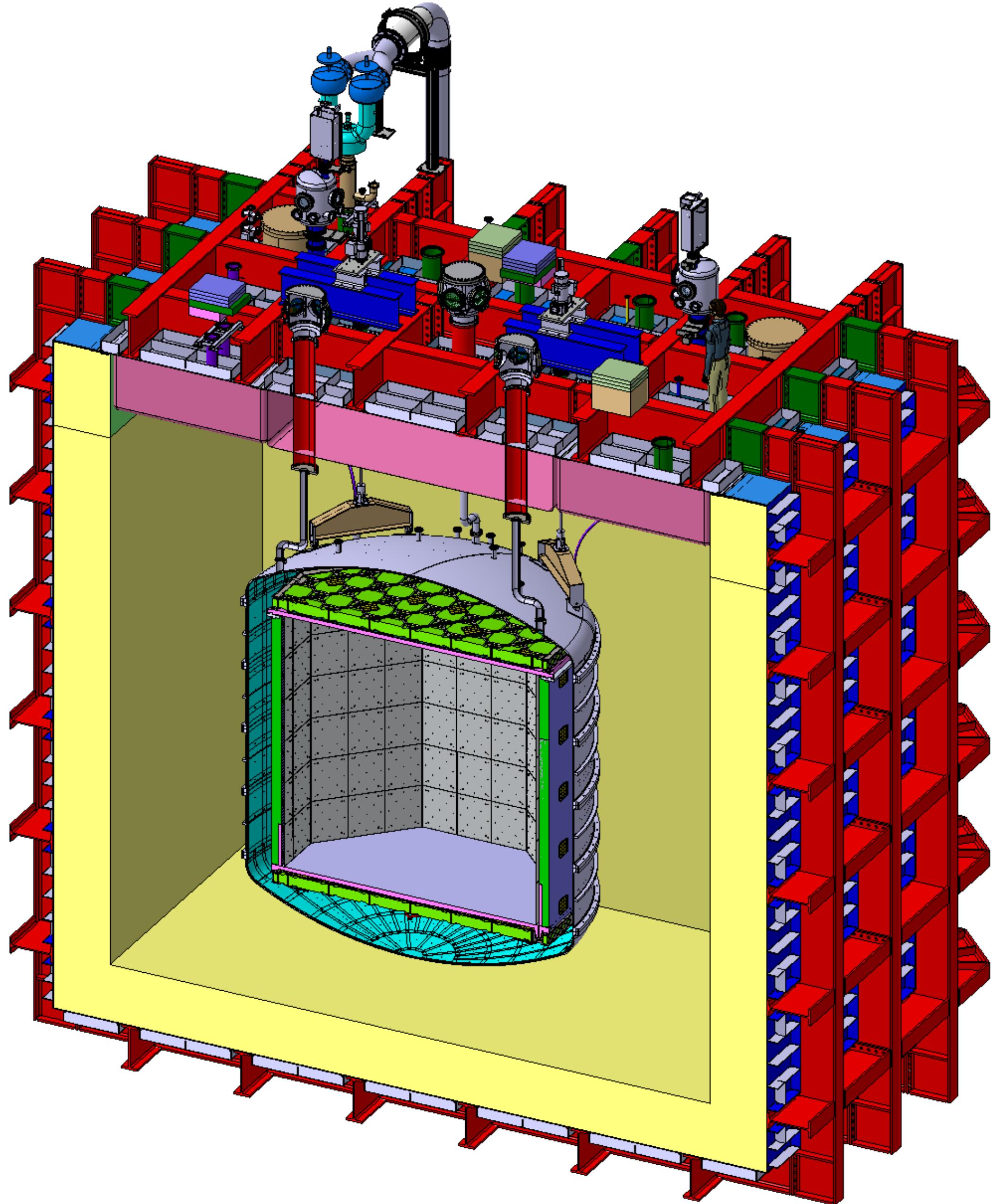
- ProtoDUNE-like cryostat ($8 \times 8 \times 8 \text{m}^3$) - Muon veto
- Ti vessel separating AAr from underground UAr.
- Neutrons and γ veto
- WIMP detector: dual-phase TPC hosting 50t of LAr
- Fiducial mass: 20 tonnes

Multiple detection channels for bkg suppression:

- Neutron after cuts: < 0.1 in 10 y
- β and γ after cuts: < 0.1 in 10 y

Position reconstruction resolution:

- 1 cm in XY
- 1 mm in Z



Photodetector System

TPC optical plane

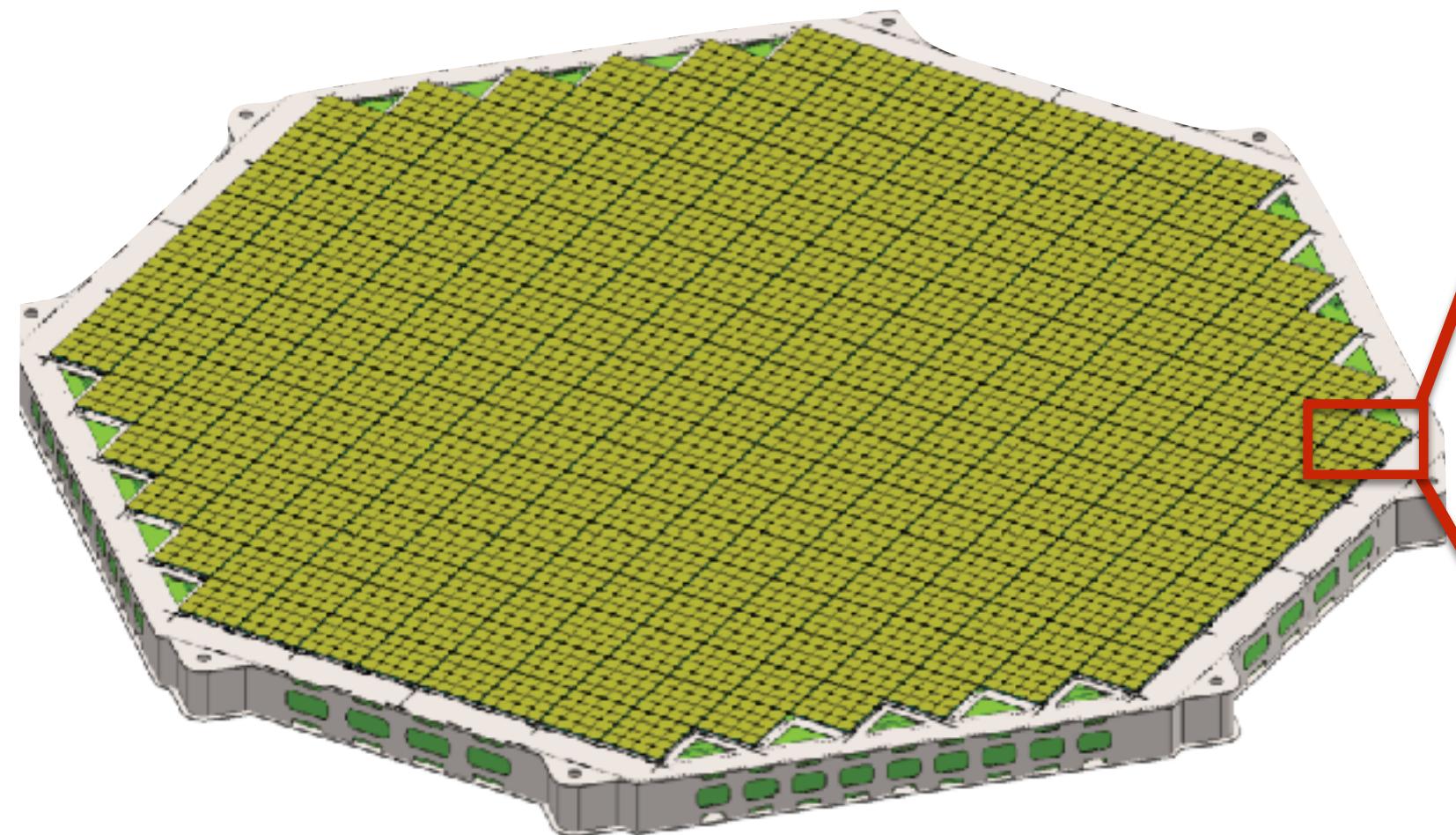
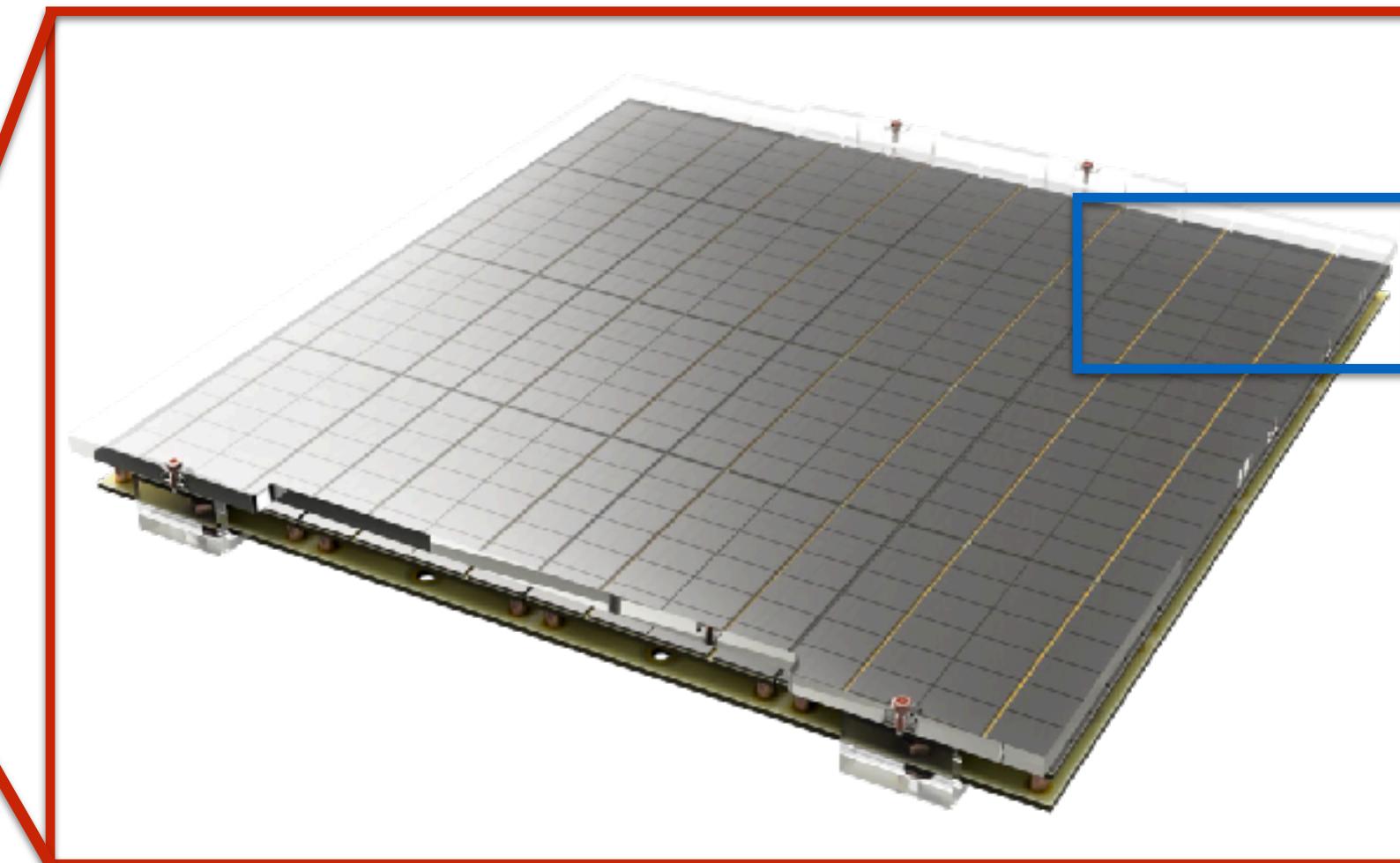
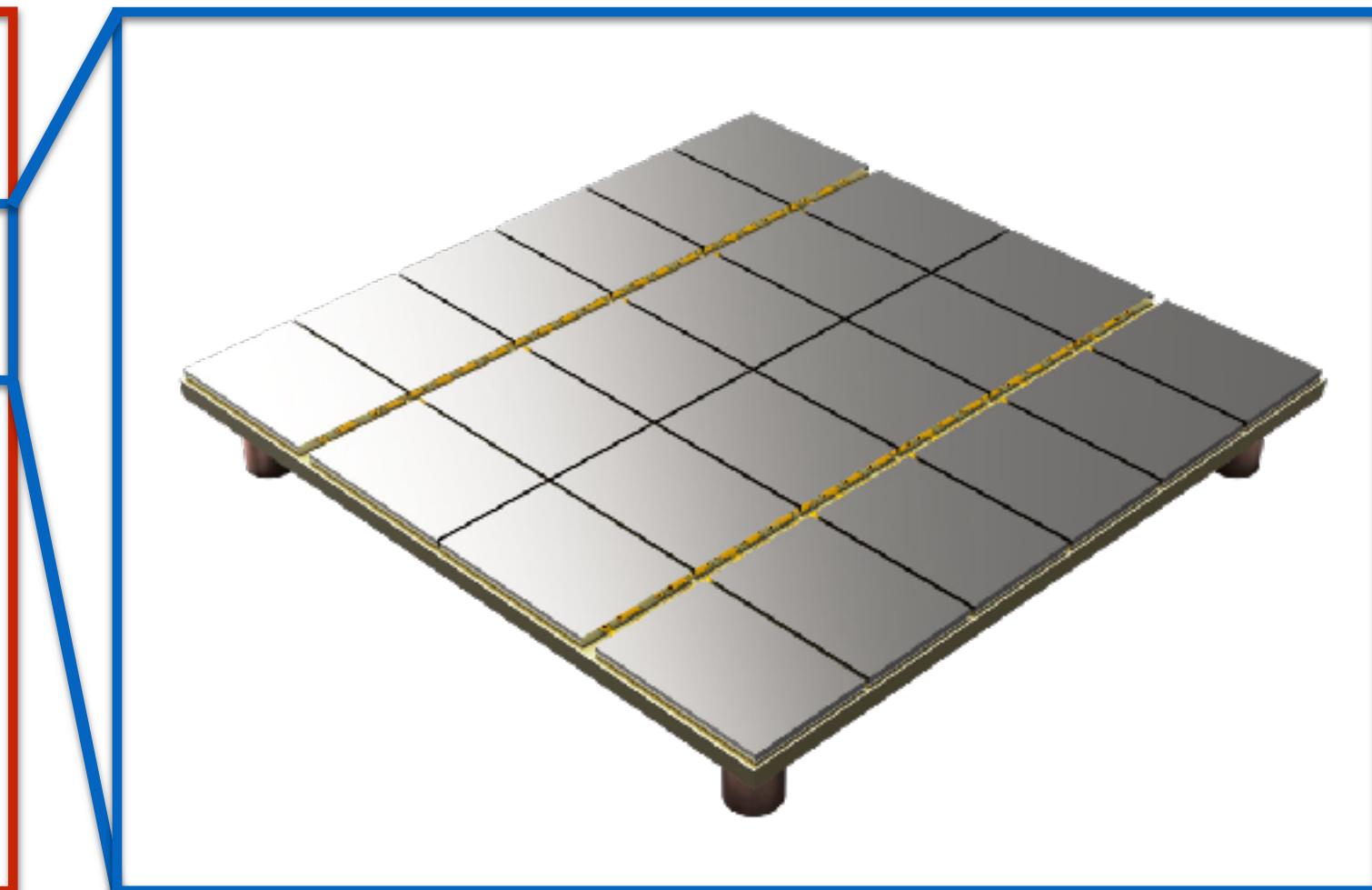


Photo-Detection Unit



Tile



40

16 tiles arranged in 4 readout channels

TPC planes area: $\sim 21\text{m}^2$

SiPM bias distribution

Photosensor

Organized in 525 PDUs

cryogenic pre-amplifiers bias

Array of 24 SiPMs

100% coverage of TPC top and bottom

Signal transmission

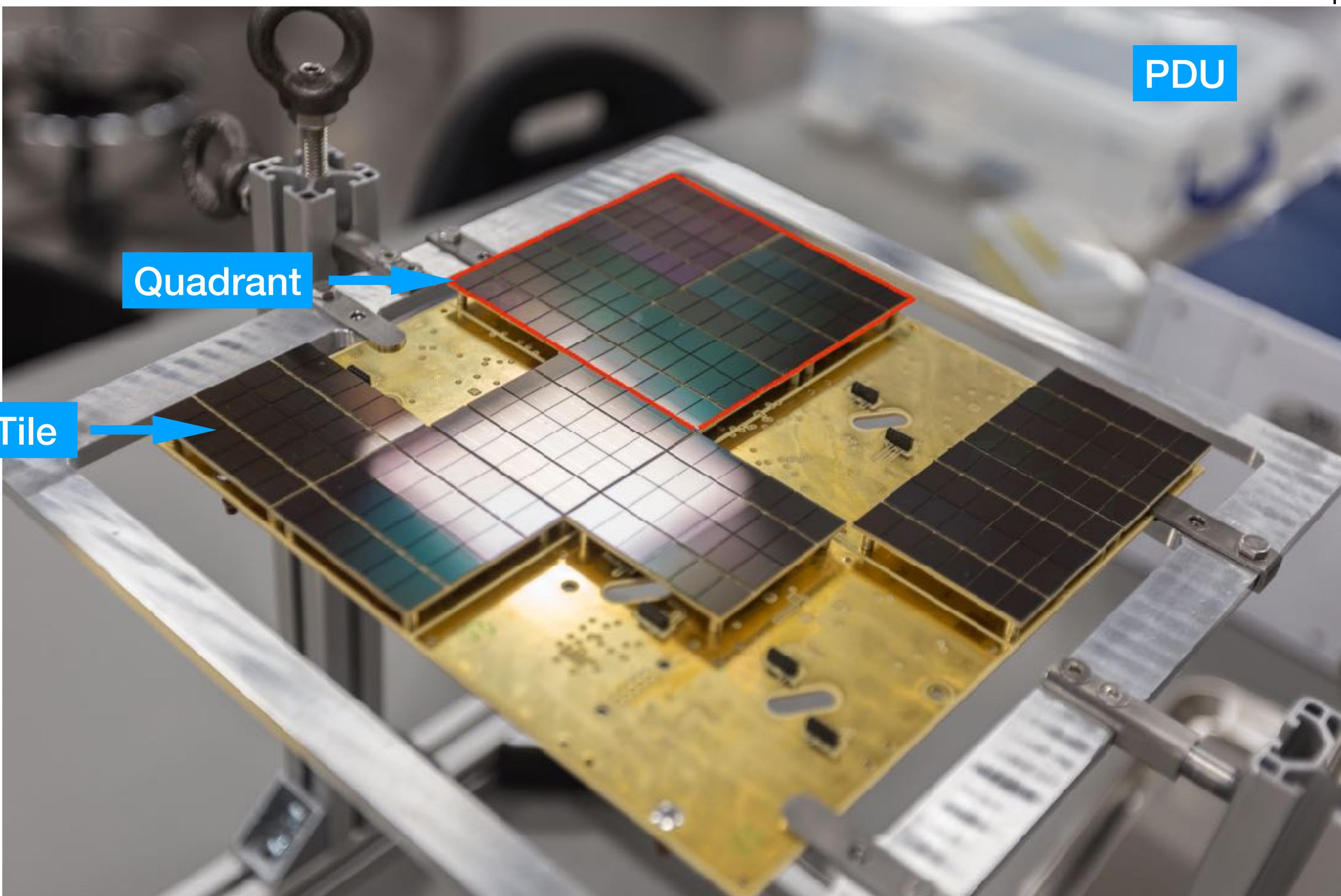
Signal pre-amplification

Channels switch-on/off

The Darkside-20k PDU

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- 24 FBK NUV-HD-Cryo SiPMs are aggregated in objects called tiles
- Tile have 4s6p topology
- SiPMs are read by a low noise transimpedance amplifier (TIA) or by a custom designed ASIC
- Tiles, in groups of four, are further aggregated in quadrants each of them read as 1 analog readout channel

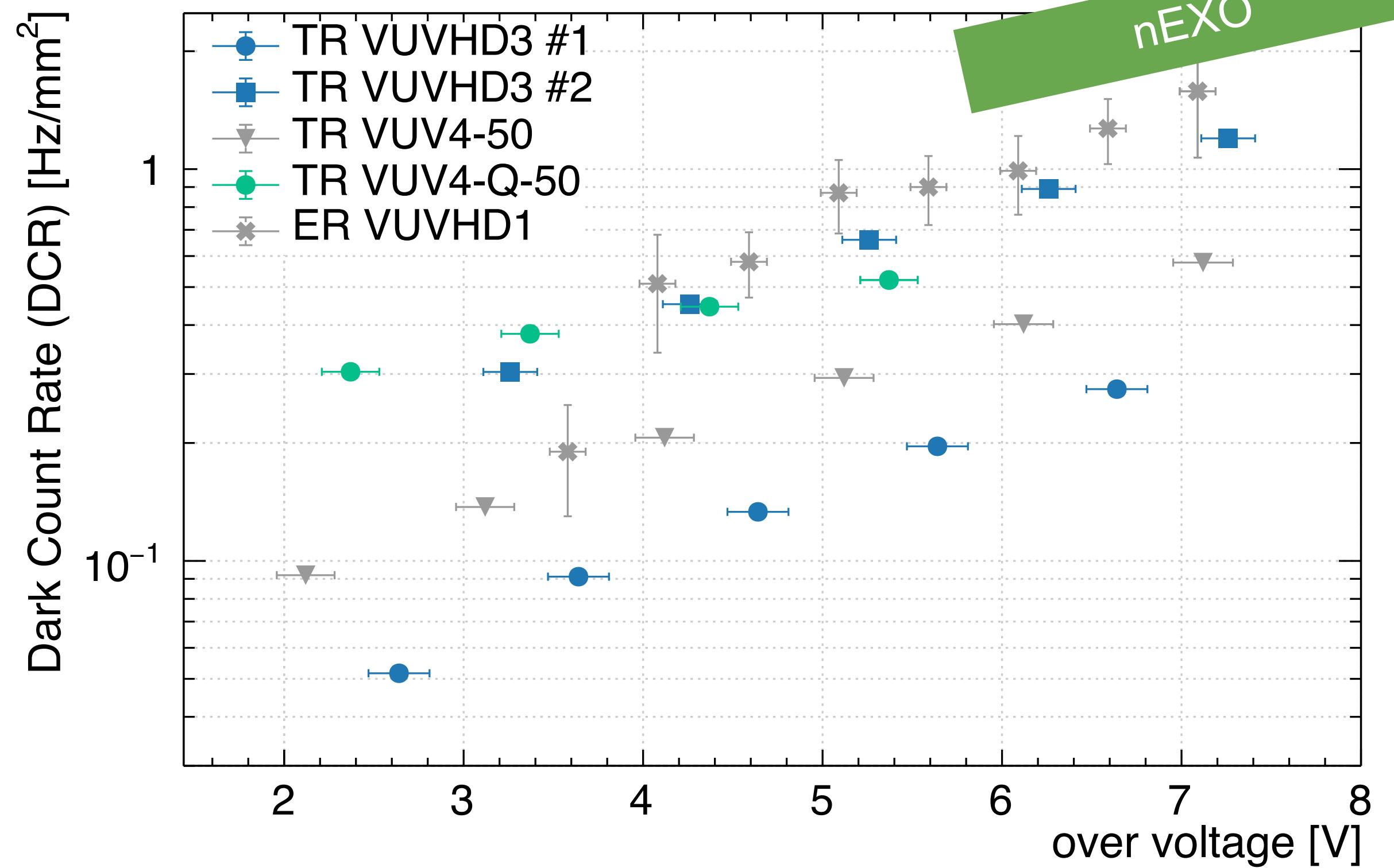
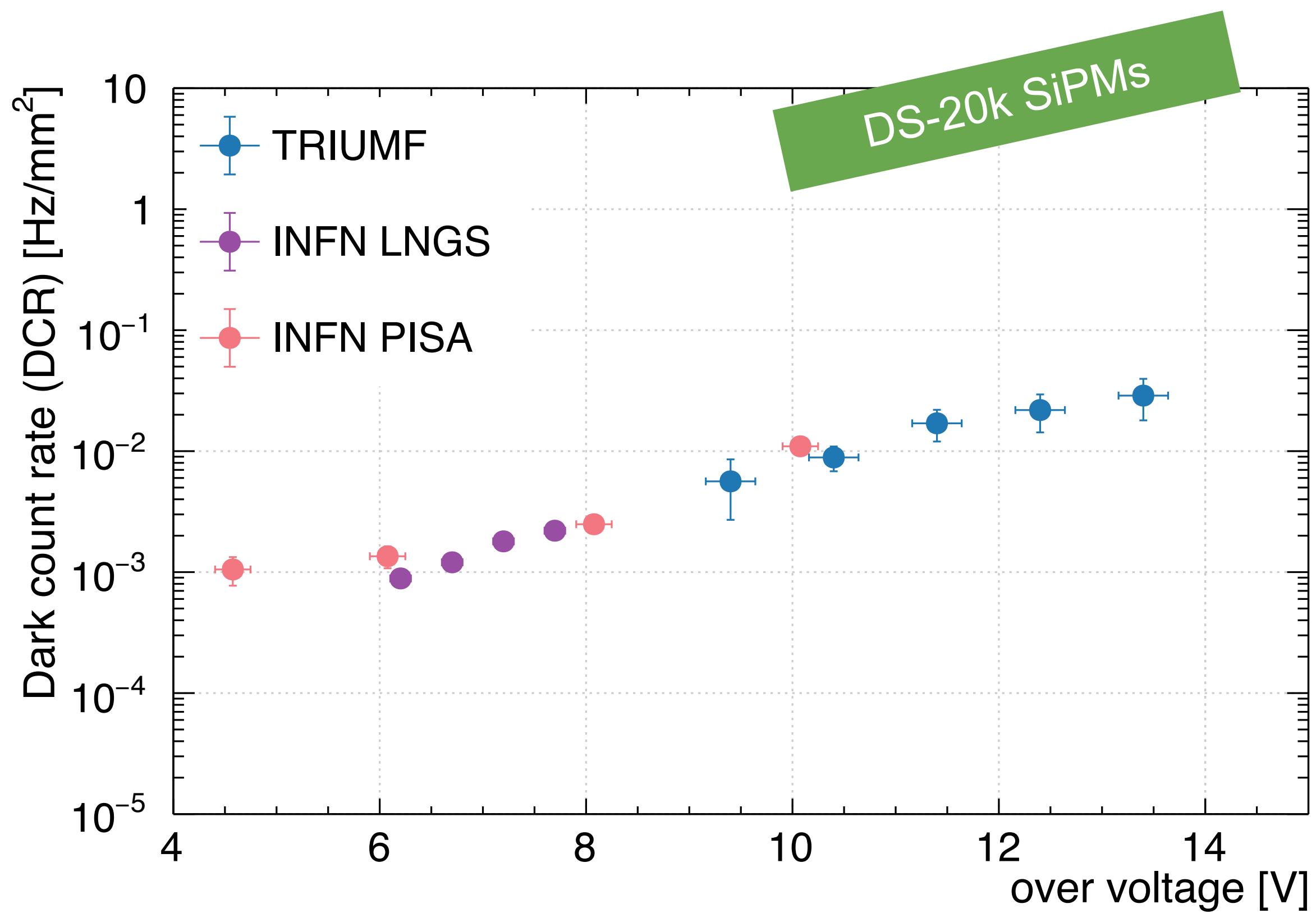


Dark Count Rate (DCR)

Computed using time differences between pulses as shown in 10.1016/j.nima.2017.08.035

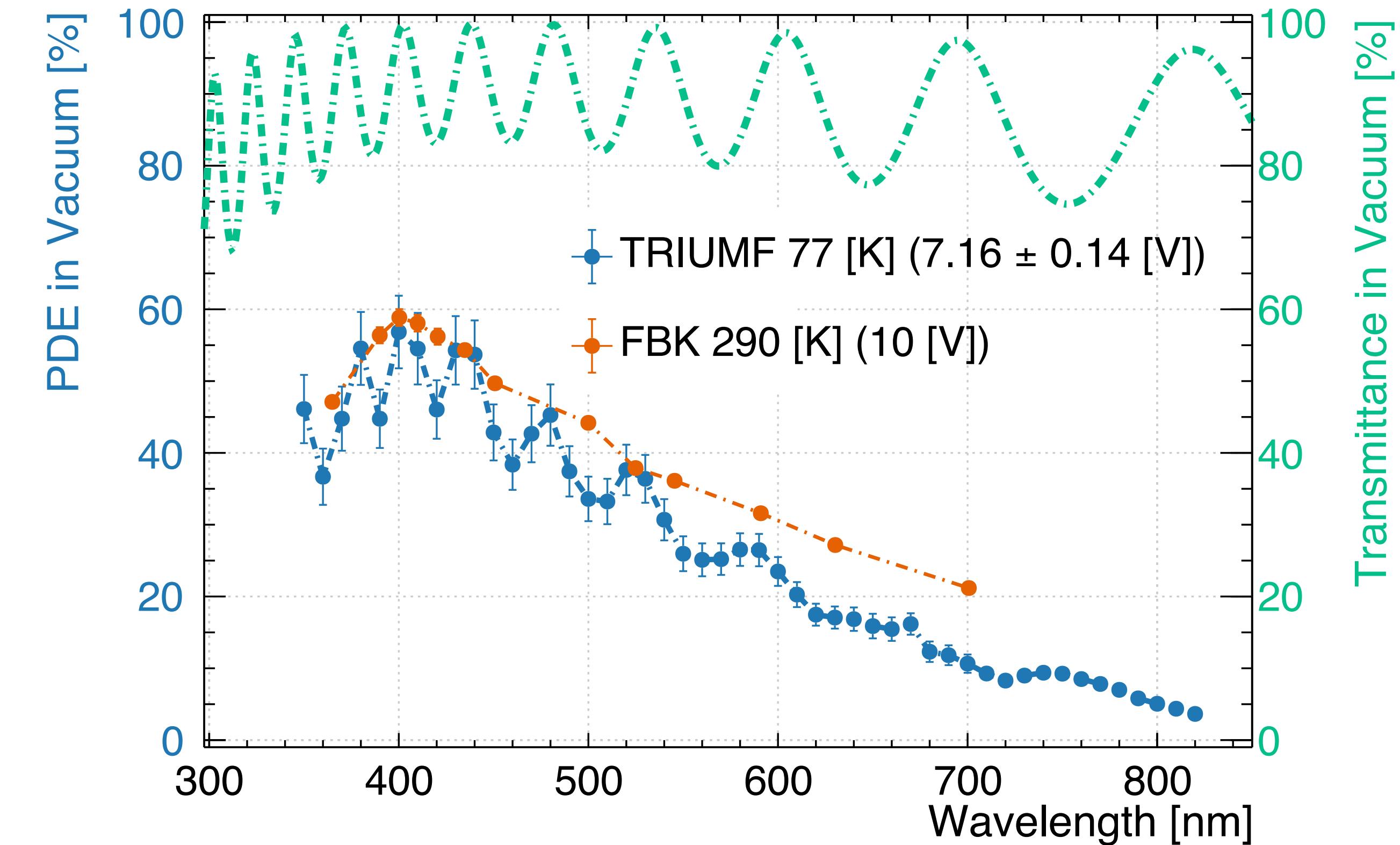
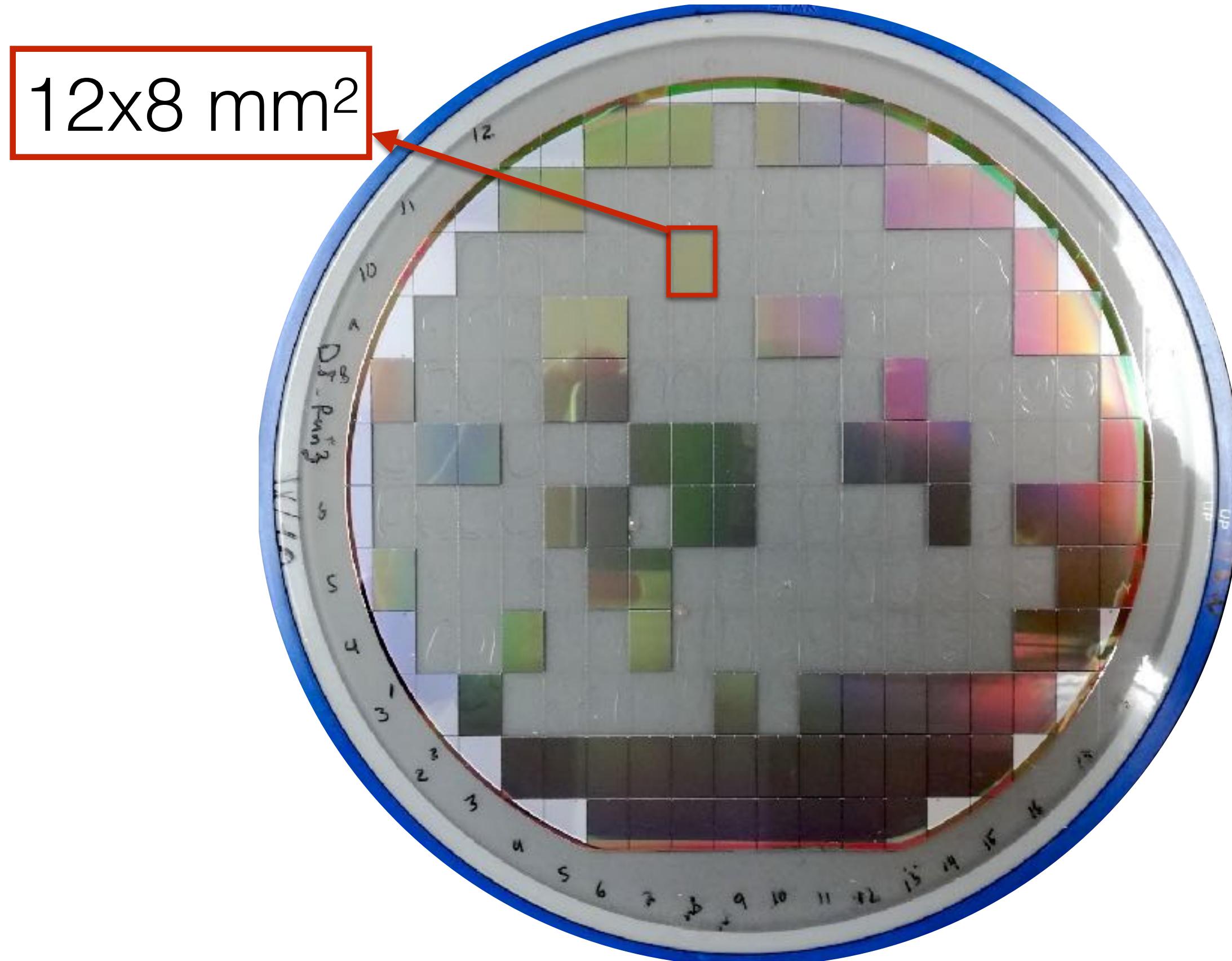
42

Roughly one order of magnitude lower than LXe temperature



One/two order of magnitude lower DCR at 77 K

SiPMs development

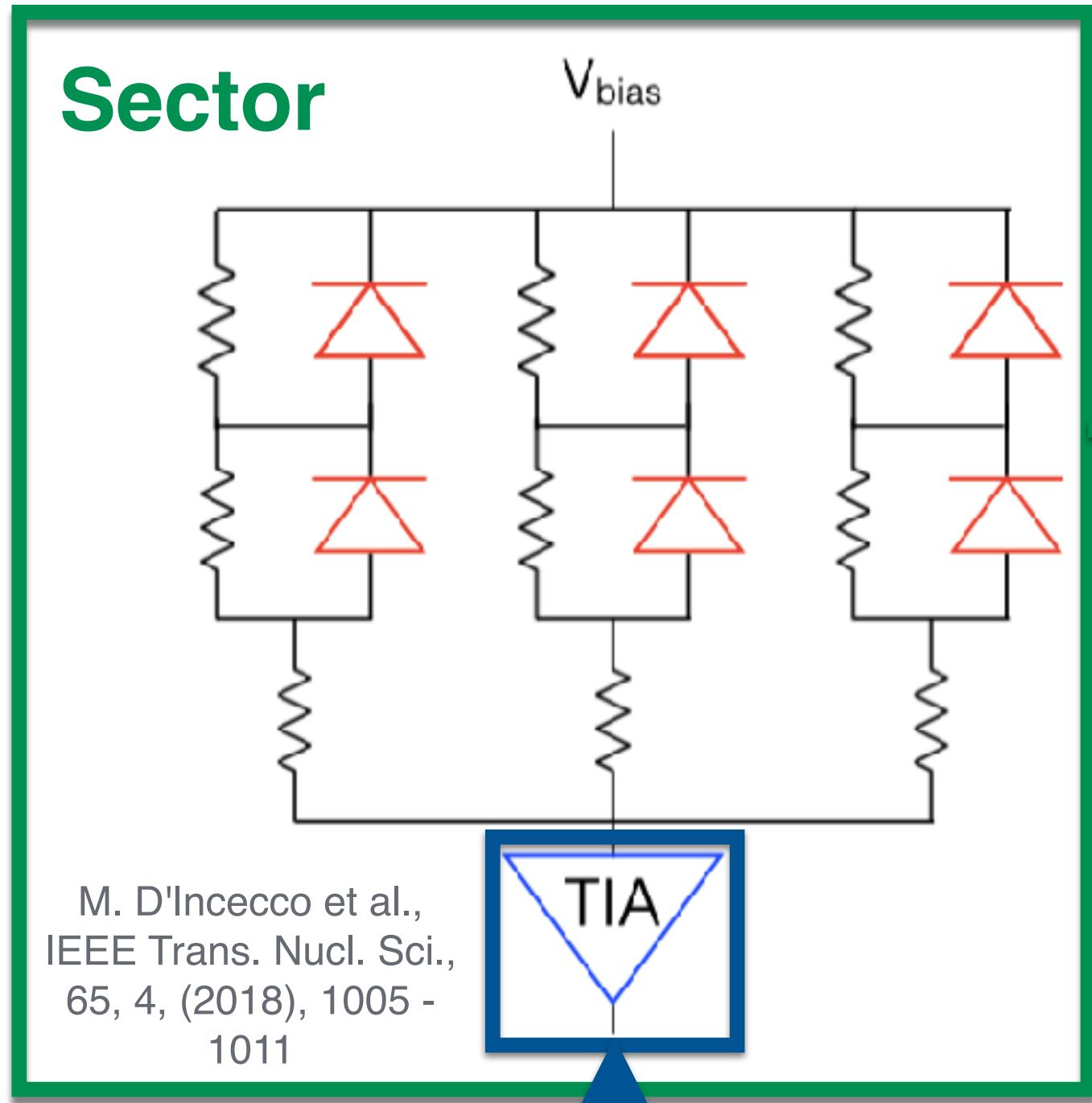


- NUV vs RGB choice
- Cell pitch and fill factor (FF) optimization
- E field profile \Rightarrow DCR+CN reduction

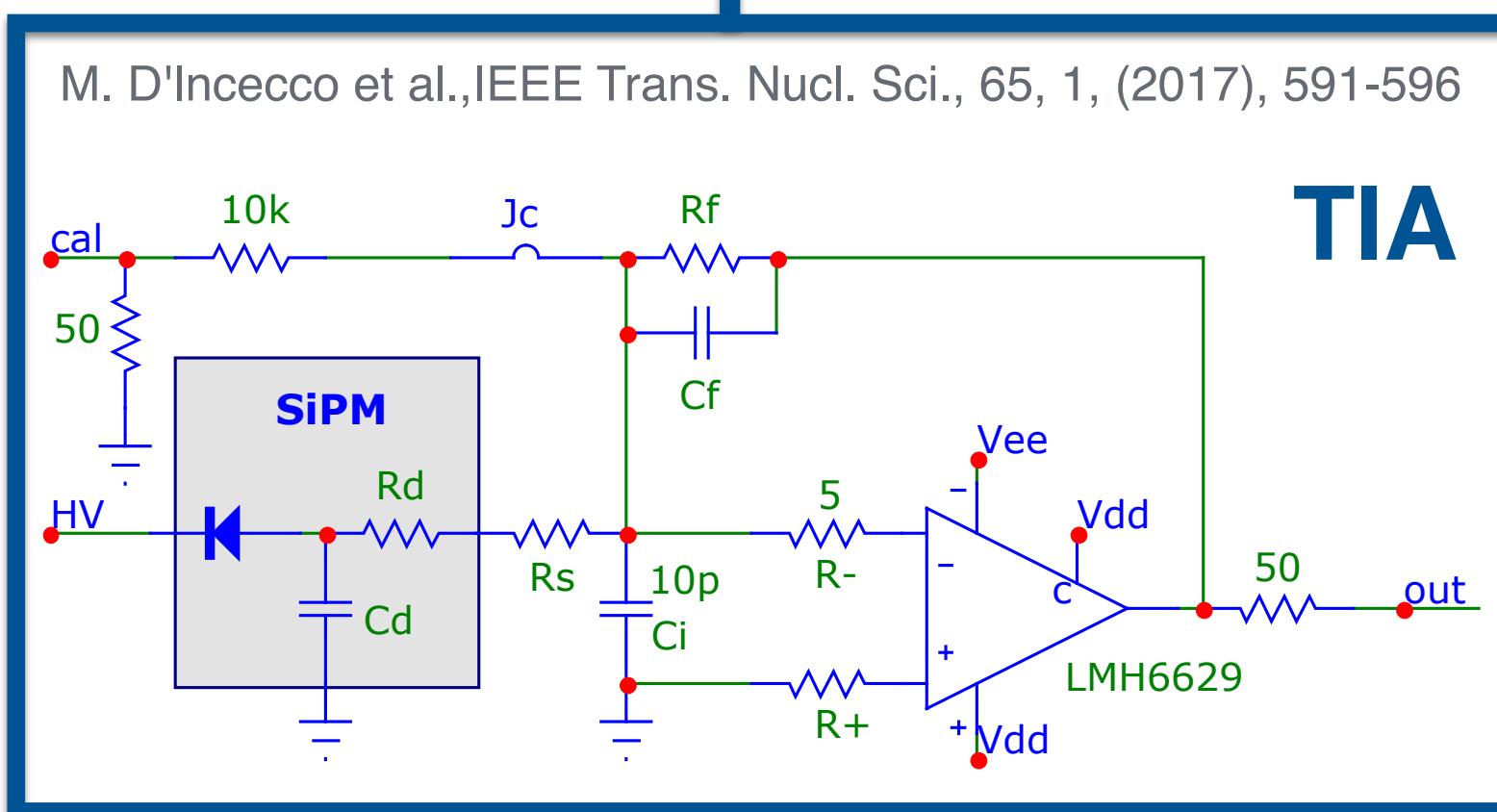
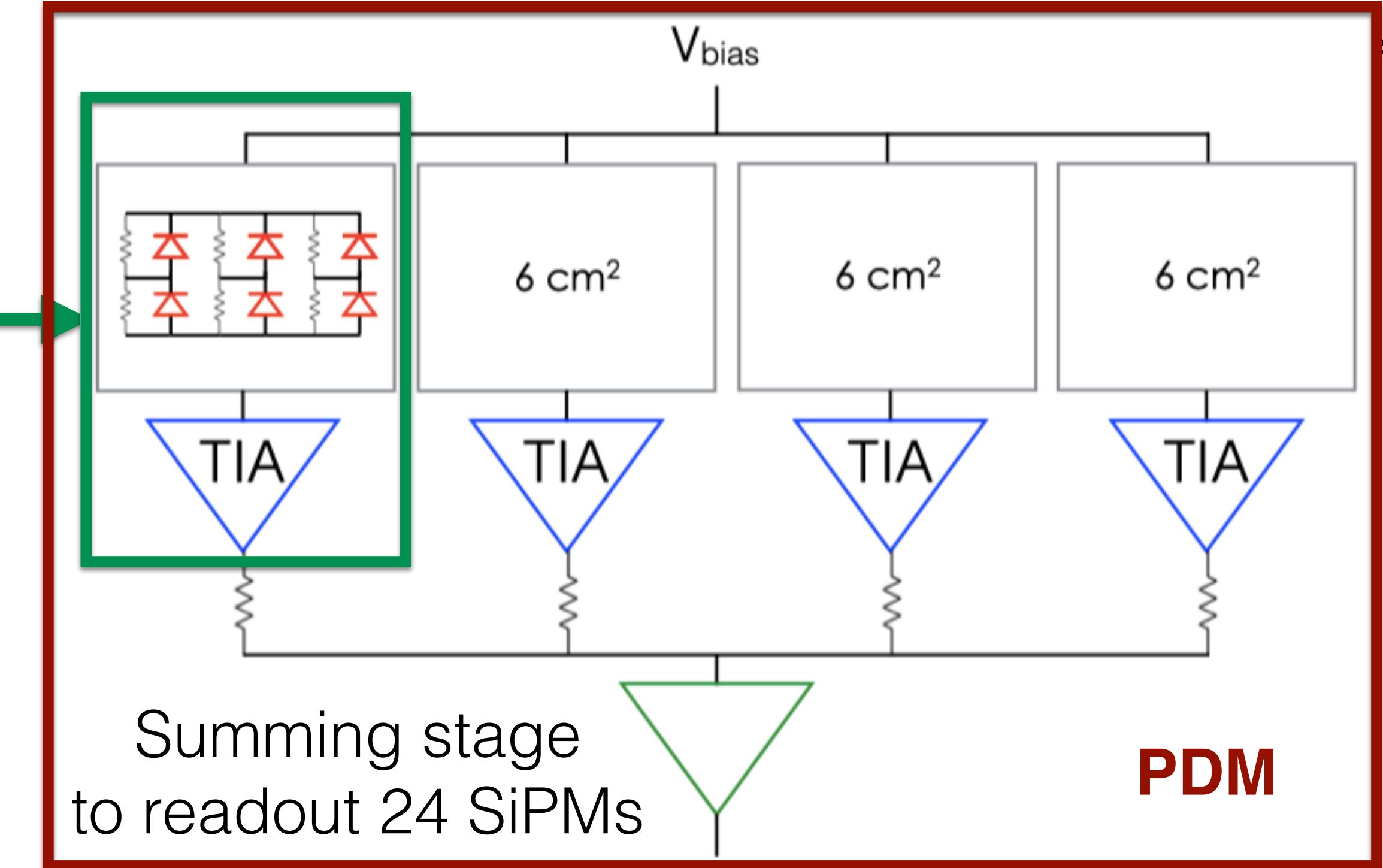
$$\text{PDE} = \text{QE} \times \text{P}_{01} \times \text{FF}$$

PDE ~50% in LAr

Readout electronics design



Mixed series/parallel configuration
Reduce $C_{in}@TIA$
Preserve BW



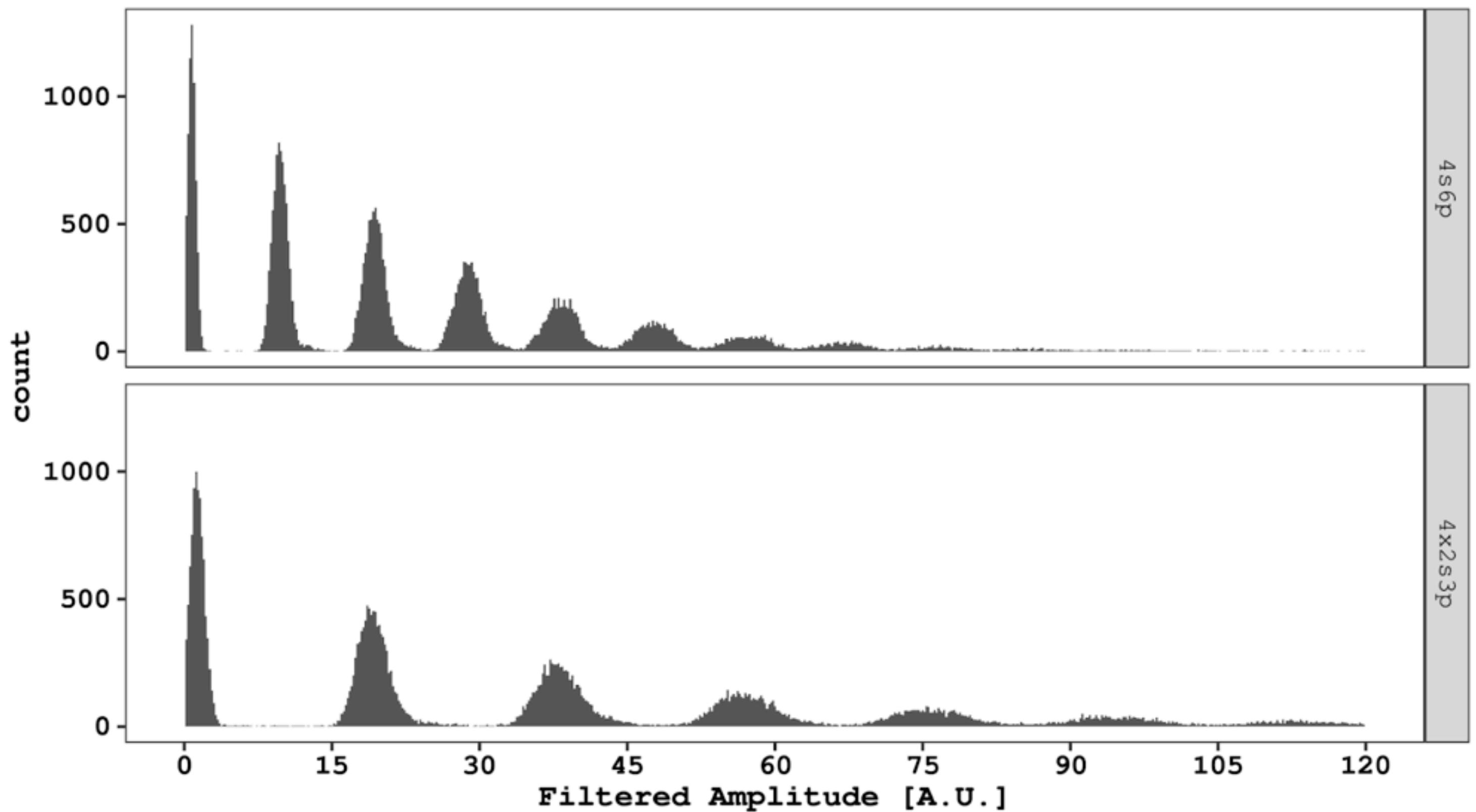
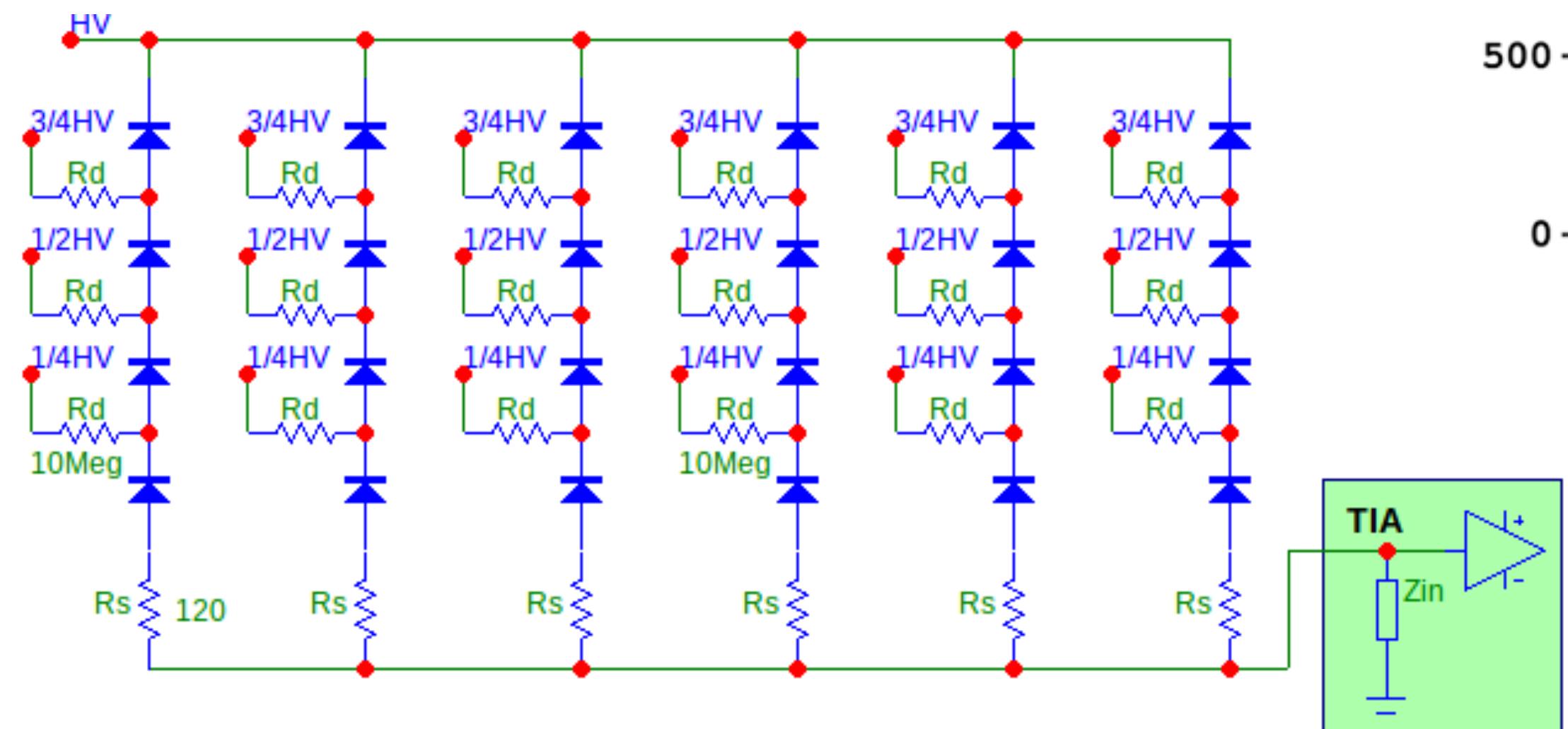
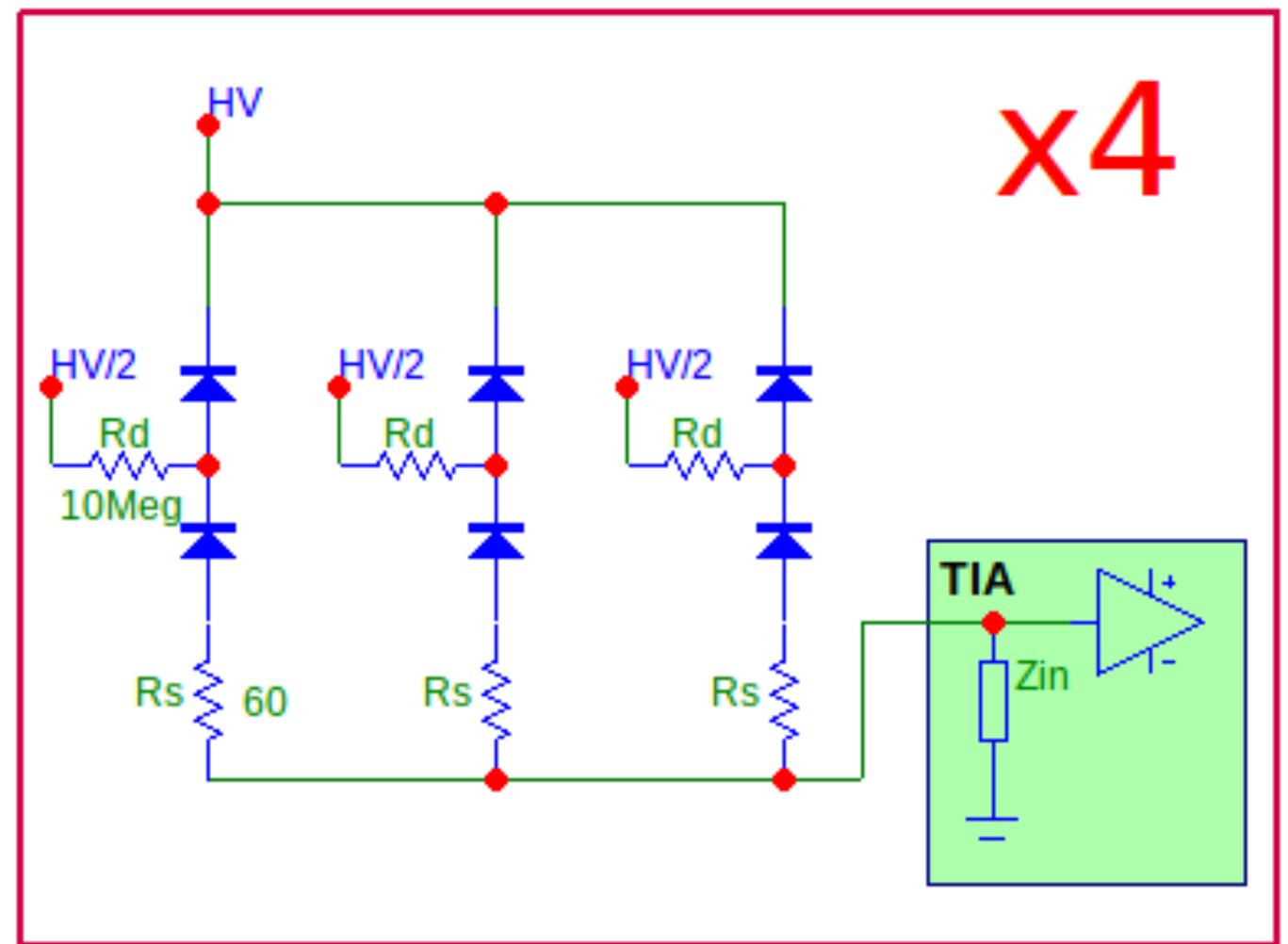
SiPM = current generators + huge output capacitance ($\sim 50\text{pF/mm}^2$)

Transimpedance amplifier (TIA) **High Bandwidth** and **Low Noise**

SNR is reduced wrt a single SiPM, but still very high

Power dissipation is $< 250\text{mW}$ per PDM

... and upgrades

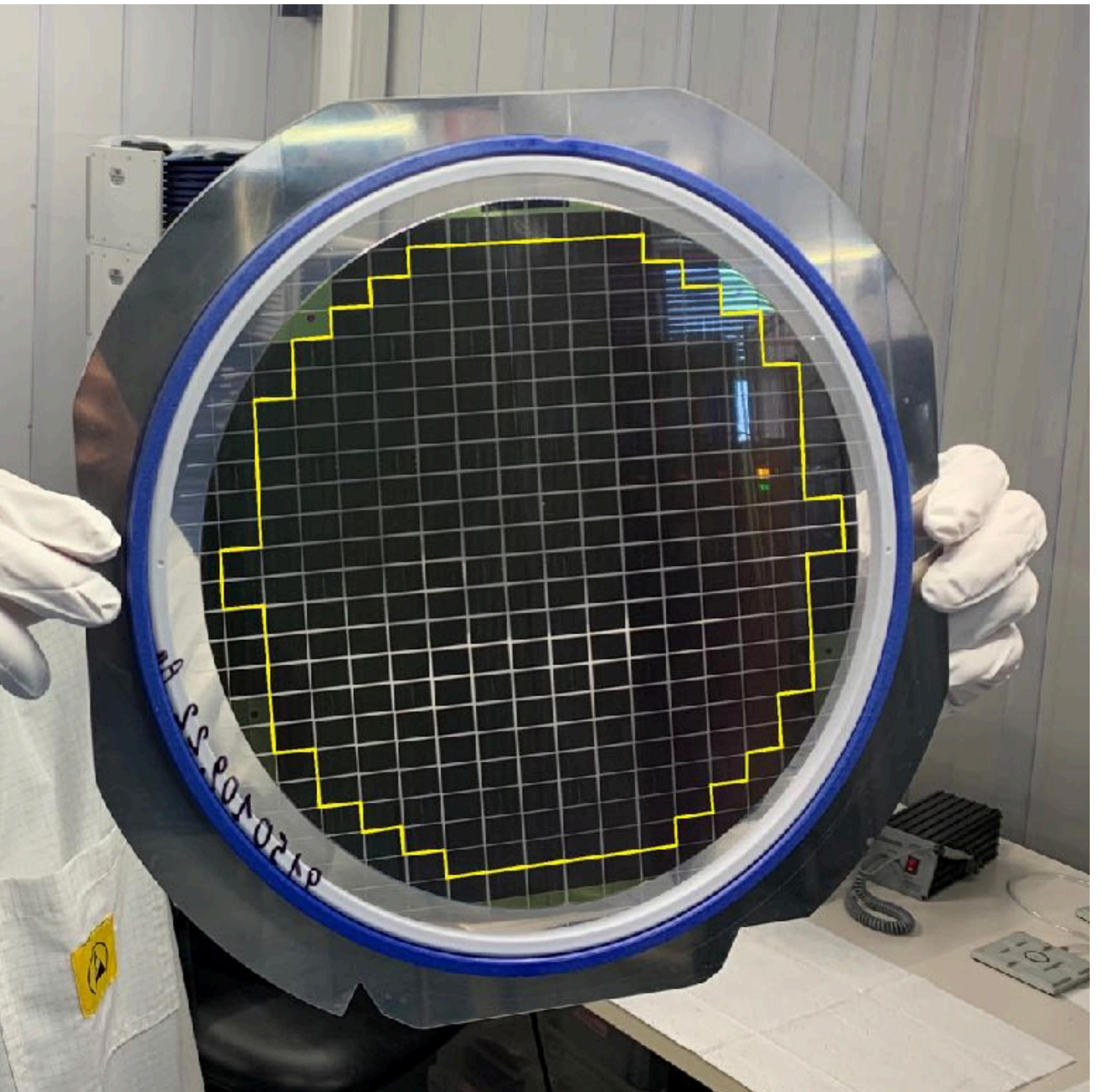


Switch from 4 sectors (6cm^2) to 1 single 24cm^2 unit

Power dissipation $< 50\text{mW}$ per tile

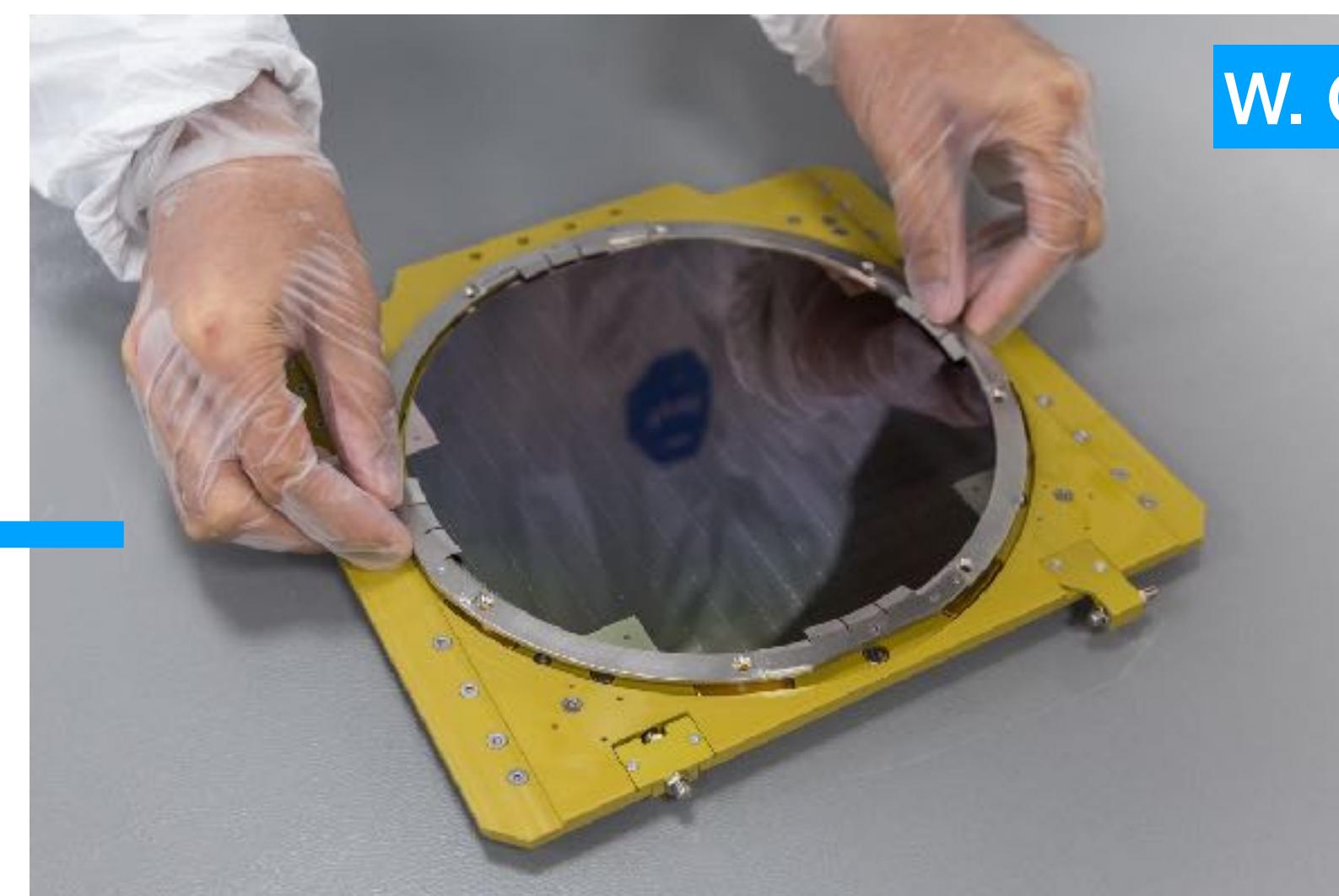
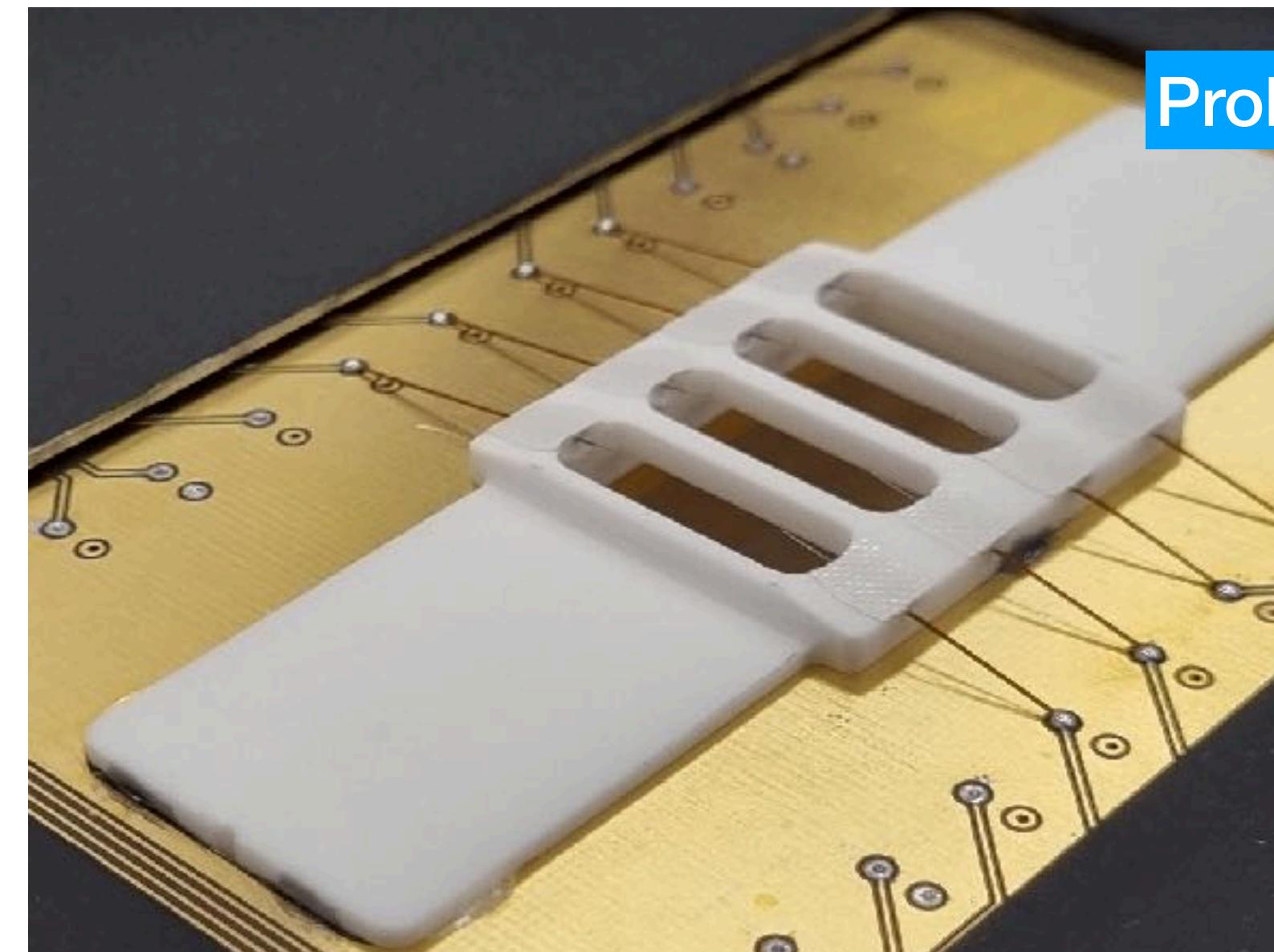
Wafers

- Wafers are produced by LFoundry (1400 in total) s.r.l. (Avezzano, AQ, Italy).
- 268 potentially working dice x wafer (264 testable).
- Wafer are produced by LFoundry in Lots (~25 wafers), 57 in total.
- Each of the ~25 wafers in a Lot travels together through the foundry process steps.
- The largest variation in the wafer performance is expected when comparing different lots.

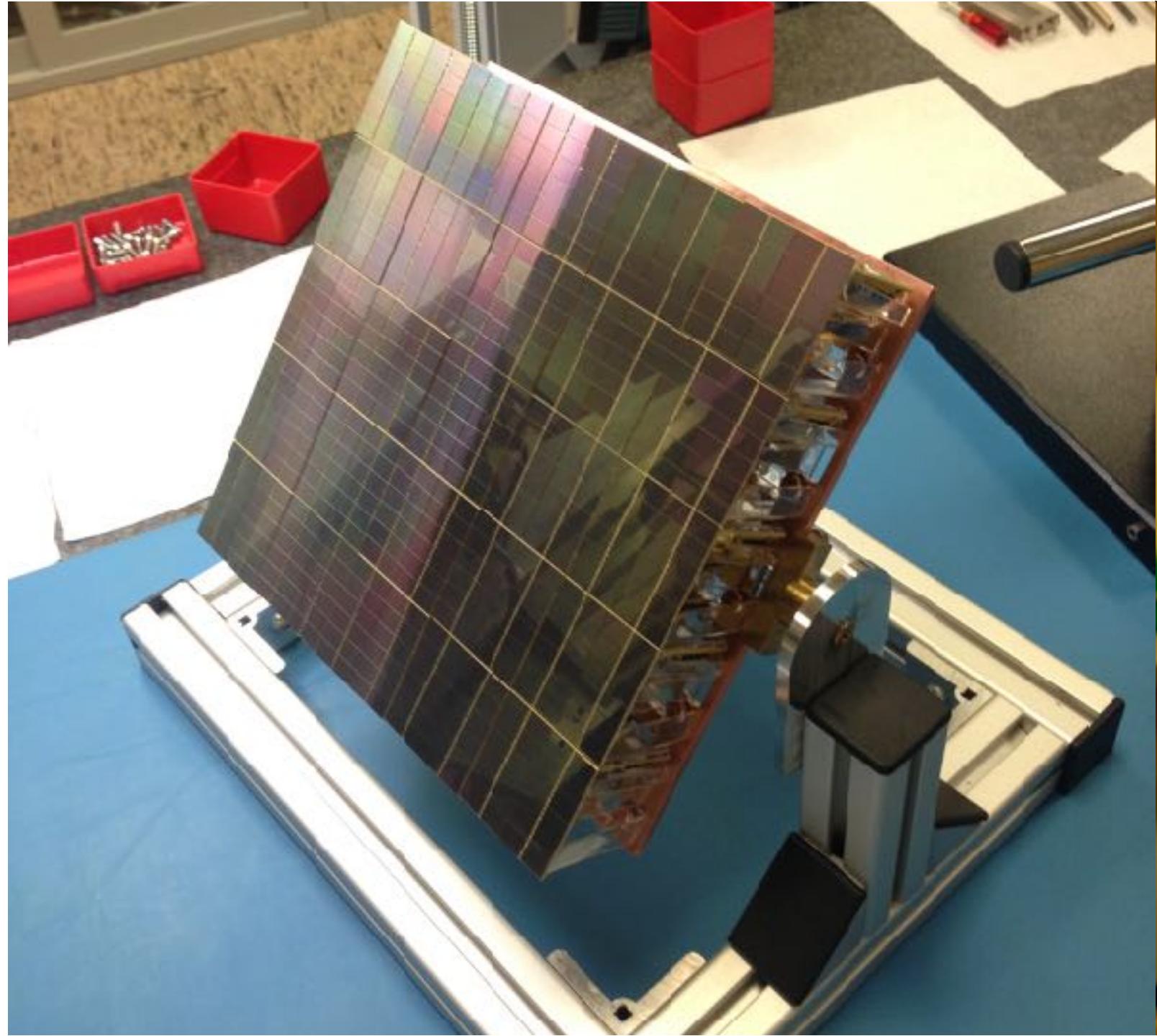


Hardware Setup

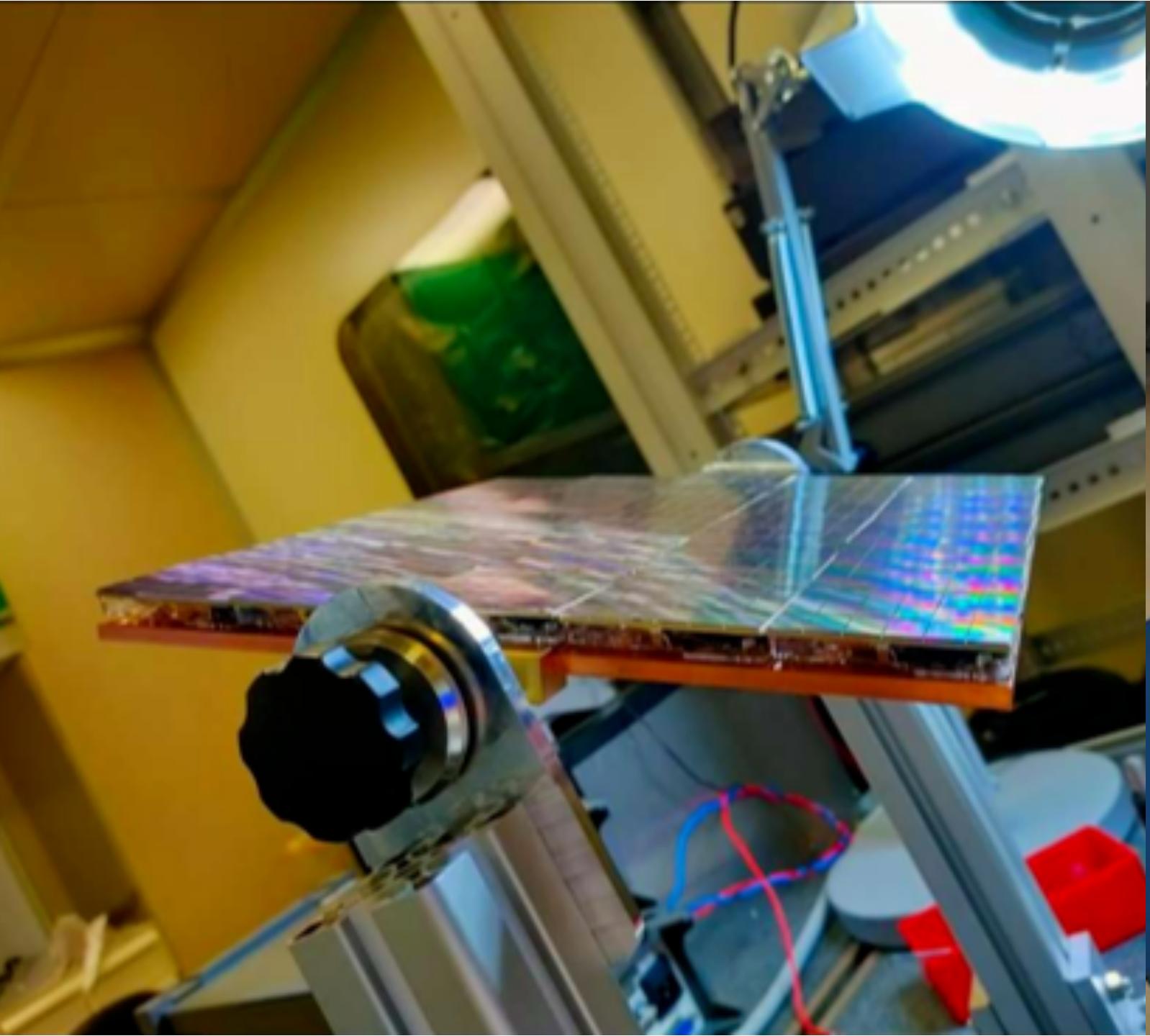
- Wafer are tested with a PAC-200 cryoprobe with a needle-based probecard (common cathode)



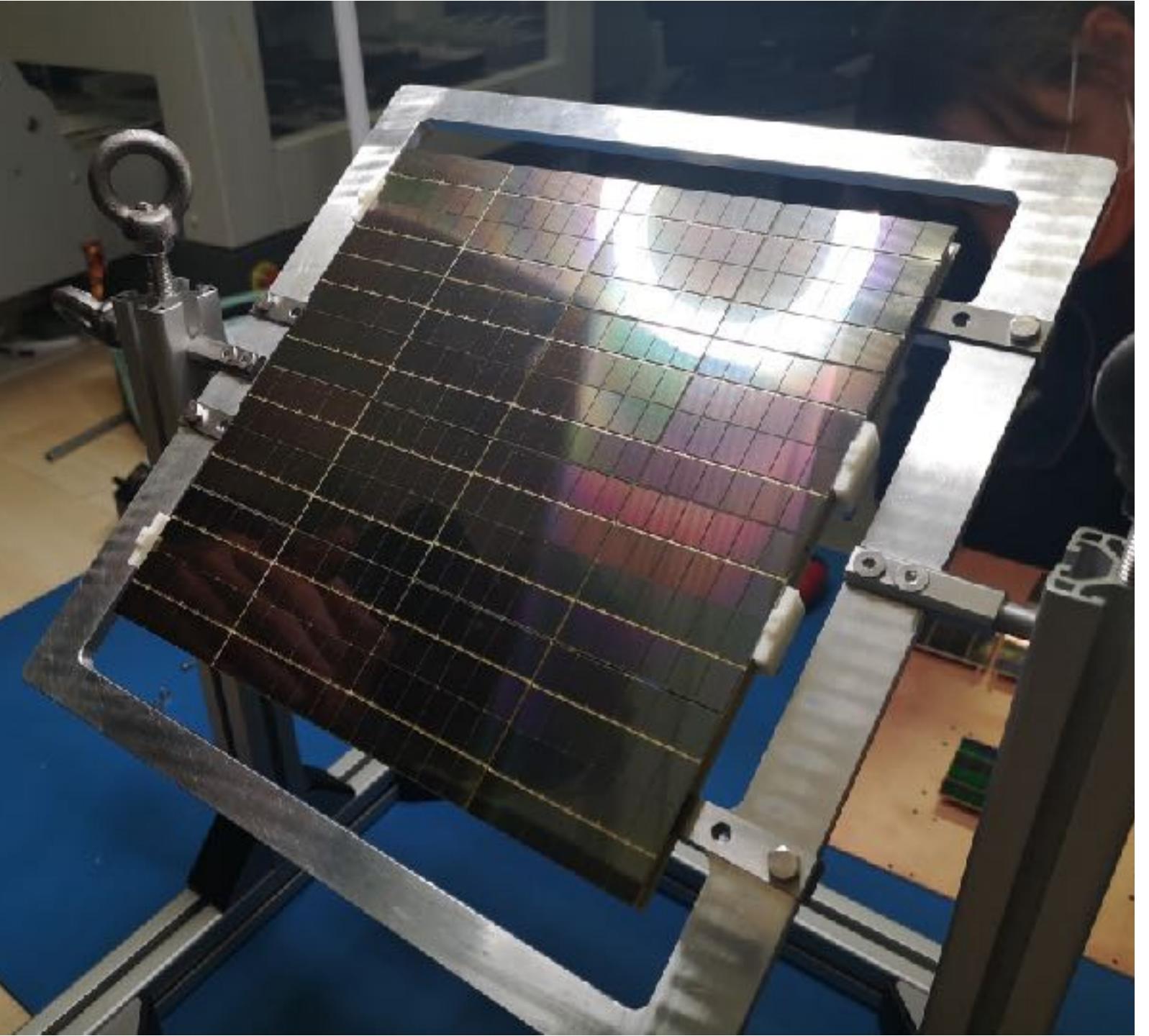
Status of photo-detection systems



First PDU prototype with 25 channels



PDU with 25 channels, less material



Final PDU: 16 tiles grouped
in 4 or 8 readout channels

- Several prototypes of Photo-Detection Units (PDU) have been produced and tested in LN and LAr.
- All the requirements on gain, SiPM noises, SNR and timing resolution are met or exceeded.
- Mass production soon to start in a dedicated facility (NOA).

Conclusions

Conclusions

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- Existing time are in front of us for photon detection for nEXO and DS-20k !
- **Significantly more information** is now available compared to what was previously known especially for PDE at cryogenic temperature !
- More measurements are available than what was shown today (i.e. **gain and Vbd** as a function of **bias voltage and temperature**, respectively, **CDA, APA etc ..**), see reference in the talk.
- Full production for DS-20k is ongoing and hopefully for nEXO we will start in the next years!
- One Darkside paper is coming soon!

Thanks!

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